November 26, 2008 10/577,255 1

=> fil reg

FILE 'REGISTRY' ENTERED AT 13:13:49 ON 26 NOV 2008

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Property values tagged with IC are from the ${\tt ZIC/VINITI}$ data file provided by ${\tt InfoChem.}$

STRUCTURE FILE UPDATES: 24 NOV 2008 HIGHEST RN 1075293-66-1 DICTIONARY FILE UPDATES: 24 NOV 2008 HIGHEST RN 1075293-66-1

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TSCA INFORMATION NOW CURRENT THROUGH July 5, 2008.

Please note that search-term pricing does apply when conducting ${\tt SmartSELECT}$ searches.

REGISTRY includes numerically searchable data for experimental and predicted properties as well as tags indicating availability of experimental property data in the original document. For information on property searching in REGISTRY, refer to:

http://www.cas.org/support/stngen/stndoc/properties.html

VAR G1=CH/3
VAR G2=5/6/11
NODE ATTRIBUTES:
CONNECT IS E2 RC AT 8
CONNECT IS E2 RC AT 13
DEFAULT MLEVEL IS ATOM
GGCAT IS SAT AT 3
GGCAT IS SAT AT 8
GGCAT IS SAT AT 11
DEFAULT ECLEVEL IS LIMITED
DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RING(S) ARE ISOLATED OR EMBEDDED NUMBER OF NODES IS 15

STEREO ATTRIBUTES: NONE

L11 SCR 2016 OR 2026 OR 2021

L13 63135 SEA FILE=REGISTRY SSS FUL L8 AND L4 NOT L11 L19 STR

November 26, 2008 10/577,255

$$\begin{array}{c} \text{CH2=G1}^2 & \text{CH0 @5} & \overset{10}{\underset{\text{eff}}{\text{0}}} & \overset{15}{\underset{\text{eff}}{\text{0}}} & \overset{15}{\underset{\text{ch}}{\text{0}}} & \overset{1}{\underset{\text{ch}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{0}}} & \overset{Me}{\underset{\text{eff}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{0}}} & \overset{Me}{\underset{\text{ch}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{0}}} & \overset{Me}{\underset{\text{ch}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{0}}} & \overset{C}{\underset{\text{ch}}{\text{ch}}} & \overset{C}{\underset{\text{ch}}} & \overset{C}{\underset{\text{ch}}}$$

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VAR G1=CH/32/34/35/36
VAR G2=5/6/11/16

NODE ATTRIBUTES:
CONNECT IS E2 RC AT 8
CONNECT IS E2 RC AT 13
CONNECT IS E2 RC AT 13
CONNECT IS E2 RC AT 12
DEFAULT MLEVEL IS ATOM
GGCAT IS SAT AT 8
GGCAT IS SAT AT 13
GGCAT IS SAT AT 18
GGCAT IS SAT AT 121
DEFAULT ECLEVEL IS LIMITED
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GRAPH ATTRIBUTES: RING(S) ARE ISOLATED OR EMBEDDED NUMBER OF NODES IS 34

STEREO ATTRIBUTES: NONE

L21 57247 SEA FILE=REGISTRY SUB=L13 SSS FUL L19

L25 181 SEA FILE=REGISTRY ABB=ON PLU=ON L21 NOT NC>=2

=> d que stat 129 L4 SCR 2043 L8 STR

VAR G1=CH/3
VAR G2=5/6/11
NODE ATTRIBUTES:
CONNECT IS E2 RC AT 8
CONNECT IS E2 RC AT 13
DEFAULT MLEVEL IS ATOM
GGCAT IS SAT AT 3
GGCAT IS SAT AT 8
GGCAT IS SAT AT 11
DEFAULT ECLEVEL IS LIMITED
DEFOULT ECLEVEL IS LIMITED

3

GRAPH ATTRIBUTES:

RING(S) ARE ISOLATED OR EMBEDDED

NUMBER OF NODES IS 15

STEREO ATTRIBUTES: NONE

SCR 2016 OR 2026 OR 2021

L13 63135 SEA FILE=REGISTRY SSS FUL L8 AND L4 NOT L11

L19

VAR G1=CH/32/34/35/36

VAR G2=5/6/11/16

NODE ATTRIBUTES:

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CONNECT IS E2 RC AT 18 CONNECT IS E2 RC AT 21

DEFAULT MLEVEL IS ATOM GGCAT IS SAT AT 8

GGCAT IS SAT AT 13 GGCAT IS SAT AT 18

GGCAT IS SAT AT 21 DEFAULT ECLEVEL IS LIMITED

GRAPH ATTRIBUTES:

RING(S) ARE ISOLATED OR EMBEDDED NUMBER OF NODES IS 34

STEREO ATTRIBUTES: NONE

1.26 STR

VAR G1=CH/32/34/35/36 VAR G2=39/40/42 NODE ATTRIBUTES: CONNECT IS E1 RC AT 39

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CONNECT IS E1 RC AT 41
CONNECT IS E2 RC AT 42
DEFAULT MLEVEL IS ATOM
GGCAT IS SAT AT 39
GGCAT IS SAT AT 41
GGCAT IS SAT AT 42
GGCAT IS UNS AT 43
DEFAULT ECLEVEL IS LIMITED
GRAPH ATTRIBUTES:
RING(S) ARE ISOLATED OR EMBEDDED
NUMBER OF NODES IS 23
STEREO ATTRIBUTES: NONE
L28 34226 SEA FILE=REGISTRY SUB=L13 SSS FUL L26 AND L19
L29
           338 SEA FILE=REGISTRY ABB=ON PLU=ON L28 NOT NC>=3
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    FILE 'HCAPLUS' ENTERED AT 11:04:26 ON 26 NOV 2008
L1
             1 SEA ABB=ON PLU=ON US20070081048/PN
               SEL RN
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1.2
              5 SEA ABB=ON PLU=ON (25086-15-1/BI OR 26355-01-1/BI OR
               3089-11-0/BI OR 643090-86-2/BI OR 911204-98-3/BI)
               D SCA
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L3
               STR
    FILE 'REGISTRY' ENTERED AT 11:51:30 ON 26 NOV 2008
T. 4
               SCR 2043
L5
             50 SEA SSS SAM L3 AND L4
     FILE 'STNGUIDE' ENTERED AT 11:59:16 ON 26 NOV 2008
    FILE 'REGISTRY' ENTERED AT 12:06:11 ON 26 NOV 2008
               SCR 2077
L6
L7
             15 SEA SSS SAM L3 AND L4 NOT L6
1.8
               STR L3
L9
            50 SEA SSS SAM L8 AND L4
L10
            29 SEA SSS SAM L8 AND L4 NOT L6
L11
               SCR 2016 OR 2026 OR 2021
            50 SEA SSS SAM L8 AND L4 NOT L11
1.12
L13
         63135 SEA SSS FUL L8 AND L4 NOT L11
L14
             1 SEA ABB=ON PLU=ON L2 AND L13
               SAV TEMP L13 EOF255/A
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L15
               STR L8
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L16
            50 SEA SUB=L13 SSS SAM L15
    FILE 'LREGISTRY' ENTERED AT 12:27:12 ON 26 NOV 2008
               STR L15
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November 26, 2008 10/577,255 5

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FILE 'REGISTRY' ENTERED AT 12:30:08 ON 26 NOV 2008
            50 SEA SUB=L13 SSS SAM L17
    FILE 'LREGISTRY' ENTERED AT 12:34:31 ON 26 NOV 2008
1.19
              STR L17
    FILE 'REGISTRY' ENTERED AT 12:37:19 ON 26 NOV 2008
L20
           50 SEA SUB=L13 SSS SAM L19
L21
         57247 SEA SUB=L13 SSS FUL L19
L22
             1 SEA ABB=ON PLU=ON L2 AND L21
               SAV L21 EOF255S1/A
L23
          4423 SEA ABB=ON PLU=ON L21 NOT NC>=3
L24
         57247 SEA ABB=ON PLU=ON L21 NOT RC>=2
L25
           181 SEA ABB=ON PLU=ON L21 NOT NC>=2
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L26
               STR L19
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1.27
           50 SEA SUB=L13 SSS SAM L26 AND L19
         34226 SEA SUB=L13 SSS FUL L26 AND L19
               SAV L28 EOF255S2/A
1.29
           338 SEA ABB=ON PLU=ON L28 NOT NC>=3
L30
             1 SEA ABB=ON PLU=ON L29 AND L2
               D RN
L31
           519 SEA ABB=ON PLU=ON L25 OR L29
    FILE 'HCAPLUS' ENTERED AT 13:03:11 ON 26 NOV 2008
1.32
               OUE ABB=ON PLU=ON (PHOTO OR LIGHT) (A) SENS? OR PHOTOSENS
               ? OR LIGHTSENS? OR PHOTOACTIVE? OR PHOTOREACTIV? OR
               LITHO? OR PHOTOLITHO?
L33
           313 SEA ABB=ON PLU=ON L31(L)L32
          1037 SEA ABB=ON PLU=ON L30
L34
L35
           60 SEA ABB=ON PLU=ON L33 AND L34
L36
            58 SEA ABB=ON PLU=ON L35 AND (PY<=2005 OR PRY<=2005 OR
               AY<=2005)
               OUE ABB=ON PLU=ON COMPOSITION
L37
           18 SEA ABB=ON PLU=ON L36 AND L37
L38
          141 SEA ABB=ON PLU=ON L33 AND L37
QUE ABB=ON PLU=ON COMPOSITION/TI
L39
L40
L41
           85 SEA ABB=ON PLU=ON L39 AND L40
L42
          282 SEA ABB=ON PLU=ON L33 AND (PY<=2005 OR PRY<=2005 OR
              AY \le 2005
L43
           75 SEA ABB=ON PLU=ON L41 AND L42
L44
           63 SEA ABB=ON PLU=ON L43 NOT L38
         1160 SEA ABB=ON PLU=ON L31(L)L37
L45
L46
           58 SEA ABB=ON PLU=ON L44 AND L45
L47
        20415 SEA ABB=ON PLU=ON L32(3A)L37
           58 SEA ABB=ON PLU=ON L46 AND L47
L48
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FILE COVERS 1907 - 26 Nov 2008 VOL 149 ISS 22 FILE LAST UPDATED: 25 Nov 2008 (20081125/ED)

HCAplus now includes complete International Patent Classification (IPC) reclassification data for the third quarter of 2008.

New CAS Information Use Policies, enter HELP USAGETERMS for details.

This file contains CAS Registry Numbers for easy and accurate substance identification.

=> d ibib abs hitstr hitind 138 1-18

L38 ANSWER 1 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2006:13571 HCAPLUS Full-text

DOCUMENT NUMBER: 144:117832

TITLE: Photosensitive resin composition for

ink jet printer head

INVENTOR(S): Ishikura, Hiroe; Shiba, Shoji; Okano, Akihiko

PATENT ASSIGNEE(S): Canon Kabushiki Kaisha, Japan

KIND DATE

SOURCE: PCT Int. Appl., 61 pp.

CODEN: PIXXD2

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION: PATENT NO.

LAIDMI	140.			1(114		DAIL			WELL	TONI	TOIN .			D	
					-										
WO 200	50015	15		A1		2006	0105		WO 2	005-	JP12	160			
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										<				2	4
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	CH,	CN,	co,	CR,	CU,	CZ,	DE,	DK,	DM,	DZ,	EC,	EE,	EG,	ES,	FΙ,
	GB,	GD,	GE,	GH,	GM,	HR,	HU,	ID,	IL,	IN,	IS,	KE,	KG,	KM,	KP,
	KR,	KZ,	LC,	LK,	LR,	LS,	LT,	LU,	LV,	MA,	MD,	MG,	MK,	MN,	MW,
	MX,	MZ,	NA.	NG.	NI.	NO.	NZ.	OM,	PG.	PH,	PL,	PT.	RO,	RU,	SC,
	SD,	SE,	SG.	SK.	SL.	SM.	SY,	TJ.	TM.	TN.	TR.	TT.	TZ.	UA,	UG,
	US.	UZ.	VC.	VN.	YU.	ZA.	ZM,	ZW							
RW	AT,								EE.	ES.	FI.	FR.	GB.	GR.	HU.
							NL,								
							GN,								
							MZ,			SL,	54,	14,	UG,	Z171,	ZiVi,
			BY,				RU,								
JP 200	50111	82		A		2006	0112		JP 2	004-	1904	84			
														2	00406
														2	8

APPLICATION NO.

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DATE

November 26, 2008		10/5/7,255		
EP 1763705	A1	20070321	EP 2005-780110	200506 24
			<	
R: DE, FR, GB,	IT			
CN 1977217	A	20070606	CN 2005-80021432	200506
				24
			<	
US 20070081048	A1	20070412	US 2006-577255	
				200604 26
			<	
KR 2007043805	A	20070425	KR 2007-701946	
				200701 26
			<	
PRIORITY APPLN. INFO.:			JP 2004-190484	A
				200406 28
			<	
			WO 2005-JP12160	W
				200506 24
			<	

AB A pos. type photosensitive resin composition comprises a polyacrylate resin having, in the structure, at least a structural unit represented by (CH2CR1C(=0)X)n-(CH2R2CC(=0)R3)m (X = hydroxyl group, C2-4 alkynol group, methylol-amino group; R1 and R2 = H, C1-3 alkyl group; R3 = C1-3 alkyl group, C1-3 alkoxyl group, aralkyl group having an aryl group or C1-2 alkyl group; n = pos. integer; and m = 0 or a pos. integer, and a condensable crosslinker). ΤТ 26355-01-1DP, 2-Hydroxyethyl methacrylate-methyl

methacrylate copolymer, reaction product with penta methoxy melamine RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(photosensitive resin composition for ink jet printer head containing)

26355-01-1 HCAPLUS

RN CN

2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 80-62-6 CMF C5 H8 O2

IC ICM G03F007-039

ICS B41J002-16

74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 35, 38

ST photosensitive resin comps ink jet head process manuf

ΙT Ink-jet printer heads

Light-sensitive materials

(photosensitive resin composition for ink jet printer head)

3089-11-0DP, Hexamethoxymethyl melamine, reaction product with methacrylate copolymer RL: SPN (Synthetic preparation); TEM (Technical or engineered

material use); PREP (Preparation); USES (Uses)

(Nikalac MW-100L; photosensitive resin composition for ink jet printer head containing)

911204-98-3, SP 172

RL: CAT (Catalyst use); USES (Uses)

(photosensitive resin composition for ink jet printer head containing)

25086-15-1DP, Methacrylic acid-methyl methacrylate copolymer, reaction product with Hexamethoxymethyl melamine

26355-01-1DP, 2-Hydroxyethyl methacrylate-methyl

methacrylate copolymer, reaction product with penta methoxy melamine 643090-86-2DP, Nikalac MX 750LM, reaction product with methacrylate copolymer

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(photosensitive resin composition for ink jet

printer head containing)

REFERENCE COUNT:

THERE ARE 5 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L38 ANSWER 2 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2002:689951 HCAPLUS Full-text

DOCUMENT NUMBER: 137:224124

TITLE: Light-sensitive solder resin composition containing specific prepolymer used for manufacturing electric parts as solder resist

and dielectric film

INVENTOR(S): Kusaka, Akira

PATENT ASSIGNEE(S): Mitsubishi Chemical Corp., Japan SOURCE: Jpn. Kokai Tokkyo Koho, 10 pp.

CODEN: JKXXAF DOCUMENT TYPE: Pat.ent. Japanese

LANGUAGE: FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 2002258477	A	20020911	JP 2001-58227	

PRIORITY APPLN. INFO.:

JP 2001-58227

200103 0.2

AB The title composition contains a prepolymer, a photopolymn. initiator, a diluent reactive towards the prepolymer, epoxides, and compds. having OH groups, wherein the prepolymer has a polymerizable unsatd, group and a carboxy group. The composition shows the good developing characteristics, the good

curing property, and the good contact with a substrate. ΤТ 26355-01-1P, Methyl methacrylate/2-hydroxyethyl methacrylate

copolymer

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (compound having OH group in light-sensitive solder resin composition)

RN 26355-01-1 HCAPLUS

2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with CN methyl 2-methyl-2-propenoate (CA INDEX NAME)

СМ

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 80-62-6 CMF C5 H8 O2

ICM G03F007-027

ICS G03F007-027; C08F002-50; C08F290-00; C08L029-04; C08L063-00; C08L063-10; C08L101-02; G03F007-004; G03F007-028; H05K003-28

74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 35, 76

light sensitive solder resin compa elec resist dielec film ST

Polyvinyl butyrals

RL: TEM (Technical or engineered material use); USES (Uses) (S-Lec BX-L; compound containing OH group in light-sensitive solder

resin composition)

Polyvinyl acetals

RL: TEM (Technical or engineered material use); USES (Uses) (acetoacetals, S-Lec KS 10; compound containing OH group in light-sensitive solder resin composition)

Electric insulators

Light-sensitive materials

(light-sensitive solder resin composition used for manufacturing elec. parts as solder resist, dielec. film)

IT Solder resists

(photoresists; light-sensitive solder resin composition used for manufacturing elec. parts as solder resist, dielec. film)

IT Photoresists

(solder; light-sensitive solder resin composition used for manufacturing elec. parts as solder resist, dielec. film) 71868-10-5. Iracure 907

RL: CAT (Catalyst use); USES (Uses)

(compound having OH group in light-sensitive solder resin composition)

IT 26355-01-1P, Methyl methacrylate/2-hydroxyethyl methacrylate
copolymer
RI: SPN (Synthetic preparation); TEM (Technical or engineered
material use); PREP (Preparation); USES (Uses)

(compound having OH group in light-sensitive solder resin composition)

IT 29570-58-9, Dipentaerythritol hexaacrylate 251471-86-0, Epikote 180880

RL: TEM (Technical or engineered material use); USES (Uses) (diluent in light-sensitive solder resin composition)

IT 289478-37-1P, Epikote 180S80/acrylic acid/tetrahydrophthalic anhydride copolymer 303006-52-2P, Epikote 157S70-acrylic acid-tetrahydrophthalic anhydride copolymer RL: SPN (Synthetic preparation); TEM (Technical or engineered

material use); PREP (Preparation); USES (Uses)
 (prepolymer for light-sensitive solder resin composition)

L38 ANSWER 3 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2001:796430 HCAPLUS Full-text

DOCUMENT NUMBER: 135:350553

TITLE: Photosensitive polymer compositions for formation of solder resist layers and

electric insulating layers

INVENTOR(S): Kusaka, Akira; Hata, Kazuyuki; Soejima, Hiroshi

PATENT ASSIGNEE(S): Mitsubishi Chemical Corp., Japan SOURCE: Jpn. Kokai Tokkyo Koho, 14 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

	PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
	JP 2001305726	A	20011102	JP 2001-30391	
					200102
					07
				<	
PRIC	RITY APPLN. INFO.:			JP 2000-39030 A	

JP 2000-39030 A 200002

AB The composition mainly consists of (A) a prepolymer having polymerizable unsatd. group and carboxyl group in a mol., (B) a photopolymn. initiator, (C) a reactive diluent which is polymerizable with the prepolymer A, (D) a blocked isocvanate having ≥2 blocked isocvanate group(s) in a mol., and (E) a

tackifier. Hardened products of the compos, and printed circuit boards having layers of the hardened products are also claimed.

26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer

RL: TEM (Technical or engineered material use); USES (Uses) (tackifier; photosensitive polymer compas.

for solder resists and insulating layers in electronic devices)

26355-01-1 HCAPLUS RN

2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM

CRN 868-77-9 CMF C6 H10 O3

CM

CRN 80-62-6 CMF C5 H8 O2

ICM G03F007-004

ICS C08G018-80; C08G059-14; G03F007-027; G03F007-085; H05K003-28

74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38, 76

ST elec insulator photosensitive polymer compn; solder resist layer photosensitive polymer compn; photosensitive polymer printed circuit board

Polyvinyl butyrals

RL: TEM (Technical or engineered material use); USES (Uses) (S-Lec BX-L, tackifier; photosensitive polymer compns.

for solder resists and insulating layers in electronic devices)

Polyvinyl acetals

RL: TEM (Technical or engineered material use); USES (Uses) (acetoacetals, S-Lec KS 10, tackifier; photosensitive polymer compas, for solder resists and insulating layers in electronic devices)

Epoxy resins, preparation

RL: PNU (Preparation, unclassified); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(acrylic; photosensitive polymer compns. for solder resists and insulating layers in electronic devices)

Polymerization catalysts

(photopolymn.; photosensitive polymer compas. for solder resists and insulating layers in electronic devices)

Tackifiers

(photosensitive polymer compns. containing; photosensitive polymer compns. for solder resists and insulating layers in electronic devices)

IT Electric insulators

Printed circuit boards

Solder resists

(photosensitive polymer compas, for solder resists and insulating layers in electronic devices)

IT Polvisocvanurates

RL: PNU (Preparation, unclassified); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(reaction products with ϵ -caprolactam or ethylhexanol; photosensitive polymer compas. for solder resists and insulating layers in electronic devices)

IT 71868-10-5, Irgacure 907

RL: CAT (Catalyst use); USES (Uses)

(photopolymn. initiator; photosensitive polymer compas.

for solder resists and insulating layers in electronic devices)
IT 104-76-7DP, 2-Ethylhexanol, reaction products with polyisocyanurates

105-60-2DP, &-Caprolactam, reaction products with polyisocyanurates 31370-61-3DP, 2,4-Tolylene

diisocyanate-2,6-tolylene diisocyanate copolymer, reaction products with 8-caprolactam or ethylhexanol 289478-37-1P, Acrylic acid-Epikote 180580-tetrahydrophthalic acid anhydride copolymer 303006-52-2P, Acrylic acid-Epikote 157570-tetrahydrophthalic acid

anhydride copolymer RL: PNU (Preparation, unclassified); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(photosensitive polymer compos, for solder resists and insulating layers in electronic devices)

IT 29570-58-9, Dipentaervthritol hexaacrvlate

RL: TEM (Technical or engineered material use); USES (Uses) (reactive diluent; photosensitive polymer compras. for solder resists and insulating layers in electronic devices)

IT 872-35-5, 2-Mercaptoimidazole 4420-74-0, 3-Mercaptopropyltrimethoxysilane 26355-01-1,

2-Hydroxyethyl methacrylate-methyl methacrylate copolymer 371113-26-7, Rikaester 8LJA 371113-28-9, Rikatac PCJ

RL: TEM (Technical or engineered material use); USES (Uses) (tackifier; photosensitive polymer comons.

(tackinier; photosensitive polymer compas.

for solder resists and insulating layers in electronic devices)

L38 ANSWER 4 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2001:225512 HCAPLUS Full-text

DOCUMENT NUMBER: 134:273548

TITLE: Light-sensitive resin composition for

dry film resist suitable for patterning with

sand blast

INVENTOR(S): Sato, Hiroaki

PATENT ASSIGNEE(S): Nippon Synthetic Chemical Industry Co., Ltd.,

Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 14 pp.

CODEN: JKXXAF

DOCUMENT TYPE: Patent
LANGUAGE: Japanese
FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

JP 2001083701 A 20010330 JP 1999-256520

199909

PRIORITY APPLN. INFO.:

JP 1999-256520

199909 10

AB The title resin composition consists of: a first urethane acrylate resin containing carboxylic groups; a photopolymn. initiator; and urethane acylate resin of

RI-O-CONH-R2-NRCOO-R3-OCONH-R2-NHCOO-(X)n-R1 (R1 = urethane residue containing ethylenic unsat. groups and a hydroxyl group; R2 = urethane bond residue of polysicoyanate; R3 = urethane bond residue of polyol; X = urethane bond residue of polyol or polyester polyol; n = 1-20 integer). The first urethane acrylate resin is prepared from: a urethane, which is prepared from a diol containing a carboxylic group, another diol of ≤ 500 average mol. weight without an acid value, and a polyisocyanate; and a compound having ethylenic unsat. groups and a hydroxyl group. The resin composition provides a resist of the excellent sand-blast resistance and the good resistance towards an alkali developer to generate the high resolution

26355-01-1F, Methyl methacrylate-2-hydroxyethyl methacrylate copolymer

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(acrylic polymer in light-sensitive resin composition for dry film resist)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 80-62-6 CMF C5 H8 O2

- IC ICM G03F007-027 ICS C08F299-06
- ${\tt CC} 74\text{--}5$ (Radiation Chemistry, Photochemistry, and Photographic and

Other Reprographic Processes)

ST light sensitive resin compa dry film resist sand blast

IT Polyurethanes, preparation

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(acrylates; light-sensitive resin composition for dry film resist suitable for use with sand blast process)

Light-sensitive materials

Photoresists

Sandblasting

(light-sensitive resin composition for dry film resist suitable for use with sand blast process)

25987-66-0P, Methyl methacrylate-butyl acrylate-methacrylic acid-styrene copolymer 26355-01-1P, Methyl

methacrylate-2-hydroxyethyl methacrylate copolymer RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(acrylic polymer in light-sensitive resin

composition for dry film resist)

818-61-1DP, 2-Hydroxyethyl acrylate, reaction products with polyurethanes 24938-37-2DP, reaction products with 2-hydroxyethyl acrylate 25569-53-3DP, reaction products with 2-hydroxyethyl acrylate 56925-73-6P, Methyl methacrylate-butyl

methacrylate-2-ethylhexyl acrylate-methacrylic acid copolymer 216377-58-1DP, reaction products with 2-hydroxyethyl acrylate 321415-66-1DP, reaction products with 2-hydroxyethyl acrylate 326480-46-0DP, reaction products with 2-hydroxyethyl acrylate 331745-54-1DP, reaction products with 2-hydroxyethyl acrylate

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(urethane acrylate resin in light-sensitive resin compn . for dry film resist)

L38 ANSWER 5 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN

ACCESSION NUMBER: 2001:225511 HCAPLUS Full-text DOCUMENT NUMBER: 134:273547

TITLE: Light-sensitive resin composition for

dry film resist suitable for use with sand blast

process Sato, Hiroaki

PATENT ASSIGNEE(S): Nippon Synthetic Chemical Industry Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkvo Koho, 12 pp. CODEN: JKXXAF Patent

DOCUMENT TYPE:

INVENTOR(S):

LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

> KIND DATE APPLICATION NO. PATENT NO. DATE JP 2001083699 A 20010330 JP 1999-256518 199909

1.0

JP 1999-256518 PRIORITY APPLN. INFO.:

199909 10

AB The title resin composition consists of: an urethane acrylate resin containing carboxylic groups; a photopolymm. initiator; and an acrylic polymer. The urethane acrylate resin is prepared from: a urethane, which is prepared from a diol containing a carboxylic group, another diol of ≤500 average mol. weight without an acid value, and a polyisocyanate; and a compound having ethylenic unsat. groups and a hydroxyl group. The acrylic polymer contains ≥50 % of monomers containing a hydroxy group and has ≤50 mg·KOH/g acid value. The resin composition provides a resist of the excellent sand-blast resistance for patterning with sand blast and also the good resistance towards an alkali developer to generate the high resoln pattern.

IT 26355-01-1P, Methyl methacrylate-2-hydroxyethyl methacrylate copolymer

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (acrylic polymer in light-sensitive resin

composition for dry film resist)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 80-62-6 CMF C5 H8 O2

IC ICM G03F007-027

ICS G03F007-027; C08F002-44; C08F002-50; C08F299-06; C08L033-08; C08L075-16; G03F007-004; G03F007-028; G03F007-033

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

ST light sensitive resin compa dry film resist sand blast

IT Polyurethanes, preparation

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (acrylates; light-sensitive resin composition for dry film

resist suitable for use with sand blast process)

IT Light-sensitive materials

Photoresists

Sandblasting

(light-sensitive resin composition for dry film resist suitable for use with sand blast process)

IT 26355-01-1P, Methyl methacrylate-2-hydroxyethyl methacrylate
copolymer 35343-65-BP, Butyl acrylate-hydroxyethyl
methacrylate-acrylic acid copolymer
RL: SPN (Synthetic preparation); TEM (Technical or engineered
material use); PREP (Preparation); USES (Uses)
(acrylic polymer in light-sensitive resin

composition for dry film resist)

IT 818-61-1DP, 2-Hydroxyethyl acrylate, reaction products with
polyurethanes 326480-46-0DP, reaction products with 2-hydroxyethyl
acrylate 331745-54-1DP, reaction products with 2-hydroxyethyl
acrylate 331746-98-6DP, reaction products with 2-hydroxyethyl
acrylate 341746-98-6DP, reaction products with 2-hydroxyethyl
acrylate

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(urethane acrylate resin in light-sensitive resin compn.
. for dry film resist)

L38 ANSWER 6 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1998:811792 HCAPLUS Full-text 130:102888

TITLE: Photosensitive color composition

containing triazine-type photosensitive

acid-generating agent and color filter using the composition

INVENTOR(S): Kita, Shinichi; Taguchi, Takao; Tamura, Akira

PATENT ASSIGNEE(S): Toppan Printing Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 6 pp.
CODEN: JKXXAF

KIND DATE

DOCUMENT TYPE: Patent
LANGUAGE: Japanese
FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO

PF

		112112			
	JP 10333334	A	19981218	JP 1997-145393	
					199706 03
				<	
RIO	RITY APPLN. INFO.:			JP 1997-145393	
					199706 03
				<	

APPLICATION NO

DATE

OTHER SOURCE(S): MARPAT 130:102888

AB The composition for the color filter contains a resin having OH group crosslinkable with an acid, a crosslinking agent, a photosensitive acid-generating agent comprising a triazine derivative I (X = Br, Cl; m, n = 0-3; R

= alkyl, aryl) containing trihalomethyl group, and a pigment. The filter without loss of light transmission, comprising orderly tapered and highly precise patterns, is manufactured at a high yield by using the composition

IT 26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer

copolymer

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive composition containing hydroxy-containing crosslinkable resin and acid-generating triazines for heat-resistant color filters)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM ·

CRN 868-77-9 CMF C6 H10 O3

H2C 0 Me_C_C_0_CH2_CH2_OH

CM 2

CRN 80-62-6 CMF C5 H8 O2

IC ICM G03F007-038

ICS C08K005-378; C08L101-06; G02B005-20; G03F007-004

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

ST photosensitive compn color filter manuf; hydroxy contg

crosslinkable resin color filter; acid generating trihalomethyl contg triazine compd; heat resistance color filter manuf

IT Aminoplasts

RL: MOA (Modifier or additive use); USES (Uses)

(crosslinking agents; photosensitive composition containing hydroxy-containing crosslinkable resin and acid-generating triazines

for heat-resistant color filters)

IT Optical filters Photoresists

(photosensitive composition containing hydroxy-containing

crosslinkable resin and acid-generating triazines for heat-resistant color filters)

IT 9003-08-1, Nikalac MW 30M

RL: MOA (Modifier or additive use); USES (Uses)

(crosslinking agents; photosensitive composition containing hydroxy-containing crosslinkable resin and acid-generating triazines for heat-resistant color filters)

November 26, 2008 10/577,255 18

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive composition containing hydroxy-containing crosslinkable resin and acid-generating triazines for heat-resistant color filters)

L38 ANSWER 7 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1995:794929 HCAPLUS Full-text

DOCUMENT NUMBER: 123:183494

ORIGINAL REFERENCE NO.: 123:32381a,32384a

TITLE: Color filter, method for manufacturing it, and

liquid crystal panel.

INVENTOR(S): Shiba, Shoji; Sato, Hiroshi; Shirota, Katsuhiro;

Yokoi, Hideto; Kashiwazaki, Akio; Murai,

Keiichi; Miyazaki, Takeshi

PATENT ASSIGNEE(S): Canon K. K., Japan SOURCE: Eur. Pat. Appl., 49 pp.

CODEN: EPXXDW

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

	TENT NO.			KIN		DATE		_					NO.			DATE
	655647			A1		1995	0531	Ε	ΞP	199	94-1	1184	32			199411
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	R: AT,	BE,	CH,	DE,	DK,	, ES,	FR,	GB,	GR	, 1	IT,	LI,	LU,	NL,	SE	, PT,
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JP 08075917	Z.	19960322		
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JP 2872595	B2	19990317		
CN 1122007	A	19960508	CN 1994-114096	
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CN 1082672	С	20020410		
KR 173149	B1	19990320	KR 1994-31035	
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JP 08136726	A	19960531	JP 1994-299633	
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JP 2872596	B2	19990317		
US 5716740	A		US 1996-695667	
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US 6180294	В1	20010130	US 1997-965466	
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US 6686104	B1	20040203	US 2000-679342	
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PRIORITY APPLN. INFO.:			< JP 1993-293395	04 A
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PRIORITY APPLN. INFO.:				04 A 199311
PRIORITY APPLN. INFO.:			JP 1993-293395	04 A 199311
PRIORITY APPLN. INFO.:			JP 1993-293395 <	04 A 199311 24
PRIORITY APPLN. INFO.:			JP 1993-293395 <	04 A 199311 24 A 199312
PRIORITY APPLN. INFO.:			JP 1993-293395 < JP 1993-322133	04 A 199311 24
PRIORITY APPLN. INFO.:			JP 1993-293395 < JP 1993-322133 <	04 A 199311 24 A 199312 21
PRIORITY APPLN. INFO.:			JP 1993-293395 < JP 1993-322133	04 A 199311 24 A 199312 21
PRIORITY APPLN. INFO.:			JP 1993-293395 < JP 1993-322133 <	04 A 199311 24 A 199312 21 A 199407
PRIORITY APPLN. INFO.:			JP 1993-293395 < JP 1993-322133 < JP 1994-150870	04 A 199311 24 A 199312 21
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870	04 A 199311 24 A 199312 21 A 199407 01
PRIORITY APPLN. INFO.:			JP 1993-293395 < JP 1993-322133 < JP 1994-150870	04 A 199311 24 A 199312 21 A 199407 01 A
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870	04 A 199311 24 A 199312 21 A 199407 01 A 199407
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870	04 A 199311 24 A 199312 21 A 199407 01 A
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870	04 A 199311 24 A 199312 21 A 199407 01 A 199407
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874	04 A 199311 24 A 199312 21 A 199407 01 A 199407
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874	A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199407
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874 JP 1994-220049	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874 JP 1994-220049	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199409 14
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874 JP 1994-220049	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199409 14 B1
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874 JP 1994-220049	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199409 14 B1 199411
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874 JP 1994-220049	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199409 14 B1
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874 JP 1994-220049	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199409 14 B1 199411
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-220049 US 1994-345710	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199409 14 B1 199411
PRIORITY APPLN. INFO.:			JP 1993-293395 JP 1993-322133 JP 1994-150870 JP 1994-150874 JP 1994-220049 US 1994-345710	04 A 199311 24 A 199312 21 A 199407 01 A 199407 01 A 199409 14 B1 199411 22

---US 1996-695667 A3 199608 08 ---US 1997-965466 A3 199711 06

23

AB Provided is a color filter which comprises a substrate and a resin layer on the substrate, the resin layer containing a plurality of colored portions of different colors and noncolored portions. The colored portions are made by ink-printing, nonimpact, ink-jet printing.

IT 26355-01-1, Hydroxyethyl methacrylate-methyl methacrylate copolymer 28502-06-9, Methyl

methacrylate-N-methylolacrylamide copolymer

RL: MOA (Modifier or additive use); POF (Polymer in formulation); USES (Uses)

(ink jet printing on photosensitive composition

for color filter for liquid-crystal display panels)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9

CMF C6 H10 O3

CM 2

CRN 80-62-6

CMF C5 H8 O2

RN 28502-06-9 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, methyl ester, polymer with N-(hydroxymethyl)-2-propenamide (CA INDEX NAME)

CM 1

CRN 924-42-5 CMF C4 H7 N O2

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November 26, 2008
                              10/577.255
 HO- CH2- NH- U- CH- CH2
    CM 2
    CRN 80-62-6
    CMF C5 H8 O2
Me_U_U_OMe
    ICM G03C007-12
    ICS G02F001-1335; B41M005-00
    74-4 (Radiation Chemistry, Photochemistry, and Photographic and
    Other Reprographic Processes)
    optical filter liq crystal display; photosensitive compo
    ink jet printing
ΙT
    Optical filters
    Photoimaging compositions and processes
        (ink jet printing on photosensitive composition for color
       filter for liquid-crystal display panels)
    Optical imaging devices
       (electrooptical liquid-crystal, ink jet printing on photosensitive
       composition for color filter for liquid-crystal display panels)
    Printing, nonimpact
       (ink-jet, ink jet printing on photosensitive composition for
       color filter for liquid-crystal display panels)
    140-95-4, Dimethylolurea 9003-08-1, Sumitex M3
                                                     9004-62-0, Ah-15
    9004-64-2, Hpc-h 9012-09-3, Cellulose triacetate
    26355-01-1, Hydroxyethyl methacrylate-methyl methacrylate
    copolymer 28502-06-9, Methyl
    methacrvlate-N-methylolacrylamide copolymer
                                                  38193-53-2
    125026-29-1 129401-30-5 160109-42-2 167860-29-9 167860-30-2
    167860-31-3
    RL: MOA (Modifier or additive use); POF (Polymer in formulation);
    USES (Uses)
       (ink jet printing on photosensitive composition
       for color filter for liquid-crystal display panels)
L38 ANSWER 8 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN
ACCESSION NUMBER:
                       1993:202127 HCAPLUS Full-text
DOCUMENT NUMBER:
                        118:202127
ORIGINAL REFERENCE NO.: 118:34537a,34540a
TITLE:
                        Dyeing of waterless lithographic plate under
                        ultrasonic wave
INVENTOR(S):
                        Kojima, Noriyoshi; Nogami, Akira; Hirai,
                        Katsura; Uehara, Masabumi
PATENT ASSIGNEE(S):
                       Konica Co., Japan
SOURCE:
                        Jpn. Kokai Tokkyo Koho, 10 pp.
                        CODEN: JKXXAF
DOCUMENT TYPE:
                        Patent
LANGUAGE:
                        Japanese
FAMILY ACC. NUM. COUNT: 1
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PATENT INFORMATION:

	PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
	JP 04299354	A	19921022	JP 1991-89754	
					199103
					28
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PRIO	RITY APPLN. INFO.:			JP 1991-89754	
					199103
					28
PRIO	RITY APPLN. INFO.:			JP 1991-89754	

- AB A presensitized waterless lithog. plate comprising, on a support, a primer layer, a photosensitive layer, and an ink-repellent layer is exposed, developed, and dyed under ultrasonic wave irradiation A presensitized waterless lithog. plate having an acrylic resin primer layer, an acrylic resin photosensitive layer, and a silicone rubber layer was exposed, developed, and dyed by using a solution containing Vitoria Pure Blue BOH under ultrasonic wave irradiation to show improved dyeability.
- IT 26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer

RL: USES (Uses)

(primer layers containing, for presensitized waterless lithog plates)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 80-62-6

CMF C5 H8 O2

- IC ICM G03F007-40
 - ICS G03F007-00
- CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 42
- IT 126714-06-5 139724-08-6, Acrylic acid-2-hydroxyethyl
 methacrylate-N-(4-hydroxyphenyl)methacrylamide copolymer
 RL: USES (USes)

(photosensitive compas. containing, for preparing waterless

lithog, plates)

26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer 65436-60-4 75577-71-8 77865-47-5

RL: USES (Uses)

(primer layers containing, for presensitized waterless lithog

L38 ANSWER 9 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1993:113210 HCAPLUS Full-text

DOCUMENT NUMBER: 118:113210

ORIGINAL REFERENCE NO.: 118:19565a,19568a

TITLE: Waterless presensitized lithographic plates with

photocured primer layer

INVENTOR(S): Tomiyasu, Hiroshi; Kasakura, Akio; Goto, Sei;

Suzuki, Norihito; Sasa, Nobumasa PATENT ASSIGNEE(S): Mitsubishi Kasei Corp., Japan: Konica Co.

SOURCE: Jpn. Kokai Tokkyo Koho, 10 pp.

CODEN: JKXXAF DOCUMENT TYPE: Patent

LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 04190358	A	19920708	JP 1990-322180	199011

26

PRIORITY APPLN. INFO.: JP 1990-322180

199011 26

AB In the title plates prepared by forming a primer layer, a photosensitive layer, and a silicone rubber layer successively on a support, the primer layer contains ≥2 polymers having ≥5° difference in glass transition temperature (Tq) from each other, ethylenically unsatd. monomers or oligomers, and photopolymn, initiators and the layer is photo-cured before coating the photosensitive layer. The primer layer shows good photocurable property, scratch resistance, and adhesion to untreated Al support. Thus, an Al plate was coated with a composition containing 2-hydroxyethyl methacrylate (I)-Me methacrylate (II) (45:55) copolymer (Tg 58°), I-II (34:66) copolymer (Tg 48°), pentaerythritol triacrylate, DA-314 (triacrylate monomer), DETX (photopolymn. initiator), and EPA (photopolymn. initiator), photo-cured, and overcoated with a photosensitive laver containing a diazo resin and with a silicone rubber layer to give a waterless presensitized lithog. plate.

ΤТ 26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate

copolymer RL: USES (Uses)

(waterless presensitized litbog, plate primer layer containing)

26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

RN

CRN 868-77-9 CMF C6 H10 O3 November 26, 2008 10/577,255 24

CM 2

CRN 80-62-6 CMF C5 H8 O2

IC ICM G03F007-00 ICS G03F007-11

CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

II 25951-39-7, Butyl acrylate-2-hydroxyethyl methacrylate-methyl methacrylate copolymer 26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer 27012-37-9, Ethyl acrylate-2-hydroxyethyl methacrylate-methyl methacrylate copolymer 126465-54-1, UR 8300 14266-84-8, UR 8700 146162-80-3 RL: USES (Uses) (waterless presensitized lithog, plate primer layer

(waterless presensitized lithog, plate primer laye, containing)

L38 ANSWER 10 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1993:30048 HCAPLUS $\frac{\text{Full-text}}{\text{Full-text}}$

DOCUMENT NUMBER: 118:30048

ORIGINAL REFERENCE NO.: 118:5389a,5392a
TITLE: Waterless litho

TITLE: Waterless lithographic original plates with photosensitive layer containing hydroxyl

group-containing polymer and boron compound Tamura, Kazutaka; Mori, Yoichi

PATENT ASSIGNEE(S): Toray Industries, Inc., Japan Jpn. Kokai Tokkyo Koho, 8 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

INVENTOR(S):

	PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
	JP 04172456	A	19920619	JP 1990-301392	
					199011
					06
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PRIC	RITY APPLN. INFO.:			JP 1990-301392	
					199011
					06

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AB The original plates are prepared by forming a silicone rubber layer and a photosensitive layer containing a polymer having OH groups in its side chain and an alkanovloxyboron compound successively on a substrate. The plates can easily be developed and show good adhesion of the silicone rubber layer to the photosensitive layer and printing durability. Thus, a sprayed Al substrate was coated with a silicone rubber layer and with a composition containing Me methacrylate-2-hydroxyethyl methacrylate copolymer, phenyldiacetoxyboron, Aronix M 310 (photopolymerizable monomer), and photoinitiator to give a waterless presensitized lithog, plate. 26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer RL: USES (Uses) (waterless presensitized lithog, plate photosensitive layer containing) 26355-01-1 HCAPLUS RN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME) CM CRN 868-77-9 CMF C6 H10 O3 ма_Й_Й_о_сн2_сн2_он CM CRN 80-62-6 CMF C5 H8 O2 _U Ŭ ICM G03F007-00 ICS G03F007-004 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) 80-62-6D, copolymer with acrylic silicone 10193-99-4, IT Pentaervthritol tetrakis(thioglycolate) 24979-70-2, Poly(p-hydroxystyrene) 26355-01-1, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer 100289-84-7, Aronix M 310 112534-55-1 145073-17-2 145073-18-3 RL: USES (Uses) (waterless presensitized lithog, plate photosensitive layer containing) L38 ANSWER 11 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1988:446208 HCAPLUS Full-text DOCUMENT NUMBER: 109:46208 ORIGINAL REFERENCE NO.: 109:7647a,7650a

TITLE: Photosensitive resins having phenylenediacrylate derivative type pendant groups

INVENTOR(S): Ichimura, Kunihiro; Nishio, Yoshihiro; Oe, Koji PATENT ASSIGNEE(S): Agency of Industrial Sciences and Technology, Japan; Dainippon Ink and Chemicals, Inc.

SOURCE: Jpn. Kokai Tokkyo Koho, 10 pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 62215607	A	19870922	JP 1986-57106	
				198603
				17
** 05010200		10050510	<	
JP 07042330 PRIORITY APPLN. INFO.:	В	19950510	JP 1986-57106	
PRIORITI APPLN. INFO.:			Jb 1380-2\100	
				198603
				17

GI

AB The title photosensitive resins are prepared by reaction of pendant CO2H group-containing vinyl polymers with epoxy group-containing p-phenylenediacrylic acid diesters. Optionally, the OH groups on the above resins are reacted with acid anhydrides. The p-phenylenediacrylate esters are selected from I (R, R1 = H, CN; R2 = an organic moiety which does not react with CO2H or epoxy group). The photosensitive resins show high sensitivity and good storage stability and are useful in preparing presensitized plates.

26:155-01-10. 2-Hydroxyethyl methacrylate-methyl methacrylate

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copolymer, esters with phthalic anhydride, glycidyl ethoxycarbonylvinylcinnamate, and acetic anhydride RL: USES (Uses)

(photosensitive resin compass. containing, for presensitized printing plates)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

November 26, 2008 10/577,255 27

CM 2

CRN 80-62-6 CMF C5 H8 O2

IC ICM C08F008-14

ICS 603C001-71 CC 74-4 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 37
II Printing plates

(presensitized, photosensitive resin compas, for) IT 67-56-1D, Methanol, esters with maleic anhydride- or itaconic anhydride-styrene copolymer, reaction products with glycidyl ehoxycarbonylvinylcinnamate and acetic anhydride 67-56-1D, Methanol, esters with maleic anhydride-styrene copolymer, reaction products with glycidyl ethoxycarbonylvinylcinnamate and acetic anhydride 85-44-9D, Phthalic anhydride, esters with poly(vinyl alc.) or hydroxyethyl methacrylate-Me methacrylate copolymer, reaction products with glycidyl ethoxycarbonylvinylcinnamate and acetic anhydride 108-24-7D, Acetic anhydride, esters with glycidyl ethoxycarbonylvinylcinnamate-modified methacrylic acid-Bu methacrylate copolymer 574-93-6, Phthalocyanine 9002-89-5D, Poly(vinyl alcohol), esters with phthalic anhydride, glycidyl ethoxycarbonylvinylcinnamate, and acetic anhydride 9010-92-8D, Methacrylic acid-styrene copolymer, esters with glycidyl ethoxycarbonylvinylcinnamates and acetic anhydride 9011-13-6D. esters with methanol, glycidyl ethoxycarbonylvinylcinnamate, and acetic anhydride 25086-15-1D. Methacrylic acid-methyl methacrylate copolymer, esters with glycidyl ethoxycarbonylvinylcinnamates and acetic anhydride 25087-26-7D, Polymethacrylic acid, esters with glycidyl ethoxycarbonylvinylcinnamates and acetic anhydride 25213-61-0D, Monomethyl maleate-styrene copolymer, esters with glycidyl ethoxycarbonylvinylcinnamates and acetic anhydride 25215-60-5D, Monoethyl maleate-styrene copolymer, esters with glycidyl ethoxycarbonylvinylcinnamate and acetic anhydride 25322-25-2D, Acrylic acid-methyl methacrylate copolymer, esters with glycidyl ethoxycarbonylvinylcinnamates and acetic anhydride 26284-14-0D, esters with glycidyl ethoxycarbonylvinylcinnamates and acetic anhydride 26355-01-10, 2-Hydroxyethyl methacrylate-methyl methacrylate copolymer, esters with phthalic anhydride, glycidyl ethoxycarbonylvinylcinnamate, and acetic anhydride 26711-20-6D, Itaconic anhydride-styrene copolymer, esters with methanol, glycidyl ethoxycarbonylvinylcinnamate, and acetic anhydride 75361-25-0D, esters with glycidyl ethoxycarbonylvinylcinnamate and acetic anhydride 87701-04-0D, esters with glycidyl ethoxycarbonylvinylcinnamates and acetic anhydride 103974-10-3D, esters with methacrylic acid copolymers and acetic anhydride 114975-31-4D, esters with glycidyl ethoxycarbonylvinylcinnamate and acetic anhydride 114975-32-5D, esters with glycidyl ethoxycarbonylvinylcinnamate and acetic

anhydride 114975-33-6D, esters with glycidyl

ethoxycarbonylvinylcinnamates and acetic anhydride 115127-93-00, esters with methacrylic acid copolymers and acetic anhydride 115127-94-1D, esters with methacrylic acid copolymers and acetic anhydride 115127-95-2 115394-93-9D, esters with glycidyl ethoxycarbonylvinylcinnamate and acetic anhydride RL: USES (Uses)

(photosensitive resin compos. containing, for presensitized printing plates)

L38 ANSWER 12 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1987:449566 HCAPLUS Full-text

DOCUMENT NUMBER: 107:49566

ORIGINAL REFERENCE NO.: 107:8087a,8090a

TITLE: Photosensitive polymer compositions

INVENTOR(S): Fujii, Kenichi; Goto, Yoshitaka; Yazawa,

Toshiya; Yamada, Eiichi
PATENT ASSIGNEE(S): Nippon Oils & Fats Co.,

PATENT ASSIGNEE(S): Nippon Oils & Fats Co., Ltd., Japan SOURCE: Jpn. Kokai Tokkyo Koho, 6 pp.

CODEN: JKXXAF

DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: : PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 61249045	A	19861106	JP 1985-90593	198504
PRIORITY APPLN. INFO.:			< JP 1985-90593	26
				198504 26

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GI

$$\begin{bmatrix} R^2 & R^2 \\ R^1 & R^2 \\ R^2 & R^2 \end{bmatrix}_{n} R = \begin{bmatrix} R^4 & R^5 \\ R^3 & R^7 \end{bmatrix}$$

AB The photopolymerizable title compas. contain film-forming polymers, polymerizable monomers, photopolymn. initiators containing organic peroxides, and 0.1-10% (based on the monomers) 21 hindered amines of the formulas I and II (R1, R2 = H, alky1; n = 1-4; R = 1-4 valent carboxylic acid residue; R3-R6 = H, alky1; R7 = H, alkoy). The compas. show excellent preservation stability, especially to heat. Thus, 10:90 (mol) 2-hydroxyethyl methacrylate—Me methacrylate copolymer (mol. weight 60,000) 60, pentaerythritol triacrylate 40, di-tert-Bu peroxyisophthalate 4, thioflavine 5 3, Sanol LS 765 [bis(1,2,2,6,6-pentamethyl-4-piperidyl) sebacate) 0.5, and methyl Cellosolve 1000 parts were mixed to obtain a composition, which was coated onto an Al

sheet and dried to form a $1-\mu$ photosensitive polymer film. The resulting plate was kept at 80°, exposed, and developed, showing fog occurrence when kept at 80° for 19 h vs. 0.1 h without Sanol LS 765. RL: USES (Uses) (photosensitive composition containing, heat-resistant) RN 26355-01-1 HCAPLUS CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME) CM 1 CRN 868-77-9 CMF C6 H10 O3 Me_C_C_C_CH2_CH2_OH CM 2 CRN 80-62-6 CMF C5 H8 O2 H2C Me_U_U_OMe ICM G03C001-68 ICS C08K005-34; C08L101-00; G03C001-00 CC 74-4 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) photosensitive polymer compn heat stability; acrylic ST copolymer amine photosensitive compn Photoimaging compositions and processes (containing acrylic polymers, heat-resistant) 91-53-2 110-26-9, N.N'-Methylenebisacrylamide tert-Butyl-peroxybenzoate 1326-12-1 2390-54-7, Thioflavine T 3524-68-3, Pentaerythritol triacrylate 4986-89-4, 2618-77-1 Pentaerythritol tetraacrylate 9002-89-5, Vinyl alchol polymer 9003-39-8, N-Vinylpyrrolidone polymer 15625-89-5, Trimethylolpropane triacrylate 26355-01-1 26780-96-1, Poly(2,2,4-trimethyl-1,2-dihydroquinoline) 33943-20-3, Di-tert-butylperoxvisophthalate 41556-26-7 52829-07-9, Sanol LS 770 77473-08-6 90164-34-4 RL: USES (Uses) (photosensitive composition containing, heat-resistant)

L38 ANSWER 13 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1986:543575 HCAPLUS Full-text DOCUMENT NUMBER: 105:143575 ORIGINAL REFERENCE NO.: 105:23001a,23004a

TITLE: Photosensitive resin composition

INVENTOR(S): Yazawa, Toshiya; Goto, Yoshitaka; Kawase, Koji;

Yamada, Eiichi

PATENT ASSIGNEE(S): Nippon Oils & Fats Co., Ltd., Japan Jpn. Kokai Tokkyo Koho, 4 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO. KIND DATE APPLICATION NO. DATE

JP 61065235 A 19860403 JP 1984-185448

198409 06

198409

PRIORITY APPLN. INFO.:

<--JP 1984-185448

06

AB The title composition consisting of a binder resin, a polymerizable compound, and a photopolymn. initiator contains tocopherol at 0.1-5% of the polymerizable monomer. The composition has improved storage stability and is usable as a material for pattern formation. Thus, a mixture containing 2-hydroxyethyl methacrylate—Memethacrylate copolymer 53.8, pentaerythritol triacrylate 44.1, tert-butylanthraquinone 2, tocopherol (E-mix 80) 0.4, and ethyl violet 0.1 part was dissolved in 5000 parts of an iso-PrOH-MEK 1:3 mixture and coated on a paper sheet to 1 µm (dry). The storage stability of the material was determined to be 1.5 yr from the photosensitivity measured after storage at 50°.

IT 26355-01-1

RL: USES (Uses)

(photosensitive resin composition containing tocopherol and, for improved storage stability)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9

CMF C6 H10 O3

CM 2

CRN 80-62-6 CMF C5 H8 O2

ICM G03C001-68 TC

ICS G03C001-00: G03F007-00

74-4 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

photosensitive resin compo storage stability; tocopherol

photosensitive resin compo stability

Photoimaging compositions and processes (containing tocopherol, for improved storage stability)

ΙT Tocopherols

RL: USES (Uses)

(photosensitive resin composition containing, for improved storage stability)

90-94-8 119-61-9, uses and miscellaneous 548-62-9 2390-59-2 3524-68-3 4986-89-4 5961-99-9 6652-28-4 9003-39-8 11121-48-5 15625-89-5 25086-15-1 26355-01-1

33943-20-3 37808-19-8 104493-53-0

RL: USES (Uses)

(photosensitive resin composition containing tocopherol and, for improved storage stability)

148-03-8 7616-22-0

RL: USES (Uses)

(photosensitive resin composition containing, for improved storage stability)

L38 ANSWER 14 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1986:543568 HCAPLUS Full-text

DOCUMENT NUMBER: 105:143568

ORIGINAL REFERENCE NO.: 105:22997a,23000a

TITLE: Photosensitive polymer compositions Yanagisawa, Kunio; Araki, Yasuhiko; Shobi,

INVENTOR(S):

Hajime Sekisui Chemical Co. Ltd., Japan Jpn. Kokai Tokkyo Koho, 6 pp.

SOURCE: CODEN: JKXXAF DOCUMENT TYPE: Patent

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT ASSIGNEE(S):

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
 JP 61025139	A	19860204	JP 1984-146627	198407 13
JP 03013582 PRIORITY APPLN. INFO.:	В	19910222	< JP 1984-146627	

198407

The photosensitive polymer compns. contain (A) a photopolymerizable unsatd. AB monomer having >2 terminal ethylenic group, (B) photosensitizers, (C) a polymer containing a OH-containing component, and (D) a compound containing ≥2 amineimide groups. The component D is typically a compound having the general

formula Z(CO:N-N+R1R2R3)n (Z, R, R1, R2, R3 = aliphatic or aromatic group that may contain O, S, or N atoms; n ≥2) or its polymer. The compast useful for preparation of printing plates and printed circuits are flame-resistant, storage stable, and readily curable to form durable layers. Thus, a composition containing 5:95 B-hydroxyethyl methacrylate-Me methacrylate copolymer 60, pentaerythritol triacrylate 30, benzophenone 3, Michler's ketone 0.5, p-methoxyphenol 0.5, and malonic acid bis[1,1-dimethyl-1-(2hydroxypropyl)amineimide] 2 parts was dissolved in MEK and coated on a PET film. The obtained material was heat-laminated onto a Cu-laminated board, exposed to UV through a neg. original, separated from the PET film, developed with a 1,1,1-trichloroethane spray, and treated at 150° for 10 min to obtain a fine protective pattern which was resistant to MEK, acetone, CHC13, trichloroethylene, MeOH, 10% H2SO4, toluene, xylene, and pH 12 acueous NaOH (at 70°). It was also resistant to 100 cycles of -65° to 125° treatment (each 1 h) and to 2 h dipping in a 260-270° solder bath. 26355-01-1

RL: USES (Uses)

(photosensitive polymer compas. containing

photopolymerizable ethylenic monomer and sensitizer and bisamineimide derivative and, for preparation of photoresists and soldering masks and protective coatings and printing plates)

RN 26355-01-1 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

ΙT

CRN 868-77-9

CMF C6 H10 O3

CM 2

CRN 80-62-6 CMF C5 H8 O2

CMF C5 H8 O2

IC ICM G03C001-68

ICS C08F002-48; C08F265-04; G03F007-10

CC 74-4 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

ST printed circuit photosensitive polymer compn; photosensitive polymer compn heat resistant; soldering mask photosensitive polymer complex

IT Soldering

(masks, photosensitive polymer compns. containing photopolymerizable ethylenic monomer and photosensitizer and hydroxo-containing polymer and bisamineimide derivative for fabrication

of)

IT Photoimaging compositions and processes

(photosensitive polymer compos. containing

photopolymerizable ethylenic monomer and photosensitizer and hydroxo-containing polymer and bisamineimide derivative as)

IT Printing plates

(photosensitive polymer compas, containing

photopolymerizable ethylenic monomer and photosensitizer and hydroxo-containing polymer and bisamineimide derivative for fabrication

of)

IT Resists

(photo-, photosensitive polymer compos. containing photopolymerizable ethylenic monomer and photosensitizer and hydroxo-containing polymer and bisamineimide derivative as)

IT Electric circuits

(printed, photosensitive polymer compns. containing photopolymerizable ethylenic monomer and photosensitizer and hydroxo-containing polymer and bisamineimide derivative for fabrication of)

T 90-94-8P 119-61-9P, uses and miscellaneous 6652-28-4P

RL: PREP (Preparation)

(photosensitive polymer compns. containing photopolymerizable ethylenic monomer and hydroxo-containing polymer and bisamineimide derivative and for preparation of photoresists and soldering masks and protective coatings and printing plates)

T 150-76-5

RL: USES (Uses)

(photosensitive polymer compas. containing

photopolymerizable ethylenic monomer and photosensitizer and hydroxo-containing polymer and bisamineimide derivative and, for preparation

of photoresists and soldering masks and protective coatings and printing plates)

IT 52352-15-5 104472-31-3 104472-32-4

RL: USES (Uses)

(photosensitive polymer compas. containing

photopolymerizable ethylenic monomer and photosensitizer and hydroxo-containing polymer and, for preparation of photoresists and soldering masks and protective coatings and printing plates)

IT 26355-01-1 76839-88-8

RL: USES (Uses)

(photosensitive polymer compos. containing

photopolymerizable ethylenic monomer and sensitizer and bisamineimide derivative and, for preparation of photoresists and

soldering masks and protective coatings and printing plates)

IT 3524-68-3

RL: USES (Uses)

(photosensitive polymer compass, containing photosensitizer and hydroxo-containing polymer and bisamineamide derivative and, for preparation of photoresists and soldering masks and protective coatings and printing plates)

L38 ANSWER 15 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1979:620360 HCAPLUS Full-text

DOCUMENT NUMBER: 91:220360

ORIGINAL REFERENCE NO.: 91:35371a,35374a

TITLE: Photosensitive resin compositions
INVENTOR(S): Iwaki, Akio; Kita, Toshiyasu; Sasazawa, Tatsuya;

Sasa, Nobumasa

PATENT ASSIGNEE(S): Konishiroku Photo Industry Co., Ltd., Japan

SOURCE:

Jpn. Kokai Tokkvo Koho, 9 pp.

CODEN: JKXXAF Patent

DOCUMENT TYPE: LANGUAGE:

Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 54098613	A	19790803	JP 1978-588	
				197801
				09
			<	
JP 61042251	В	19860919		
PRIORITY APPLN. INFO.:			JP 1978-588 A	
				197801

A photosensitive resin composition contains (1) a lipophilic resin binder and AB (2) a photosensitive reaction product of halogenated Lewis acid salt (or perhalate salt) with a diazo resin which is prepared by condensation of a diazo compound with an active carbonyl-group-containing organic compound The photosensitive resin compas. have good shelf life and give relief images having good mech. strength, and hence the resin compass. are useful in relief printing plates or resists. Thus, a diazo resin (aromatic diazonium compoundaldehyde condensation product; double salt with ZnC12 and H2SO4) was dissolved in H2O, reacted with NH4PF6 to give a water-insol, diazo resin salt. The salt 0.5, 2-hydroxyethyl methacrylate 30, Me methacrylate-Bu acrylate (30:65:5 weight ratio) copolymer 5.0, tricresyl phosphate 0.5, Victoria Pure Blue BOH 0.1 q, and Me Cellosolve are mixed and the mixture was coated on an Al support. The plate was imagewise exposed and developed with a solution containing PhCH2OH and Alkanol XC to give a relief printing plate having excellent durability (≥100,000 prints).

26355-01-1

RL: USES (Uses)

(photosensitive diazo resin compos. containing, for photoresists and relief printing plates)

26355-01-1 HCAPLUS RN

2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CN

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 80-62-6

CMF C5 H8 O2

IC G03C001-71; G03F007-02; H05K003-06

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic Processes)

Section cross-reference(s): 76

IT Acrylic polymers, uses and miscellaneous Epoxy resins, uses and miscellaneous

RL: USES (Uses)

(photosensitive diazo resin compas. containing, for photoresists and relief printing plates)

IT 1325-85-5 1330-78-5 2390-60-5 9004-57-3 25035-68-1 25035-89-6 25951-39-7 25987-66-0 26355-01-1 59592-92-6 67185-56-2 72063-21-9

RL: USES (Uses)

(photosensitive diazo resin compos. containing,

for photoresists and relief printing plates)

T 7790-98-9D, reaction products with diazo photosensitive resin 16941-11-0D, reaction products with diazo photosensitive resin RL: USES (Uses)

(photosensitive resin compas. containing, for relief images)

L38 ANSWER 16 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1976:454617 HCAPLUS Full-text

DOCUMENT NUMBER: 85:54617

ORIGINAL REFERENCE NO.: 85:8773a,8776a
TITLE: Photosensitive compositions for

presensitized lithographic printing plates

INVENTOR(S): Kita, Nobuyuki; Narutomi, Yasuhisa
PATENT ASSIGNEE(S): Fuji Photo Film Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 10 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent
LANGUAGE: Japanese
FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 50112101	A	19750903	JP 1974-13464	
				197402 01
			<	
JP 56009697	В	19810303		
PRIORITY APPLN. INFO.:			JP 1974-13464 A	
				197402
				01

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AB Light-sensitive compas. for presensitized lithog, plates are composed of a diazo compound, a copolymer having ≥50 weight% monomeric units of structure I (R1 = H, Me; R2 = H, Me, Et, chloromethyl; n = 1-10), and a low mol. weight polyurethane resin R4CONHZNHCO[O(CH2CHR3O)mCONHZNHCO]pR4 [R4 = monohydric alc. residue, HO(C2CHR3O)m, Z = isocvanate compound residue; R3 = H, Me; m ≥2; and p = 1-10]. The addition of the polyurethane resin improves the developability of the compas. without reducing their sensitivity, printing durability, and lipophilicity. Thus, toluene diisocyanate 54 and triethylene glycol 30 g were heated at 140° under N, β -hydroxyethyl methacrylate 26 g was then added, and the mixture was heated for 10 hr at 80° to give a polyurethane resin with an isocyanate value of 4.1. The polyurethane resin 0.20, β -hydroxyethyl methacrylate-methyl methacrylate (70-30) copolymer 0.6, 2-methoxy-4-hydroxy-5benzovlbenzenesulfonate of p-diazodiphenvlamine-paraformaldehyde condensate 0.2, Oil Blue 603 (Orient Chemical Co.) 0.03, ZnCl2 0.02, and 4,4'-thiobis(3methyl-6-tert-butylphenol) 0.01 g were mixed, and coated as a 0.8 g/m2 dry layer on an Al support to give a presensitized lithog. plate which was imagewise exposed to a 30-A C arc lamp at 70 cm for 40 sec. and developed with a solution consisting of Monogen Y-100 60, benzyl alc. 10, MgSO4.7H2O 15, citric acid 5, and H2O 910 g. The time required for the development was 7 sec and the printing lifetime was 15,000 prints. TТ 26355-01-1

RL: USES (Uses)

(photopolymerizable composition containing diazo compound, urethane polymer and, for lithog. plates)

26355-01-1 HCAPLUS RN CN

2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME)

CM

CRN 868-77-9 CMF C6 H10 O3

CM

CRN 80-62-6 CMF C5 H8 O2

G03F; G03C; C08L

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic Processes)

Urethane polymers, uses and miscellaneous RL: USES (Uses)

> (photopolymerizable compas. containing diazo compound, acrylic copolymer and, for presensitized lithog. plates)

Acrylic polymers

RL: USES (Uses)

(photopolymerizable compas. containing diazo compound, urethane polymer and, for lithog, plates)

Lithographic plates

(photopolymerizable compas. for, containing diazo compound,

acrylic copolymer and urethane polymer)

96-69-5 4065-45-6D, Benzenesulfonic acid, 5-benzoyl-4-hydroxy-2-methoxy-, reaction product with diazodiphenylamine-paraformaldehyde condensate 16072-57-4D, Benzenediazonium, 4-(phenylamino)-, reaction product with paraformaldehyde and hydroxymethoxybenzoylbenzenesulfonic acid 30525-89-4D, Paraformaldehyde, reaction product with diazodiphenvlamine and hydroxymethoxybenzovlbenzenesulfonic acid

RL: USES (Uses) (photopolymerizable composition containing acrylic copolymer, urethane polymer and, for lithog. plates)

59158-36-0

RL: USES (Uses)

(photopolymerizable composition containing diazo compound, acrylic copolymer and, for lithog, plates)

26355-01-1 RL: USES (Uses)

> (photopolymerizable composition containing diazo compound, urethane polymer and, for lithog, plates)

L38 ANSWER 17 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN

ACCESSION NUMBER: 1975:606945 HCAPLUS Full-text

83:206945 DOCUMENT NUMBER:

ORIGINAL REFERENCE NO.: 83:32583a,32586a

TITLE . Photosensitive material

AUTHOR(S): Foster, J. S.; Brandon, R.; Wagner, H. M. CORPORATE SOURCE: Kodak Ltd., London, UK

SOURCE: Research Disclosure (1975), 137, 17-18 (No. 13723)

CODEN: RSDSBB; ISSN: 0374-4353

Journal; Patent

DOCUMENT TYPE:

LANGUAGE: English FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
RD 137023		19750910	RD 1975-137023	197509 10
			<	

RD 1975-137023 PRIORITY APPLN. INFO.: 197509 10

AB Polymer [57308-05-1] prepared by treating hydroxyethyl methacrylate-methyl methacrylate polymer (I) [26355~01-1] (1:5) with C13CCOC1 [76-02-8] was mixed with styrene [100-42-5] and Mn2(CO)10 [10170-69-1] in cyclohexane, an Al foil

coated with this composition, dried, exposed to Hg vapor lamp, developed to produce a resist image, and used in an offset process giving good clean copies. I was also treated with CH2:CHCOCl [814-68-6] to give an unsatd. polymer [57308-04-0] useful for photosensitive composition 26355-01-1P RL: RCT (Reactant); SPN (Synthetic preparation); PREP (Preparation); RACT (Reactant or reagent) (preparation and reaction with acid chlorides) 26355-01-1 HCAPLUS CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate (CA INDEX NAME) CM 1 CRN 868-77-9 CMF C6 H10 O3 Me_U_U_U_O_CH2_CH2_OH CM 2 CRN 80-62-6 CMF C5 H8 O2 H2C Me_U_U_U 36-6 (Plastics Manufacture and Processing) Section cross-reference(s): 74 trichloroacetyl polymethacrylate photoresist compa; printing plate photoresist Printing plates (photopolymerizable compns. for, containing trichloroacetyl ester of hydroxyethyl methacrylate polymers) 100-42-5, uses and miscellaneous RL: USES (Uses) (photopolymerizable compas. containing, for resists) 10170-69-1 RL: USES (Uses) (photopolymerizable methacrylate-styrene compas. containing, for resists) 57308-05-1 RL: USES (Uses) (photosensitive compos. containing, for photoresist) 26355-01-IP RL: RCT (Reactant); SPN (Synthetic preparation); PREP (Preparation); RACT (Reactant or reagent) (preparation and reaction with acid chlorides)

L38 ANSWER 18 OF 18 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1975:44397 HCAPLUS Full-text DOCUMENT NUMBER: 82:44397

RN

ST

ΙT

ORIGINAL REFERENCE NO.: 82:7077a,7080a

TITLE: Light-sensitive resin compositions

INVENTOR(S): Tsukada, Katsushige; Isobe, Asao; Havashi,

Nobuyuki; Abo, Masahiro; Ogawa, Ken PATENT ASSIGNEE(S): Hitachi Chemical Co., Ltd.

Ger. Offen., 20 pp.

SOURCE: CODEN: GWXXBX

DOCUMENT TYPE: Patent

LANGUAGE: German FAMILY ACC. NUM. COUNT: 2

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
DE 2406400	A1	19740905	DE 1974-2406400	197402 11
			<	
DE 2406400	B2	19770428		
JP 49107333	A	19741011	JP 1973-17914	
				197302 14
			<	
JP 50030515	A	19750326	JP 1973-80345	197307 18
			<	10
JP 51040451	В	19761104		
JP 50055404	A	19750515	JP 1973-105064	
				197309 19
			<	
JP 52028159	В	19770725		
PRIORITY APPLN. INFO.:			JP 1973-17914 A	197302 14
			<	
			JP 1973-80345	197307
				18
			<	
			JP 1973-105064 A	197309 19

AB Light-sensitive resin compas, were manufactured by compounding photopolymerizable glycol acrylates with sensitizers, epoxy resins, diamine or diacid epoxy curing agents, hardening accelerator, and polyacrylates or allyl polymers and were useful for printed circuits and in precision metal work. Thus, a mixture of methacrylic acid-methyl methacrylate copolymer [25086-15-1] 40, pentaerythritol triacrylate [3524-68-3] 30, ECN 1280 [51875-34-4] epoxy resin 25, dicyandiamide [461-58-5] 1.5, benzophenone [119-61-9] 2.7, Michler's ketone [90-94-8] 0.3, p-methoxyphenol [150-76-5] 0.6, and methyl ethyl ketone 200 parts was coated on Cu-plated laminate, dried for 10 min at room temperature then for 10 min at 80° to give a 20 μ light sensitive coat which overlaid with 25 μ transparent poly(ethylene terephthalate) film, exposed to 3 kW super high pressure Hg lamp with 4,000 µW/cm2 intensity for 60 sec from negative mask, and developed with MeCCl3 for 1 min to give protective film

applicable to etching, galvanizing or strong alkaline nonelectrolytic chemical RL: USES (Uses) (light-sensitive compas., containing acrylate and epoxy resins) RN 26355-01-1 HCAPLUS 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with CN methyl 2-methyl-2-propengate (CA INDEX NAME) CM 1 CRN 868-77-9 CMF C6 H10 O3 Me_U_U_U_O_CH2_CH2_OH CM 2 CRN 80-62-6 CMF C5 H8 O2

H2C _U_U______

IC C08F; C09D

36-6 (Plastics Manufacture and Processing) Section cross-reference(s): 74

light sensitive polymer compo; polymethacrylate acrylate ST resin compn; epoxy resin acrylate compn; dimethylaminobenzophenone acrylate resin compn

Epoxy resins

RL: USES (Uses)

(light-sensitive compos., containing acrylates and polymethacrylates)

25053-15-0 25086-15-1 26141-88-8 26355-01-1 RL: USES (Uses)

(light-sensitive compas., containing

acrylate and epoxy resins)

25068-38-6 56361-55-8 63992-68-7 63992-68-7 RL: USES (Uses)

> (light-sensitive compas., containing acrylates and polymethacrylates)

3524-68-3 4986-89-4 15625-89-5 25852-47-5 26570-48-9 RL: USES (Uses)

(light-sensitive compas., containing epoxy resins and polymethacrylates)

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L46 ANSWER 1 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN

ACCESSION NUMBER: 2007:697903 HCAPLUS Full-text

DOCUMENT NUMBER: 147:96375

TITLE: Urethane acrylate-based photocurable resin

compositions and their stereo-lithography process

INVENTOR(S): Ito, Takashi; Hagiwara, Tsuneo; Nakamura,

Takayuki; Nakamura, Seisaku

PATENT ASSIGNEE(S): Cmet Inc., Japan; Shin-Nakamura Chemical Co.,

SOURCE: Ltd.
Jpn. Kokai

OURCE: Jpn. Kokai Tokkyo Koho, 34pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent

LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

200512 16

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PRIORITY APPLN. INFO.: JP 2005-363244

200512 16 41

The compast contain (i) ≥1 kinds of urethanized acrylic compds. represented by AB the general formula [[(CH2:CR1CO2)dAOCONH]eDNHCO2GCH2]fCR24-f [I; R1 = H, Me; d = 1, 2; when d = 2, one or both of R1 = Me; A = diol or triol residue; D = divalent or trivalent (un) substituted hydrocarbylene; G = (CH2CH2O)q (q = 1-4 integer), (CH2CHMeO)h (h = 1-4 integer), (CH2CH2O)j(CH2CHMeO)k (j, k = 1-3 integer, j + k = 2-4; R2 = H, alkyl; e = 1, 2; f = 3, 4], (ii) monofunctional acrylates represented by the general formula R302CCH:CH2 (II; R3 = C5-20 hydrocarbyl), (iii) (meth)acrylates other than I nor II, and (iv) actinic energy ray-sensitive radical polymerization initiators. Thus, reacting 187.2 g Aronix M 5600 (acrylic acid dimer) with 142 g glycidyl methacrylate in the presence of Et3N gave a glycerin (meth)acrylate of a formula HOCH(CH2CO2CMe:CH2)(CH2CO2CH2CH2CO2CH:CH2), 288.8 g of which was mixed with 0.48 g metoquinone, added dropwise to a mixture of isophorone diisocyanate 177.6, morpholinoacrylamide (III) 205.6, and dibutyltin dilaurate 0.48 g, and stirred at 80-90° for 2 h. Then 72.3 g pentaerythritol propylene oxide 4 mol adduct was added dropwise to the mixture and reacted at 80-90° to give a transparent viscous liquid of the reaction product containing an urethanized acrylic compound I [d = 2, R1 = H and Me, A = glycerin residue; e = 1, D = isophorone group, G = propylene oxide group (h = 1), f = 4] (Ia) and III. A transparent viscous (500 mPa.s at 25°) composition comprised the reaction product containing Ia and III 500, lauryl acrylate 100, isobornyl acrylate 200, tricyclodecanedimethanol diacrylate 300, and Irgacure 651 [2,2-dimethoxy-1,2-diphenylethan-1-one] 50 g. A 0.1-mm thick layer of the composition was scanned with a UV lamp via a stereo-lithog, apparatus having a TFT-VGA liquid crystalline mask whose image was changed dynamically and continuously as scanned to give a test piece with low curing shrinkage.

IT 942430-57-1P

RL: IMF (Industrial manufacture); RCT (Reactant); PREP (Preparation); RACT (Reactant or reagent)

(urethane acrylate-based photocurable resin compos. and their stereo-lithog, process)

RN 942430-57-1 HCAPLUS

CN Poly(oxy(methyl-1,2-ethanediyl)), α-hydro-ω-hydroxy-,

ether with 2,2-bis(hydroxymethyl)-1,3-propanediol (4:1), tetraester with N-[3-[(acrboxymino)methyl]-3,5,5-trimethylcyclohexyl]carbamic acid mono[2-[(1-oxo-2-propen-1-yl)oxy]ethyl] ester (CA INDEX NAME)

CM :

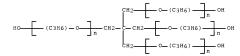
CRN 52337-42-5 CMF C12 H22 N2 O4

CM

CRN 9051-49-4

CMF (C3 H6 O)n (C3 H6 O)n (C3 H6 O)n (C3 H6 O)n C5 H12 O4

CCI IDS, PMS



CM 3

CRN 818-61-1 CMF C5 H8 O3

- CC 37-6 (Plastics Manufacture and Processing)
- ST urethane acrylate photocurable compn stereo lithog
- IT Polyurethanes, preparation

RL: IMF (Industrial manufacture); RCT (Reactant); PREP

(Preparation); RACT (Reactant or reagent) (acrylate-terminated, polyoxyalkylene-; urethane acrylate-based photocurable resin comp.rs. for stereo-lithog.)

T Polyurethanes, preparation

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(acrylic-polyoxyalkylene-, crosslinked; urethane acrylate-based

November 26, 2008 photocurable resin compas. for stereo-lithog.) Polyoxyalkylenes, preparation RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (acrylic-polyurethane-, crosslinked; urethane acrylate-based photocurable resin compas. for stereo-lithog.) ΤТ Lithography (urethane acrylate-based photocurable resin compos. for stereo-lithog.) 127823-21-6, A-TCM RL: RCT (Reactant); RACT (Reactant or reagent) (A-TCM; urethane acrylate-based photocurable resin compas . and their stereo-lithog. process) 942430-54-8P 942430-55-9P 942430-56-0P 942430-58-2P 942434-81-3P 942439-81-8P RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (crosslinked; urethane acrylate-based photocurable resin compas. and their stereo-lithog, process) 24650-42-8, Irgacure 651 75980-60-8, Darocure TPO RL: CAT (Catalyst use); USES (Uses) (urethane acrylate-based photocurable resin compas. and their stereo-lithog. process) 942430-57-1P 942434-80-2P RL: IMF (Industrial manufacture); RCT (Reactant); PREP (Preparation); RACT (Reactant or reagent) (urethane acrylate-based photocurable resin compns. and their stereo-lithog, process) 5888-33-5, Isobornyl acrylate 7398-56-3, FA 513A 42594-17-2, A-DCP 942434-82-4 RL: RCT (Reactant); RACT (Reactant or reagent) (urethane acrylate-based photocurable resin compas, and their stereo-lithog, process) 286426-01-5P 286426-03-7P RL: IMF (Industrial manufacture); RCT (Reactant); PREP (Preparation); RACT (Reactant or reagent) (urethane acrylate-based photocurable resin compos, for stereo-lithog.) 2156-97-0, Lauryl acrylate 53058-82-5 RL: RCT (Reactant); RACT (Reactant or reagent) (urethane acrylate-based photocurable resin compas. for stereo-lithog.) L46 ANSWER 2 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN 146:216374

ACCESSION NUMBER: 2007:58799 HCAPLUS Full-text DOCUMENT NUMBER: TITLE: Photosensitive composition and laminated products INVENTOR(S): Igarashi, Tsutomu; Yamashita, Hidetoshi PATENT ASSIGNEE(S): Asahi Kasei Electronics Co., Ltd., Japan SOURCE: Faming Zhuanli Shenging Gongkai Shuomingshu, 29pp. CODEN: CNXXEV

DOCUMENT TYPE: Patent LANGUAGE: Chinese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

CN 1892424	A	20070110	CN 2006-10094231	200606 27
JP 2007041497	А	20070215	< JP 2005-354220	21
JP 200/04149/	А	20070215	JP 2005-354220	200512 08
			<	
JP 2007041498	A	20070215	JP 2005-354221	
				200512 08
			<	
PRIORITY APPLN. INFO.:			JP 2005-187786	A 200506 28
			<	
			JP 2005-354221	A 200512 08
			<	

OTHER SOURCE(S): MARPAT 146:216374

AB The title composition comprises carboxyl-containing binder resins 20-90, photopolymerizable unsatd. compds. 3-70, and photopolymn. initiators 0.1-20 weights. The carboxyl-containing binder resins have acid value of 100-600 and weight-average mol. weight of 5,000-500,000. The photopolymerizable unsatd. compds. are bisphenol A-polyoxyalkylene ether (meth)acrylates. The photoresist resin composition and its laminate have the advantages of good dispersing stability in the developing solution, no coacervate formation, and good resolution and binding property after developing. The photoresist laminate has pore-covering property and good antietching property.

IT 39420-45-6D, Blemmer PP 1000, reaction products with

hexamethylene diisocyanate, methacrylates

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive composition and laminated

products)

RN 39420-45-6 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)],

 $\alpha\text{-(2-methyl-1-oxo-2-propen-1-yl)-}\omega\text{-hydroxy-}$ (CA INDEX NAME)

- CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)
- IT Photoresists
- (photosensitive composition and laminated products)
- IT Laminated plastics, uses
- RL: TEM (Technical or engineered material use); USES (Uses)
 (photosensitive composition and laminated products)
- IT 90-93-7, 4,4*-Bis(diethylamino)diphenyl ketone 1338-39-2, Ionet S 20 1707-67-ID, 2-(2-Chlorophenyl)-4,5-diphenylimidazole, dimer 9005-70-3, Newcol 3-80 Els MOA (Modifier or additive use); USES (Uses)

November 26, 2008 10/577,255 45

(photosensitive composition and laminated products)

179-41-4D, Methacrylic acid, reaction products with reaction products of hexamethylene disocyanate and polypropylene glycol monomethacrylate, 548-62-9, Crystal violet 633-03-4, Diamond Green GH 25035-69-2, Methyl methacrylate-methacrylic acid-butyl acrylate copolymer 25035-81-8, Methyl methacrylate-methacrylic acid-styrene copolymer 37353-75-6, Bisphenol A-propylene oxide adduct 39420-45-60, Blemmer PP 1000, reaction products with hexamethylene disocyanate, methacrylates 41637-38-1, NK ester BPE 500 56744-60-6, NK ester BPE 200 65722-01-2, Victoria Pure Blue 72270-11-2, LS-100A 119564-97-5 194497-24-0
RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive composition and laminated products)

L46 ANSWER 3 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN

ACCESSION NUMBER: 2006:1202448 HCAPLUS <u>Full-text</u>
DOCUMENT NUMBER: 145:497693

TITLE: Modified silica particles, photosensitive

composition containing same, and photosensitive lithography plate precursors

INVENTOR(S): pnotosensitive litnography plate precurso:

PATENT ASSIGNEE(S): Eastman Kodak Company, USA SOURCE: PCT Int. Appl., 64pp.

CODEN: PIXXD2
DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PAT	TENT	NO.			KIN	D	DATE		APPLICATION NO.			O. DATE		ATE		
	2006		72		A1		2006	1116		WO 2		JP30	9610		2	00605 8
		CH, GB, KP, MN, RU, UA, AT, IE, BF, TG,	CN, GD, KR, MW, SC, UG, BE, IS, BJ, BW,	CO, GE, KZ, MX, SD, US, BG, IT, CF, GH,	CR, GH, LC, MZ, SE, UZ, CH, LT, CG, GM,	CU, GM, LK, NA, SG, VC, CY, LU, CI, KE,	AU, CZ, HR, LR, NG, SK, VN, CZ, LV, CM, LS,	DE, HU, LS, NI, SL, YU, DE, MC, GA, MW,	DK, ID, LT, NO, SM, ZA, DK, NL, GN,	DM, IL, LU, NZ, SY, ZM, EE, PL, GQ, NA,	DZ, IN, LV, OM, TJ, ZW ES, PT, GW, SD,	EC, IS, LY, PG, TM, FI, RO, ML,	EE, KE, MA, PH, TN, FR, SE, MR,	EG, KG, MD, PL, TR, GB, SI, NE,	ES, KM, MG, PT, TT, GR, SK, SN,	FI, KN, MK, RO, TZ, HU, TR, TD,
JP	2006											1404	11		_	00505
EP	1880	978			A1		2008	0123	:	EP 2		7463	57		2:0:	00605
CN	R: 1011		FR, 5	GB	A		2008	0507		CN 2	>	8001	6397		2	00711

PRIORITY APPLN. INFO.:

12

46

- AB Adhesion between a photosensitive layer and a supporting body of a photosensitive lithog. plate is adequately maintained after exposure to light. Modified silica particles whose surfaces are modified with an organic compound having at least one ethylenically unsatd. group, at least one hydrophilic molety and at least one silyloxy group are blended in a photosensitive layer of a photosensitive lithos. plate.
- IT 26403-59-7DP, Polyethylene glycol monoacrylate, reaction product with alkyl trialkoxy silane, polymerized 39420-45-6DP, Polypropylene glycol monomethacrylate, reaction product with alkyl trialkoxy silane, polymerized RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (modified silica particles, photosensitive composition containing same, and photosensitive
- lithog. plate precursors)
- RN 26403-58-7 HCAPLUS
- CN Poly(oxy-1,2-ethanediy1), α-(1-oxo-2-propen-1-y1)-ωhydroxy- (CA INDEX NAME)

$$\mathtt{H}_{2}\mathtt{C} \underline{\hspace{1cm}} \mathtt{C}\mathtt{H} \underline{\hspace{1cm}} \overset{\circ}{\mathtt{C}} \underline{\hspace{1cm}} \mathtt{C} - \mathtt{C}\mathtt{H}_{2} \underline{\hspace{1cm}} \mathtt{C}\mathtt{H}_{2} \underline{\hspace{1cm}} \mathtt{D} + \mathtt{C}\mathtt{D} + \mathtt{D} + \mathtt{C}\mathtt{D} + \mathtt{C}\mathtt{D} + \mathtt{C}\mathtt{D} + \mathtt{D}$$

- RN 39420-45-6 HCAPLUS
- CN Poly[oxy(methyl-1,2-ethanediyl)], α -(2-methyl-1-oxo-2-propen-1-yl)- ω -hydroxy- (CA INDEX NAME)

- CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)
- ST silica particle photosensitive compo lithog plate precursor
- IT Lithographic plates
 - (photosensitive precursors; modified silica particles, photosensitive composition containing same, and photosensitive lithog. plate precursors)
- IT 107-11-9DP, Allylamine, copolymer with acrylic monomer 107-18-6DP, Allyl alcohol, copolymer with acrylic monomer 9004-74-4DP, Polyethylene glycol monomethyl ether, reaction product with alkyl

trialkoxy silane, polymerized 24801-88-5DP, reaction product with alkyloxylene ether 26403-58-7DF, Polyethylene glycol monoacrylate, reaction product with alkyl trialkoxy silane, polymerized 39420-45-6DF, Polypropylene glycol monomethacrylate, reaction product with alkyl trialkoxy silane, polymerized 860478-34-BDP, Bayhydur VPLS 2306, reaction product with alkyl trialkoxy silane, polymerized RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(modified silica particles, photosensitive composition containing same, and photosensitive

lithog, plate precursors)

REFERENCE COUNT:

THERE ARE 6 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

L46 ANSWER 4 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2006:543953 HCAPLUS Full-text

DOCUMENT NUMBER: 145:37339

TITLE: Photosensitive resin composition, ink

jet recording head using such composition and method for manufacturing

such recording head

INVENTOR(S): Ishikura, Hiroe; Shiba, Shoji; Okano, Akihiko

PATENT ASSIGNEE(S): Canon Kabushiki Kaisha, Japan SOURCE: U.S. Pat. Appl. Publ., 14 pp.

CODEN: USXXCO
DOCUMENT TYPE: Patent

LANGUAGE: English
FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
US 20060117564	A1	20060608	US 2005-291956	200512 02
JP 2006162769	A	20060622	Z JP 2004-351347	200412 03
PRIORITY APPLN. INFO.:			JP 2004-351347 A	200412 03

AB The present invention provides a method for manufacturing a high quality ink jet head, and an ink jet head manufactured by such a method, in which, in a case where a coating resin layer constituting ink flow path walls is formed, even when a solvent having a strong dissolving force is used, it is not feared that a configuration of an ink flow path pattern is distorted. In the method, a photosensitive resin composition layer in which an inter-mol. bridging reaction proceeds by irradiation of an ionization radiant ray having a first wavelength band and a mol. decaying reaction of main chain decomposing type of the resin proceeds by irradiation of an ionization radiant ray having a second wavelength band different from the first wavelength band is formed on a substrate on which energy generating elements were provided. Thereafter, an ink flow path pattern is formed by the irradiation of the ionization radiant ray having the first wavelength band and a developing process. Then, a

coating resin layer constituting ink flow path walls is formed on the ink flow path pattern. After ink discharge ports are formed, the photosensitive resin composition layer forming the ink flow path pattern is dissolved and removed by irradiating the ionization radiant ray having the second wavelength band. 31292-66-7, Hydroxymethyl methacrylamide-methyl methacrylate copolymer RL: DEV (Device component use); TEM (Technical or engineered material use); USES (Uses) (photosensitive resin composition, ink jet recording head using such composition and method for manufacturing such recording head) 31292-66-7 HCAPLUS 2-Propenoic acid, 2-methyl-, methyl ester, polymer with N-(hydroxymethyl)-2-methyl-2-propenamide (9CI) (CA INDEX NAME) CM CRN 923-02-4 CMF C5 H9 N O2 H2C Me_U_U_NH_CH2_OH CM 2 CRN 80-62-6 CMF C5 H8 O2 H2C Me_U_U_OMe INCL 029890100; 347001000; 430270100 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38 ink jet recording head printer manuf photosensitive resin compn Photoimaging materials (photopolymerizable; photosensitive resin composition, ink

ST

jet recording head using such composition and method for manufacturing such recording head)

Ink-jet printer heads

Photoresists

(photosensitive resin composition, ink jet recording head using such composition and method for manufacturing such recording head)

Aminoplasts

RN

RL: CAT (Catalyst use); USES (Uses)

(photosensitive resin composition, ink jet recording head using such composition and method for manufacturing such recording head)

125054-47-9, SP 170 RL: CAT (Catalyst use); USES (Uses)

(cationic photopolymn. initiator; photosensitive resin composition, ink jet recording head using such compo-. and method for manufacturing such recording head)

IT 9003-08-1, MW 30HM

RL: CAT (Catalyst use); USES (Uses)

(photosensitive resin composition, ink jet recording head using such composition and method for manufacturing such recording head)

26141-88-8, Glycidyl methacrylate-methyl methacrylate copolymer 31260-64-7 31292-66-7, Hydroxymethyl methacrylamide-methyl methacrylate copolymer 68103-75-3, Glycidyl methacrylate-phenyl methacrylate copolymer 85920-08-7, Glycidyl methacrylate-methyl isopropenyl ketone copolymer 889447-24-9, Glycidyl methacrylate-phenyl isopropenyl ketone copolymer 889447-26-1, Glycidyl methacrylate-methyl isopropenyl ketone-methyl methacrylate

RL: DEV (Device component use); TEM (Technical or engineered material use); USES (Uses)

(photosensitive resin composition, ink jet

recording head using such composition and method for manufacturing such recording head)

L46 ANSWER 5 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2006:437599 HCAPLUS <u>Full-text</u>

DOCUMENT NUMBER: 144:442679

TITLE: Photosensitive polymer compositions

for adhesives, their application to laminates and printing plates, and their manufacture

INVENTOR(S): Yamada, Hiroshi; Tomeba, Hiroshi

PATENT ASSIGNEE(S): Asahi Kasei Chemicals Corporation, Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 16 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION: PATENT NO. KIND DATE APPLICATION NO. DATE

JP 2006117858 A 20060511 JP 2004-309156 200410

25

PRIORITY APPLN. INFO.: JP 2004-309156

200410

AB The compass. contain (a) polymers having number-average mol. weight (Mn) 1000-500,000 and (b) polymerizable unsatd, group-containing organic compds, having Mn 100-1000, wherein the polymers of (a) contain 20-100 weight% of compds. with main chains containing carbonate bonds and urethane bonds and are photocrosslinkable. Laminates bearing adhesives obtained by applying the compass, on sheet or cylindrical supports and photocrosslinking the compas, are also claimed. Printing substrates in which polyester film-supported sheet

also claimed. The adhesives are manufactured by applying the compas, on sheet or cylindrical supports to form 0.5 µm to 5 mm-thick layers and irradiating light to the layers for photocrosslinking. The adhesives with specific

printing (master) plates are bonded on the adhesives of the laminates in such a way that the polyester film side are in contact with the adhesive side, are adhesion to polyesters are suitable for fixing flexible polyester film supports on plate cylinders of printers.

IT 39420-45-6, Polypropylene glycol monomethacrylate

RL: TEM (Technical or engineered material use); USES (Uses) (photocurable adhesive containing; photosensitive polymer compns. for adhesives with specific adhesion to polyester film supports in printing plates)

RN 39420-45-6 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)],

 α -(2-methyl-1-oxo-2-propen-1-yl)- ω -hydroxy- (CA INDEX NAME)

74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38

IT Laminated materials

(adhesive layer-bearing; photosensitive polymer compus. for adhesives with specific adhesion to polyester film supports in printing plates)

Adhesives

(photocurable; photosensitive polymer compns. for adhesives with specific adhesion to polyester film supports in printing plates)

T Polyesters, uses

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive polymer compos. for adhesives with specific adhesion to polyester film supports in printing plates)

IT Polyurethanes, preparation

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (polycarbonate-, methacryl-terminated, photocurable adhesive

containing; photosensitive polymer compns. for adhesives with specific adhesion to polyester film supports in printing plates)

IT Polycarbonates, preparation

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyurethane-, methacryl-terminated, photocurable adhesive containing, photosensitive polymer compns. for adhesives with specific adhesion to polyester film supports in printing plates)

Flexographic printing plates

(supports; photosensitive polymer compns. for adhesives with specific adhesion to polyester film supports in printing plates)

II 918885-95-7P, PCDLL 4672-TDI copolymer carbamate with 2-methacryloyloxy ethylisocyanate

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(photocurable adhesive containing; photosensitive polymer compass for adhesives with specific adhesion to polyester film supports in printing plates)

109-17-1, Tetraethylene glycol dimethacrylate 142-90-5, Lauryl methacrylate 3290-92-4, Trimethylolpropane trimethacrylate 10595-06-9, Phenoxyethyl methacrylate 13532-94-0 39420-45-6, Polypropylene glycol monomethacrylate 701908-05-6, Diethylene glycol-2-ethylhexyl methacrylate copolymer RL: TEM (Technical or engineered material use); USES (Uses) (photocurable adhesive containing; photosensitive polymer compas, for adhesives with specific adhesion to polyester film supports in printing plates)

25038-59-9, uses

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive polymer compas, for adhesives with specific adhesion to polyester film supports in printing plates)

L46 ANSWER 6 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2006:125370 HCAPLUS Full-text

DOCUMENT NUMBER: 144:202157

TITLE:

Photosensitive resin composition for manufacturing display panel electrode INVENTOR(S): Arihisa, Shinji; Ichise, Hiroyuki; Fujimori,

Jiro Asahi Kasei Electronics Co., Ltd., Japan; PATENT ASSIGNEE(S):

Pioneer Electronic Corp. SOURCE: Jpn. Kokai Tokkyo Koho, 15 pp.

EIND DATE

CODEN: JKXXAF

DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION: DATENT NO

AΒ

	PAIENI NO.	KTMD	DAIL	APPLICATION NO.	DAIL
	JP 2006039386	A	20060209	JP 2004-221838	
					200407
					29
				<	
PRIOR	RITY APPLN. INFO.:			JP 2004-221838	
					200407

Disclosed is a photosensitive resin composition comprising (a) an alkali soluble polymer 30-76%, (b) an addition polymerizable monomer 15-60%, (c) a photopolymn. initiator 0.01-20%, wherein the addition polymerizable monomer contains OH and C=C and the composition is applied on an Al or its alloy

ADDITION NO

DATE

substrate. 39420-45-6D, Blemmer PP1000, reaction product with hexamethylene diisocvanate RL: NUU (Other use, unclassified); USES (Uses)

(photosensitive resin composition for manufacture of display panel electrodes)

39420-45-6 HCAPLUS RN

Poly[oxy(methyl-1,2-ethanediyl)], CN

α-(2-methyl-1-oxo-2-propen-1-v1)-ω-hydroxy- (CA INDEX NAME)

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38

photosensitive resin compn display panel electrode resist

IT Optical imaging devices Photoimaging materials Plasma display panels

Resists

(photosensitive resin composition for manufacture of display panel electrodes)

Aluminum alloy, base

RL: NUU (Other use, unclassified); USES (Uses) (photosensitive resin composition for manufacture of display panel electrodes)

109-17-1, Tetraethylene glycol dimethacrylate 822-06-0D, Hexamethylene diisocyanate, reaction product with Blemmer PP1000 3524-68-3, Pentaerythritol triacrylate 7429-90-5, Aluminum, uses 15625-89-5, Trimethylolpropane triacrylate 28961-43-5, Ethoxylated trimethylolpropane triacrylate 39420-45-6D, Blemmer PP1000, reaction product with hexamethylene diisocyanate 57491-53-9, Nonaethylene glycol diacrylate 61370-16-9, β-Hydroxypropyl-β'-(acryloyloxy)propylphthalate RL: NUU (Other use, unclassified); USES (Uses) (photosessitive resin composition for manufacture of display panel electrodes)

L46 ANSWER 7 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2005:1153363 HCAPLUS Full-text

DOCUMENT NUMBER: 143:430033

TITLE: Photosensitive resin compositions and

their applications

INVENTOR(S): Igarashi, Tsutomu; Yamashita, Hidetoshi PATENT ASSIGNEE(S): Asahi Kasei Electronics Co., Ltd., Japan SOURCE:

Jpn. Kokai Tokkyo Koho, 20 pp.

CODEN: JKXXAF DOCUMENT TYPE: Patent. LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 2005301101	A	20051027	JP 2004-119974	200404 15

PRIORITY APPLN. INFO .: JP 2004-119974

> 200404 15

<--

The title composition contains 20-90% binder resin, 3-70% photopolymerizable unsatd. compds., and 0.1-10 % a photopolymn. initiator, wherein the binder resin contains 100-600 acid value corresponding to carboxyl groups, benzyl (meth)acrylate-based repeating units and has 5,000-500,000 weight average mol. weight and wherein the photopolymerizable compound has general structure H2=C(R1)-COO-(C2H4O)n1-(CH2C(CH3)HO)n2-(C2H4O)n3-CO-C(R2)=CH2(R1-2=H, CH3;n1-3 = integer 2-20) or alkoxylated bisphenol A diacrylate derivative The composition provides good electroconductive pattern profile and is suitable for chip on film(COF) devices.

39420-45-6, Blemmer PP 1000

RL: TEM (Technical or engineered material use); USES (Uses) (polymerizable compound; photosensitive resin

compos, and their applications)

RN 39420-45-6 HCAPLUS

CN Poly(oxy(methyl-1,2-ethanediyl)),

α-(2-methyl-1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX

IC ICM G03F007-033

ICS C08F002-44; C08F002-50; C08F020-26; G03F007-004; G03F007-027; G03F007-029; H05K003-06; H05K003-18

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 76

photosensitive resin compo polymer

ΙT Printed circuit boards

> (chip on film(COF); photosensitive resin compos. and their applications)

Photoresists

Semiconductor device fabrication

(photosensitive resin compas, and their applications)

3290-92-4, Trimethylolpropane trimethacrylate 15625-89-5, тт Trimethylolpropane triacrylate 28961-43-5, NK Ester A-TMPT 3EO 39420-45-6, Blemmer PP 1000 41637-38-1, NK Ester BPE 500 56744-60-6, NK-BPE 200 57491-53-9, Nonaethylene glycol diacrylate

83868-76-2, Ethoxylated propoxylated bisphenol A dimethacrylate 122985-55-1, Ethylene oxide-propylene oxide block copolymer

dimethacrylate

RL: TEM (Technical or engineered material use); USES (Uses) (polymerizable compound; photosensitive resin

compas. and their applications)

25035-69-2, Methyl methacrylate/methacrylic acid/butyl acrylate copolymer 25035-81-8, Methyl methacrylate/methacrylic acid/styrene copolymer 65697-21-4, Benzyl methacrylate/methacrylic acid copolymer

RL: TEM (Technical or engineered material use); USES (Uses) (resin; photosensitive resin compas. and their applications)

L46 ANSWER 8 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2005:731999 HCAPLUS Full-text DOCUMENT NUMBER: 143:183281

TITLE:

Manufacture of plasma display front panels equipped with precisely patterned spacer layers with uniform thickness, photosensitive inorganic

paste compositions therefor, and unsintered sheets therefrom

INVENTOR(S): Obitani, Hiroyuki; Oshio, Kiminori; Kumasawa,

Akira; Fushida, Hitoshi
PATENT ASSIGNEE(S): Tokyo Ohka Kogyo Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 34 pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

	ENT I				KIN	D -	DATE			APPL	ICAT	ION :	NO.		D	ATE
JP	2005	- 2151:	34		A		2005	0811		JP 2	004-	1962	9		_	00401
WO	2005	0738	09		A1		2005	0811		WO 2			56		2	00501
	W:	CH, GB, KZ, MZ,	CN, GD, LC, NA,	CO, GE, LK, NI,	CR, GH, LR, NO,	CU, GM, LS, NZ,	AU, CZ, HR, LT, OM, TM,	DE, HU, LU, PG,	DK, ID, LV, PH,	DM, IL, MA, PL,	DZ, IN, MD, PT,	EC, IS, MG, RO,	EE, KE, MK, RU,	EG, KG, MN, SC,	ES, KP, MW, SD,	FI, KR, MX, SE,
	RW:	BW, AM, DE, NL,	GH, AZ, DK, PL,	GM, BY, EE, PT,	KG, ES, RO,	LS, KZ, FI, SE,	MW, MD, FR, SI, NE,	RU, GB, SK,	TJ, GR, TR,	TM, HU, BF,	AT, IE,	BE, IS,	BG, IT,	CH, LT,	CY, LU,	CZ, MC,
CN	1910	518			A		2007	0207		CN 2			3023		_	00501 7
KR	8182	22			В1		2008	0402		KR 2	< 006-		17			00607 6
RIORITY	APP:	LN.	INFO	.:						JP 2	< 004-		9			00401
										WO 2	< 005-		56		2	00501 7

AB The compnis comprise photopolymerizable monomers, inorg. powders, and photopolymn. initiators containing those of Norrish type I (e.g., benzoin ethers, benzyl ketals) and those of H abstraction type (e.g., aromatic ketones, thioxanthones). Plasma display front panels are manufactured by (i) successively forming of (A) unsintered dielec. layers containing inorg. powders and binder resins and (B) plural unsintered spacer layers comprising

the above compnet, on glass substrates equipped with plural surface electrodes, (ii) radiating B with patterned lights and developing, and (iii) firing the layers A and B simultaneously to give dielec. layers and plural spacer layers with uniform thickness. Unsintered sheets having B on release films and optionally A and/or water—soluble/swellable sinterable interlayers on B are useful for laminating on the glass substrates.

IT 56315-94-7, Isobutyl methacrylate-hydroxyethyl methacrylate copolymer

RL: CPS (Chemical process); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(dielec. layers; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg, paste compus.)

RN 56315-94-7 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with 2-methylpropyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1 CRN 868-77-9 CMF C6 H10 03

CM 2

CRN 97-86-9 CMF C8 H14 O2

IC ICM G03F007-004

ICS G03F007-029; G03F007-031; G03F007-40; H01J009-02; H01J011-02

CC 74-13 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38, 57

IT Dicarbonvl compounds

RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(Ph. Norrish type I photopolymm. initiators; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compos.)

IT Alcohols, processes

RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process), PTP (Physical process), TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(amino, alkyl, hydrogen abstraction-type photopolymn. initiators; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste

compas.)

Ketones, processes

RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(aromatic, hydrogen abstraction-type photopolymn. initiators; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compas.)

Ketals

IΤ

RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(benzyl, Norrish type I photopolymn. initiators; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compns.)

Aromatic compounds

RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(dialkylamino-containing, hydrogen abstraction-type photopolymn. initiators; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg, paste compos.)

Glass, processes

RL: CPS (Chemical process); DEV (Device component use); MOA (Modifier or additive use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(frits, spacers; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg.

paste compns.) Electric insulators

> Glass substrates Lamination

Photolithography Plasma display panels

Sintering

(manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compos.)

IT Inorganic compounds

RL: CPS (Chemical process); DEV (Device component use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorq. paste compris.)

Polyesters, uses

RL: TEM (Technical or engineered material use); USES (Uses) (manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compas.)

IΤ Oximes

> RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)

(phenylacyl, Norrish type I photopolymn. initiators; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compas.)

- IT Photoimaging materials
 - (photopolymerizable; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive
- inorg. paste compns.)
 TPolymerization catalysts
 - (photopolymn.; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste comons.)
- T Frits
 - (spacers; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compos.)
- IT 582-24-1D, α -Hydroxyacetophenone, derivs. 613-89-8D, α -Aminoacetophenone, derivs. 13840-40-9D, Phosphine oxide, acyl derivs. 24650-42-8, IR 651 RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PYP (Physical process); TeM (Technical or engineered
 - material use); PROC (Process); USES (Uses)
 (Norrish type I photopolymm. initiators; manufacture of plasma display
 front panels equipped with uniform-thickness spacer layers from
 photosensitive inorg. paste compas.)
- IT 56315-94-7, Isobutyl methacrylate-hydroxyethyl methacrylate copolymer
 - RL: CPS (Chemical process); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)
 - (dielec. layers; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste combus.)
- IT 84-65-1D, Anthraquinone, derivs. 82799-44-8, DETX-S RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)
 - (hydrogen abstraction-type photopolymn. initiators; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorq. paste compons.)
- IT 177646-18-3, Poval PVA 235
 - RL: CPS (Chemical process); PEP (Physical, engineering or chemical process); PYP (Physical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses)
 - (interlayers; manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste compos.)
- IT 68406-95-1, Light Ester HO-MPP
 - RL: PEP (Physical, engineering or chemical process); PYP (Physical process); RCT (Reactant); TEM (Technical or engineered material use); PROC (Process); RACT (Reactant or reagent); USES (Uses) (manufacture of plasma display front panels equipped with uniform-thickness spacer layers from photosensitive inorg. paste COMPURS.)
- IT 25038-59-9, Purex A 24, uses
 - RL: TEM (Technical or engineered material use); USES (Uses) (release films; manufacture of plasma display front panels equipped with uniform—thickness spacer layers from photosensitive inorg. paste compna.)
- IT 805246-81-5P, HO-MPP homopolymer RL: CPS (Chemical process); IMF (Industrial manufacture); PEP (Physical, engineering or chemical process); TEM (Technical or

(Physical, engineering or chemical process); TEM (Technical or engineered material use); PREP (Preparation); PROC (Process); USES (Uses)

(spacers; manufacture of plasma display front panels equipped with uniform—thickness spacer layers from photosensitive inorg. paste compos.)

L46 ANSWER 9 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2005:323300 HCAPLUS Full-text

DOCUMENT NUMBER: 142:400561

TITLE: Photosensitive resin composition and photosensitive resin laminate therefrom

INVENTOR(S): Inoue, Naoto; Tomita, Hiroaki

PATENT ASSIGNEE(S): Asahi Kasei Electronics Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 17 pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent

LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.
JP 2005099339	A	20050414	JP 2003-331962

1 JP 2003-331962 200309 24

PRIORITY APPLN. INFO.: JP 2003-331962

200309

DATE

<--

OTHER SOURCE(S): MARPAT 142:400561

AB Disclosed is a photosensitive resin composition comprising (a) a binder resin 20-90% containing a linear polymer with a weight average mol. weight 2-5 + 105 and a carboxy group at an acid equivalence 100-600, (b) a photopolymerizable unsatd. compound 3-70% H2C=CR1COO(A-O)n1-(B-O)nn2-(CH2)n3-CR2R3R4 (R1 = H, Me; R2 = H, C1-20 alky1; R3 - C1+20 alky1; R3 - C2H4; B = C3H6; n1 = 1-30; n2 = 0-30; n3 = 0-20), and a photopolymn. initiator 0.1-20% such as 2,4,5-triarvlimidazole dimer.

- IT 39420-49-6D, Polypropylene glycol monomethacrylate, reaction products with hexamethylenediisocyanate RL: TEM (Technical or engineered material use); USES (Uses)
 - (photosensitive resin composition)
- RN 39420-45-6 HCAPLUS
- CN Poly[oxy(methyl-1, 2-ethanediyl)],

α-(2-methyl-1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX NAME)

- IC ICM G03F007-027
- ICS C08F002-50; C08F290-06; G03F007-004; G03F007-029; H01L021-027
- CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38
- ST photosensitive resin compa laminate triarylimidazole dimer

photopolymn initiator

Polymerization catalysts

(photopolymn.; photosensitive resin composition)

Photoresists

Resists

(photosensitive resin composition)

90-93-7, 4,4'-Bis(diethylamino)benzophenone

RL: CAT (Catalyst use); USES (Uses)

(photopolymn, initiator; photosensitive resin composition)

822-06-0D, Hexamethylenediisocvanate, reaction products with

oligopropylene glycol monomethacrylate 9003-11-6D, 4-nonylphenyl and acrylate terminated 25035-69-2, Butvl acrylate-methacrylic acid-methyl methacrylate copolymer 39420-45-60,

Polypropylene glycol monomethacrylate, reaction products with hexamethylenediisocyanate 84154-99-4 225109-16-0 849791-72-6, Dodecapropylene glycol-triethylene glycol triblock copolymer dimethacrylate

RL: TEM (Technical or engineered material use); USES (Uses)

(photosensitive resin composition)

L46 ANSWER 10 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN 2005:302419 HCAPLUS Full-text

ACCESSION NUMBER: DOCUMENT NUMBER: 142:374901

TITLE: Photosensitive polymer compositions,

their fire-resistant dry films, and articles

having the dry films

INVENTOR(S): Funaki, Katsuhiko; Tahara, Shuji; Fujita,

Kazuto; Okawado, Etsuo

PATENT ASSIGNEE(S): Mitsui Chemicals Inc., Japan

SOURCE: Jpn. Kokai Tokkvo Koho, 16 pp.

CODEN: JKXXAF Patent

DOCUMENT TYPE: LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 2005091399	A	20050407	JP 2003-320492	200309

12

PRIORITY APPLN. INFO.:

<--JP 2003-320492

200309

The compas,, useful for insulator films of flexible printed circuit boards, AB comprise (A) bis(meth)acrylates H2C:CR3CO(OR1)nOCONHR5NHCO2(R2O)mCOC(R4):CH2 (R1, R2 = C2-5 aliphatic hydrocarbylene; R3, R4 = H, Me; R5 = benzenecontaining divalent aromatic group; n, m = 1-15), (B) polyimide precursors, and (C) photopolymn. catalysts. Thus, a composition containing (a) Blemmer DP 403AU (bismethacrylate prepared from polyethylene glycol monomethacrylate and MDI), (b) a polyamic acid prepared from pyromellitic dianhydride, Jeffamine D 400 (polypropylene glycol diamine), and 1,3-bis(3-aminophenoxy)benzene, and (c) Speedcure TPO (photopolymn. catalyst) was applied on a PET film, dried, exposed, and developed with 1% aqueous Na2CO3 solution to give a test piece showing good chemical, solder heat, and bending crack resistance.

ΙT 26403-58-7DP, Blemmer AE 200, carbamate ester with polymeric MDI

November 26, 2008 60

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (crosslinked; photosensitive polymer compas.

for fire-resistant dry films)

26403-58-7 HCAPLUS RN

Poly(oxv-1,2-ethanediv1), α -(1-oxo-2-propen-1-v1)- ω -CN hydroxy- (CA INDEX NAME)

$$H_2 C = CH = 0 - CH_2 - CH_2 - CH_2$$

25736-86-1DP, Blemmer PE 350, diester derivs, with Cosmonate ND, polymers 26403-58-7DP, Polyethylene glycol monoacrylate, diester derivs. with Cosmonate PH, polymers RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (photosensitive polymer compas. for

fire-resistant dry films) RN 25736-86-1 HCAPLUS

Poly(oxy-1,2-ethanediyl), α -(2-methyl-1-oxo-2-propen-1-yl)-CN ω-hydroxy- (CA INDEX NAME)

RN 26403-58-7 HCAPLUS

Poly(oxy-1,2-ethanediyl), α -(1-oxo-2-propen-1-yl)- ω hydroxy- (CA INDEX NAME)

$$\mathtt{H}_{2}\mathtt{C} = \mathtt{C}\mathtt{H} - \overset{\circ}{\mathtt{C}} = \underbrace{} \mathtt{C} - \mathtt{C}\mathtt{H}_{2} - \mathtt{C}\mathtt{H}_{2} = \underbrace{} \mathtt{h}$$

IC ICM G03F007-027

ICS G03F007-004; G03F007-037; H05K003-28; H05K003-46

38-3 (Plastics Fabrication and Uses)

Section cross-reference(s): 74, 76

Polyurethanes, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(acrylic-polyoxyalkylene-; photosensitive polymer commons . for fire-resistant dry films)

Plastic films

(dry; photosensitive polymer compas. for fire-resistant dry films)

Printed circuit boards

(flexible; photosensitive polymer compas. for fire-resistant dry films)

IT Chemically resistant materials

Dielectric films

Fire-resistant materials

(photosensitive polymer compns, for fire-resistant dry films)

IT Polyethers, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyamic acid-, block; photosensitive polymer compast for fire-resistant dry films)

T Polyethers, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyamic acid-polyester-, block; photosensitive polymer compns. for fire-resistant dry films)

IT Polvesters, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyamic acid-polyether-, block; photosensitive polymer compos. for fire-resistant dry films)

IT Polyamic acids

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyester-polyether-, block; photosensitive polymer compas, for fire-resistant dry films)

IT Polyoxyalkylenes, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyester-polyether-polyimide-, block; photosensitive polymer compos. for fire-resistant dry films)

IT Polyimides, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyester-polyether-polyoxyalkylene-, block; photosensitive polymer compns. for fire-resistant dry films)

IT Polyethers, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses) (polyester-polyimide-polyoxyalkylene-, block; photosensitive polymer compos, for fire-resistant dry films)

IT Polyamic acids

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyether-, block; photosensitive polymer compas. for fire-resistant dry films)

Tire-resistant dry Tilms

T Polyoxyalkylenes, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyether-polyimide-, block; photosensitive polymer compos. for fire-resistant dry films)

T Polyesters, uses

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyether-polyimi

INFORMATION:

PATENT NO. KIND DATE APPLICATION NO. DATE

US 20040162363 A1 20040819 US 2003-736529 200312 17

US 7115673 B2 20061003 PRIORITY APPLM, INFO.: JP 1999-335851 A

20040224

B1

US 6696529

<--JP 2000-238807 A 200008 07

<--

US 2000-721666

24

200011 27

199911 26 62

US 2000-721666 A3 200011 27

AB The photosensitive resin composition comprises a polyamic acid resin, a photosensitive agent, a dispersible compound which is dispersible in the polyamic acid resin, and a solvent. The porous resin is obtained by removing the dispersible compound from the photosensitive resin composition to make the composition pronus, and curing the porous photosensitive resin composition The porous resin enables to form a fine circuit pattern and has a low dielec. constant and, when used as an insulating layer of a circuit board, brings about improved high frequency characteristics.

RL: MOA (Modifier or additive use); PEP (Physical, engineering or chemical process); PROC (Process); USES (Uses)

(removing dispersible compound to make photosensitive resin composition porous)

IT 25736-86-1, Polyethylene glycol monomethacrylate

- RN 25736-86-1 HCAPLUS
- CN Poly(oxy-1,2-ethanediy1), α -(2-methy1-1-oxo-2-propen-1-y1)- ω -hydroxy- (CA INDEX NAME)

$$Me^{-\frac{H_2C}{C}}$$
 $O = CH_2 - CH_2$ $O = OH_2 - CH_2$ $OH_2 - CH_3$ $OH_3 - CH_3$ $OH_4 - CH_3$ OH_5 O

- IC ICM G03F007-037
- CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)
- Section cross-reference(s): 76
 ST porous photosensitive resin compn insulating layer circuit
- board; insulating film porous material coating photosensitive resin

 Folyurethanes, processes
 - RL: MOA (Modifier or additive use); PEP (Physical, engineering or chemical process); PROC (Process); USES (Uses) (acrylates, dispersible compound; removing dispersible compound to
 - make photosensitive resin composition porous)
- IT Porous materials
 - (coatings; porous photosensitive resin composition based on polyamic acid resin for circuit board and wireless suspension board insulating layer)
- IT Construction materials
 - (insulating boards; porous photosensitive resin composition based on polyamic acid resin for circuit board and wireless suspension board insulating layer)
- IT Dielectric films

Porous materials

Printed circuit boards

(porous photosensitive resin composition based on polyamic acid resin for circuit board and wireless suspension board insulating layer)

- IT Polyamic acids
 - RL: PEP (Physical, engineering or chemical process); PRP (Properties); SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); PROC (Process); USES (Uses)
 - (porous photosensitive resin composition based on polyamic acid resin for circuit board and wireless suspension board insulating layer)
 - T Coating materials
 - (porous; porous photosensitive resin composition based on polyamic acid resin for circuit board and wireless suspension board insulating laver)
- IT 28155-61-5P 153554-40-6P 340699-12-9P
 - RL: PEP (Physical, engineering or chemical process); PRP (Properties); SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); PROC (Process); USES (Uses)
 - (porous photosensitive resin composition based on polyamic acid resin for circuit board and wireless suspension board insulating layer)
- IT 25736-86-1, Polyethylene glycol monomethacrylate 26570-48-9, Polyethylene glycol diacrylate 26915-72-0, Polyethylene glycol monomethyl ether methacrylate

RL: MOA (Modifier or additive use); PEP (Physical, engineering or chemical process); PROC (Process); USES (Uses) (removing dispersible compound to make shotosensitive

resin composition porous)

THERE ARE 5 CITED REFERENCES AVAILABLE FOR REFERENCE COUNT: THIS RECORD, ALL CITATIONS AVAILABLE IN

THE RE FORMAT

L46 ANSWER 26 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2001:299122 HCAPLUS Full-text

DOCUMENT NUMBER: 134:334276

TITLE: Photosensitive polymer compositions,

their laminates, and manufacture of printed

circuit boards Yoshida, Tomoko; Tomita, Hiroaki INVENTOR(S):

PATENT ASSIGNEE(S):

Asahi Chemical Industry Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 10 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 2001117225	A	20010427	JP 1999-292688	199910

14

PRIORITY APPLN. INFO.: JP 1999-292688

199910 14

AB The compast comprise (i) 20-80 weight% alkaline-soluble polymers containing CO2H of acid value 100-600 and having weight average mol. weight 10000-500,000, (ii) 10-40 weight% urethane compds. (A) obtained by reaction of (a) terminate isocyanate on polyurethanes derived from diisocyanate and OHterminated compds. and (b) ethylenically unsatd. compds. having groups containing active H and/or (B) CH2:CR1COR2OCONHWNHCOR3OCOCR4:CH2 (R1, R4 = H, Me; R2-3 = (OCH2CH2)n1, (OCH2CHMe)n2, (OCHMeCH2)n3, (OCH2CH2CH2CH2)n4, (OCHMeCH2CH2)n5, (OCH2CHMeCH2)n6; total of n1 to n6 = integer of 1-25; W = C2-20 bivalent hydrocarbon), (iii) 5-30 weight% photopolymerizable monomers having ≥3 ethylenically unsatd, groups, and (iv) 0.01-30 weight% photoinitiators. The compas . show 0-20% swelling of developing agents, have tent piercing strength ≥2.45 N, and tent piercing elongation ≥1 mm. Supports laminated with layers of the compas. are also claimed. Printed circuits are manufactured by heat-press lamination of the above stated laminate on a substrate metal surface, imagewise exposure of the laminate through a photomask, development of the layer with an aqueous alkaline solution, etching or plating of the exposed metal surface, and removal of the cured resist with an aqueous alkaline solution stronger than that used for development. The support of the laminate is removed before or after imagewise exposure. The laminates, used as dry film resists, have high resolution, excellent edge fusing properties, and tenting reliability.

25736-86-1DP, Blemmer PE 200, reaction products with hexamethylene diisocyanate 39420-45-6DP, Blemmer PP 1000, reaction products with hexamethylene diisocyanate RL: PEP (Physical, engineering or chemical process); PNU (Preparation, unclassified); TEM (Technical or engineered material use); PREP (Preparation); PROC (Process); USES (Uses) (photosensitive polymer compus, for dry-film resists having high resolution and tenting reliabil

resists having high resolution and tenting reliability and manufacture of printed circuits)

RN 25736-86-1 HCAPLUS

CN Poly(oxy-1,2-ethanediy1), α -(2-methy1-1-oxo-2-propen-1-y1)- ω -hydroxy- (CA INDEX NAME)

RN 39420-45-6 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)], $\alpha-(2-methyl-1-oxo-2-propen-1-yl)-\omega-hydroxy- \quad (CA INDEX NAME)$

IC ICM G03F007-027

ICS G03F007-004; H05K003-00
CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and

Other Reprographic Processes)
Section cross-reference(s): 76

ST dry film resist printed circuit manuf; acrylate terminated polyester polyurethane photosensitive compn

IT Photoresists

(dry-film; photosensitive polymer compns. for dry-film resists having high resolution and tenting reliability and manufacture of printed circuits)

IT Printed circuit boards

(photosensitive polymer compns. for dry-film resists having high resolution and tenting reliability and manufacture of printed circuits)

IT Polyurethanes, processes

RL: PEP (Physical, engineering or chemical process); PNU (Preparation, unclassified); TEM (Technical or engineered material use); PREP (Preparation); PROC (Process); USES (Uses) (polyester-, acrylate-terminated; photosensitive polymer

compas. for dry-film resists having high resolution and tenting reliability and manufacture of printed circuits)

tenting reliability and manufacture of printed circuits

IT Polyurethanes, processes

RL: PEP (Physical, engineering or chemical process); PNU (Preparation, unclassified); TEM (Technical or engineered material use); PREP (Preparation); PROC (Process); USES (Uses)

(polyester-polyoxyalkylene-, block, acrylate-terminated; photosensitive polymer compas. for dry-film resists

having high resolution and tenting reliability and manufacture of printed circuits)

IIT 90-94-8 119-61-9, Benzophenone, processes 1707-68-2, 2-(o-Chlorophenyl)-4,5-diphenyl imidazolyl dimer RL: CAT (Catalyst use); PEP (Physical, engineering or chemical process); PROC (Process); USES (Uses)

(photoinitiator; photosensitive polymer compas, for

dry-film resists having high resolution and tenting reliability and manufacture of printed circuits)

818-61-1DP, reaction products with polyurethanes 822-06-0DP, Hexamethylene diisocyanate, reaction products with polyoxyalkylene monomethacrylate 25/36-86-1DP, Blemmer PE 200, reaction products with hexamethylene diisocvanate 36671-24-6DP, Adipic acid-ethylene glycol-m-xylylene diisocyanate polymer, reaction products with hydroxyethyl acrylate 39420-45-65P, Blemmer PP 1000, reaction products with hexamethylene diisocvanate 232927-51-4DP, Adipic acid-1,4-butanediol-ethylene oxide-isophorone diisocyanate-propylene oxide block copolymer, reaction products with hydroxyethyl acrylate

RL: PEP (Physical, engineering or chemical process); PNU (Preparation, unclassified); TEM (Technical or engineered material

use); PREP (Preparation); PROC (Process); USES (Uses) (photosensitive polymer compas. for dry-film

resists having high resolution and tenting reliability and manufacture of printed circuits)

15625-89-5, Trimethylolpropane triacrylate 25035-69-2, n-Butyl acrylate-methacrylic acid-methyl methacrylate copolymer 29763-27-7, Acrylonitrile-methacrylic acid-methyl methacrylate copolymer 57491-53-9, Nonaethylene glycol diacrylate 75577-70-7 RL: PEP (Physical, engineering or chemical process); TEM (Technical or engineered material use); PROC (Process); USES (Uses) (photosensitive polymer compas. for dry-film resists

having high resolution and tenting reliability and manufacture of printed circuits)

L46 ANSWER 27 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 2000:144640 HCAPLUS Full-text 132:173437 DOCUMENT NUMBER:

TITLE: Photosensitive resin composition

useful in fabricating flexographic printing plate

INVENTOR(S): Leach, Douglas PATENT ASSIGNEE(S):

Macdermid Incorporated, USA SOURCE: Eur. Pat. Appl., 11 pp.

CODEN: EPXXDW

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PA'	TENT NO.	KIND	DATE	APPLICATION NO.	DATE
EP	982629	A1	20000301	EP 1999-305585	
					199907
					14
				<	
EP	982629	B1	20030924		

R: AT, BE, CH, DE, DK, ES, FR, GB, GR, IT, LI, LU, NL, SE, MC, PT, IE, SI, LT, LV, FI, RO US 6214522 B1 20010410 US 1998-143427

199808 28

November 20, 2008		10/3//,233		
ES 2207912	Т3	20040601	ES 1999-305585	
				199907
				14
			<	
JP 2000075481	A	20000314	JP 1999-225900	
				199908
				10
			<	10
JP 3354117	B2	20021209	~	
US 6197459	B1	20021209	US 2000-620884	
05 619/459	DI	20010306	03 2000-620004	200007
				21
				21
			<	
CN 1347929	A	20020508	CN 2000-129670	
				200010
				10
			<	
PRIORITY APPLN. INFO.:			US 1998-143427	A
				199808
				28
			<	

AB A photosensitive resin composition useful in fabricating a flexog, printing plate comprises (i) a polyurethane prepolymer which is the reaction product of at least one polyether diol having an olefin unsath. equal to or less than 0.01 meg/gm, at least one diisocyanate, and a hydroxy-functionalized (meth) acrylate, (ii) at least one monomer, and (iii) at least one photoinitiator.

IT 39420-45-6, Polypropylene glycol monomethacrylate

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive resin compns. for flexog.

printing plate preparation containing methacrylates, polyurethane prepolymers and)

RN 39420-45-6 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)],

 $\alpha\text{-(2-methyl-1-oxo-2-propen-1-yl)-}\omega\text{-hydroxy-}$ (CA INDEX NAME)



- IC ICM G03F007-027 ICS B41M001-04
 - ICS B41M001-04
- ${\tt CC} 74{\tt -6}$ (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)
- ST photosensitive resin compn polyurethane prepolymer flexog printing plate
- IT Polyurethanes, uses
 - RL: TEM (Technical or engineered material use); USES (Uses) (acrylates; photosensitive resin compus, for flexog.

printing plate preparation containing methacrylates and)

IT Flexographic printing plates

(photosensitive resin compns. containing methacrylates and polyurethane prepolymers for preparation of)

IT 105-16-8 105-59-9 109-17-1, Tetraethylene glycol dimethacrylate 119-61-9, Benzophenone, uses 142-90-5 544-63-8, Tetradecanoic acid, uses 3290-92-4 24650-42-8, Tragarure 651 3943-45-6

, Polypropylene glycol monomethacrylate

RL: TEM (Technical or engineered material use); USES (Uses)

(photosensitive resin compns. for flexog.
printing plate preparation containing methacrylates, polyurethane

printing plate preparation containing methacrylates, polyurethane prepolymers and)

IT 258872-53-6P, Acclaim 3205-polypropylene glycol

monomethacrylate-toluene diisocyanate copolymer 258872-54-7P, Acclaim 2220-polypropylene qlycol monomethacrylate-toluene

diisocyanate copolymer

RL: SPN (Synthetic preparation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(preparation and use in photosensitive resin compas. for

flexog. printing plate preparation)

REFERENCE COUNT: 3 THERE ARE 3 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN

THE RE FORMAT

L46 ANSWER 28 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1999:56342 HCAPLUS Full-text

DOCUMENT NUMBER: 130:117368

TITLE: Photosensitive resin composition for

fabricating printing plate resistant to polar

solvent-based ink INVENTOR(S): Pohl, Rudolph

PATENT ASSIGNEE(S): MacDermid, Incorporated, USA

SOURCE: U.S., 5 pp.
CODEN: USXXAM

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
US 5861234	A	19990119	US 1997-790492	199701 29
PRIORITY APPLN. INFO.:			< US 1997-790492	

INIONIII IIII IIII IIII IIII III

199701 29

- AB The addition of a vinyl ether to a photosensitive resin compon. is suggested to improve the resistance of the cured resin composition obtained from the photosensitive resin compon, to polar solvents. A long-chain vinyl ether such as octadecyl vinyl ether or dodecyl vinyl ether is preferred. The resulting photosensitive resin is particularly useful in the fabrication of a printing plate resistant to a polar solvent-based ink.
- IT 39420-45-6D, Polypropylene glycol monomethacrylate, reaction products with isocyanate-terminated polyurethanes
 RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive resin compute for printing

plate preparation containing vinyl ethers and)

RN 39420-45-6 HCAPLUS

NAME)

CN Poly[oxy(methyl-1,2-ethanediyl)], α -(2-methyl-1-oxo-2-propen-1-yl)- ω -hydroxy- (CA INDEX

$$\mathsf{Me} = \bigcup_{n=0}^{\mathsf{H2C}} \bigcup_{n=0}^{\mathsf{O}} \mathsf{O} + (\mathsf{C3H6}) = \bigcup_{n=0}^{\mathsf{D}} \mathsf{OH}$$

IC ICM G03F007-26

ICS G03F007-30

INCL 430300000

CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

IT Polyurethanes, uses

RL: TEM (Technical or engineered material use); USES (Uses) (polyether-; photosensitive resin compas. for printing plate preparation containing vinyl ethers and)

T Printing plates

(resistant to polar solvent-based inks and prepared from photosensitive resin compns. containing unsatd. polyurethanes and vinyl ethers)

T Polyurethanes, uses

RL: TEM (Technical or engineered material use); USES (Uses) (unsatd.; photosensitive resin compos. for printing

plate preparation containing vinyl ethers and)

- (T 765-14-0, Dodecyl vinyl ether 930-02-9, Octadecyl vinyl ether RL: TBM (Technical or engineered material use); USES (Uses) (photosensitive resin compns. for printing plate preparation containing unsatd. polyurethanes and)
- IT 143-07-7, Dodecanoic acid, uses 544-63-8, Tetradecanoic acid, uses 24650-42-8, 2,2-Dimethoxy-2-phenylacetophenone

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive resin compns. for printing plate preparation containing unsatd, polyurethanes, ethylenically unsatd, monomers,

vinyl ethers and)
142-90-5, Lauryl methacrylate 3290-92-4 7534-94-3, Isobornyl

methacrylate 29964-84-9, Isodecyl methacrylate RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive resin compus. for printing plate preparation

containing unsatd. polyurethanes, vinyl ethers and) \$84-84-9D, 2,4-TDI, polymers with hydroxy-terminated polybutadiene, reaction products with polypropylene glycol monomethacrylate 9003-17-ZD, Polybutadiene, hydroxy-terminated, polymers with TDI, reaction products with polypropylene glycol monomethacrylate

reaction products with polypropylene glycol monomethacrylate 35420-45-6D, Polypropylene glycol monomethacrylate, reaction products with isocyanate-terminated polyurethanes 219713-38-9, Merigraph F 025-3

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive resin compns. for printing

plate preparation containing vinyl ethers and)

REFERENCE COUNT: 3 THERE ARE 3 CITED REFERENCES AVAILABLE FOR THIS RECORD. ALL CITATIONS AVAILABLE IN THE RE FORMAT

DOCUMENT NUMBER: 127:270500

ORIGINAL REFERENCE NO.: 127:52661a,52664a

TITLE: Photopolymerizable composition for photosensitive lithographic printing plate

INVENTOR(S): Tsuji, Shigeo; Okamoto, Hideaki
PATENT ASSIGNEE(S): Mitsubishi Chemical Corporation, Japan

70 SOURCE: Eur. Pat. Appl., 22 pp.

CODEN: EPXXDW Patent

DOCUMENT TYPE: LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
EP 793145	A1	19970903	EP 1997-103156	199702
			<	26
	B1	20010124		
R: DE, FR, GB				
JP 10010719	A	19980116	JP 1996-265947	199610 07
			<	
JP 3255042	B2	20020212		
US 5800965	A	19980901	US 1996-772569	
				199612 26
			<	
PRIORITY APPLN. INFO.:			JP 1996-43259	A
				199602
				29
			<	
			JP 1996-102476	A
				199604
				24

A photopolymerizable composition for a photosensitive lithog, printing plate is provided comprising (A) addition-polymerizable ethylenically unsatd. bondcontaining monomers, (B) a photopolymn. initiator system, and (C) a polymer binder having carboxyl groups in its mol., wherein the addition-polymerizable ethylenically unsatd. bond-containing monomers (A) contain a specific monomer which is a phosphoric acid ester compound having at least one (meth)acryloyl group and/or a compound of the formula CH2=C[CO2(XO)mH]R wherein R1 is a hydrogen atom or a Me group, X is a C1-6 alkylene group which may be branched and may be substituted by halogen, and m is an integer of at least 2 and the polymer binder (C) having carboxyl groups in its mol. is a compound having at least a part of the carboxyl groups reacted with an alicyclic epoxy groupcontaining unsatd. compound

ΙT 25736-86-1

> RL: POF (Polymer in formulation); TEM (Technical or engineered material use); USES (Uses)

(presensitized lithog, plate preparation using photopolymerizable compas. containing)

RN 25736-86-1 HCAPLUS

Poly(oxy-1,2-ethanediy1), α -(2-methy1-1-oxo-2-propen-1-y1)ω-hvdroxv- (CA INDEX NAME)



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IC ICM G03F007-027
    ICS G03F007-033
CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and
    Other Reprographic Processes)
ST photopolymerizable compn presensitized lithog plate
IT Lithographic plates
     (presensitized; photopolymerizable compas, for)
IT 77001-81-1, UA 306H
    RL: POF (Polymer in formulation); TEM (Technical or engineered
    material use); USES (Uses)
       (oligomeric; presensitized lithog, plate preparation using
       photopolymerizable compas. containing)
IT 24599-21-1 25736-86-1 32435-46-4 56361-55-8, A BPE 4
    125051-32-3 162461-65-6 163859-22-1 196296-02-3 196296-03-4
    196296-04-5
     RL: POF (Polymer in formulation); TEM (Technical or engineered
    material use); USES (Uses)
      (presensitized lithog. plate preparation using
       photopolymerizable compns. containing)
L46 ANSWER 30 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN
ACCESSION NUMBER: 1997:113405 HCAPLUS Full-text DOCUMENT NUMBER: 126:118569
ORIGINAL REFERENCE NO.: 126:22893a,22896a
                      Thiol-containing photosensitive polyurethane
TITLE:
                       foam compositions
INVENTOR(S): Tsao, Jung Hsien
PATENT ASSIGNEE(S): Pt Sub, Inc., USA
SOURCE: PCT Int. Appl., 35 pp.
                       CODEN: PIXXD2
DOCUMENT TYPE:
                       Patent
LANGUAGE:
                       English
FAMILY ACC. NUM. COUNT: 1
PATENT INFORMATION:
    PATENT NO. KIND DATE APPLICATION NO. DATE
     WO 9640528 A1 19961219 WO 1996-US963
                                                                199601
                                                                24
        W: AU, CA, JP
        RW: AT, BE, CH, DE, DK, ES, FR, GB, GR, IE, IT, LU, MC, NL, PT,
    AU 9647055 A 19961230 AU 1996-47055
                                                                199601
                                                                24
PRIORITY APPLN. INFO.:
                                         US 1995-473444
                                                                199506
                                                                07
                                               <---
                                          WO 1996-US963
                                                                199601
                                                                24
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AB A photosensitive resin composition comprises (1) 100 parts of a urethane prepolymer comprising a plurality of diol segments linked through a urethane linkage and having an addition polymerizable ethylenic group at both terminals, (2) 1-50 parts of a thiol, (3) 5-80 parts of a reactive diluent, and 0.1-5 parts of a photosinitiator and/or photosensitizer. The composition is used to produce foam sheets for printing blankets and printing plates. A polyurethane prepolymer was prepared by the reaction of polytetramethylene glycol, ethylene oxide-propylene oxide block copolymer, Desmodur W, hydroxyethyl acrylate, and hydroxyethyl methacrylate. The prepolymer then was mixed with hydroxyethyl methacrylate, polypropylene glycol monomethacrylate, diethylene glycol dimethacrylate, trimethylolpropane tris(β-mercaptopropionate), and Darocur 1173 to give a photosensitive composition, which was frothed mech., coated on a polyester baking, and cured by UV irradiation to give a foam sheet.

IT 39420-45-6, Polypropylene glycol monomethacrylate

RL: MOA (Modifier or additive use); TEM (Technical or engineered material use); USES (Uses)

(reactive diluent; thiol-containing photosensitive polyurethane foam compos.)

RN 39420-45-6 HCAPLUS

CN Poly(oxy(methyl-1,2-ethanediyl)).

 α -(2-methyl-1-oxo-2-propen-1-yl)- ω -hydroxy- (CA INDEX NAME)

IC ICM B41N001-00

ICS B41N003-00; B41N003-03; B41N003-04; B41N003-08; B32B003-12; B32B003-26; B32B007-00; B32B009-04; C08L075-00; C08L075-16

CC 37-3 (Plastics Manufacture and Processing)

Section cross-reference(s): 38, 74 IT Household furnishings

(blankets; thiol-containing photosensitive polyurethane foam compans, for printing blanket)

IT Printing plates

(compressible; thiol-containing photosensitive polyurethane foam compns. for printing plates)

IT Polyurethanes, preparation

RL: IMF (Industrial manufacture); POF (Polymer in formulation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(polyoxyalkylene-, acrylic, cellular; laminates containing foams made from thiol-containing photosensitive polyurethane compas.

for printing blankets and plates)

IT Polyurethanes, preparation

RL: IMF (Industrial manufacture); POF (Polymer in formulation); TEM (Technical or engineered material use); PREP (Preparation); USES (USes)

(polyoxyalkylene-, ethylenic group-terminated; thiol-containing photosensitive polyurethane foam compans.)

Polyesters, uses

Polvesters, uses

RL: TEM (Technical or engineered material use); USES (Uses)
(support films; laminates containing foams made from thiol-containing

photosensitive polyurethane compast for printing blankets and plates)

Thiols (organic), uses

RL: MOA (Modifier or additive use); TEM (Technical or engineered material use); USES (Uses)

(thiol-containing photosensitive polyurethane foam compas.) Printing apparatus

(thiol-containing photosensitive polyurethane foam compas. for printing blanket)

186255-98-1P 186256-00-8P 186256-03-1P 186256-04-2P RL: IMF (Industrial manufacture); POF (Polymer in formulation); TEM

(Technical or engineered material use); PREP (Preparation); USES (Uses)

(cellular; laminates containing foams made from thiol-containing photosensitive polyurethane compas. for printing blankets and plates)

тт 7473-98-5, Darocur 1173

RL: CAT (Catalyst use); USES (Uses)

(photoinitiator; thiol-containing photosensitive polyurethane foam compos.)

868-77-9 2358-84-1, Diethylene glycol dimethacrylate 39420-45-6, Polypropylene glycol monomethacrylate RL: MOA (Modifier or additive use); TEM (Technical or engineered material use); USES (Uses)

(reactive diluent; thiol-containing photosensitive polyurethane foam compas.)

25038-59-9, uses

RL: TEM (Technical or engineered material use); USES (Uses) (support films; laminates containing foams made from thiol-containing photosensitive polyurethane compas, for printing blankets and plates)

TТ 818-61-1DP, reaction products with isocyanato group-terminated polyurethanes 868-77-9DP, reaction products with isocyanato group-terminated polyurethanes 60857-76-3DP, reaction products with hydroxy-containing (meth)acrylates 181895-37-4DP, reaction products with hydroxy-containing (meth)acrylates 186255-94-7DP, reaction products with hydroxy-containing (meth)acrylates 186255-96-9DP, reaction products with hydroxy-containing (meth)acrylates RL: IMF (Industrial manufacture); POF (Polymer in formulation); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(thiol-containing photosensitive polyurethane foam compas.)

7575-23-7, Pentaerythritol tetrakis (β-mercaptopropionate) 33007-83-9, Trimethylolpropane tris(β-mercaptopropionate) RL: MOA (Modifier or additive use); TEM (Technical or engineered material use); USES (Uses)

(thiol-containing photosensitive polyurethane foam compns.)

L46 ANSWER 31 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1996:530850 HCAPLUS <u>Full-text</u> 125:181399

ORIGINAL REFERENCE NO.: 125:33721a,33724a

DOCUMENT NUMBER:

TITLE: Photopolymerizable composition,

presensitized lithographic plate using it, and its development with organic solvent-free

developer

INVENTOR(S): Ishii, Nobuyuki; Kizu, Noryuki; Matsumura, Tomoyuki; Murata, Masahisa; Tsuji, Shigeo PATENT ASSIGNEE(S): Konishiroku Photo Ind, Japan; Mitsubishi

Chemical Corp.

November 26, 2008 10/577,255 74

> Jpn. Kokai Tokkvo Koho, 13 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

SOURCE:

PATENT NO. KIND DATE APPLICATION NO. DATE JP 08146606 A 19960607 JP 1994-304199

> 199411 <--

PRIORITY APPLN. INFO.: JP 1994-304199

199411 15

AΒ The composition contains a linear polymer with a repeating unit terminated with an addition-polymerizable unsatd. linkage, a photopolymn. initiator, and an alkali-soluble polymer. The lithog, plate comprises a support with a hydrophilic surface. The lithog, plate is developed with an organic solventfree developer. The lithog. plate showed good ink receptivity.

IT 39420-45-6, Blemmer PP 500

RL: DEV (Device component use); TEM (Technical or engineered material use); USES (Uses)

(presensitized lithog. plate containing photopolymerizable composition developed with organic solvent-free developer)

RN 39420-45-6 HCAPLUS CN Polv[oxv(methvl-1,2-ethanedivl)],

α-(2-methyl-1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX

- ICM G03F007-038
 - ICS G03F007-00; G03F007-021; G03F007-027; G03F007-028; G03F007-30
- 74-6 (Radiation Chemistry, Photochemistry, and Photographic and CC
- Other Reprographic Processes)
- photopolymerizable compon presensitized lithog plate; printing plate photosensitive lithog development; solvent org free development lithog plate
- Lithographic plates

(presensitized lithog. plate containing photopolymerizable composition developed with organic solvent-free developer)

Resists

(photo-, presensitized lithog. plate containing photopolymerizable composition developed with organic solvent-free developer)

82799-44-8, 2,4-Diethylthioxanthone

RL: DEV (Device component use); TEM (Technical or engineered material use); USES (Uses)

(photopolymn. initiator; presensitized lithog. plate containing photopolymerizable composition developed with organic solvent-free developer)

IT 125785-09-3P 180483-43-6P, Acrylonitrile-ethyl acrylate-ethyl methacrylate-N-(4-hydroxyphenyl)methacrylamide-methacrylic acid copolymer

RL: DEV (Device component use); IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(presensitized lithog. plate containing photopolymerizable composition developed with organic solvent-free developer) 15625-89-5, Trimethylolpropane triacrylate 39420-45-6,

Blemmer PP 500 123938-67-0, AS 6 123997-17-1, AB 6 RL: DEV (Device component use); TEM (Technical or engineered material use); USES (Uses)

(presensitized lithog. plate containing photopolymerizable composition developed with organic solvent-free developer)

IT 7429-90-5, Aluminum, uses

RL: DEV (Device component use); USES (Uses)

(support; presensitized lithog. plate containing photopolymerizable composition developed with organic solvent-free developer)

L46 ANSWER 32 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1996:509458 HCAPLUS Full-text

DOCUMENT NUMBER: 125:154424

ORIGINAL REFERENCE NO.: 125:28675a,28678a

TITLE: Photosensitive compositions and clean

running photopolymer printing plates therefrom INVENTOR(S): Leach, Douglas R.

INVENTOR(S): Leach, Douglas R.

PATENT ASSIGNEE(S): Hercules Inc., USA
SOURCE: PCT Int. Appl., 47 pp.

CODEN: PIXXD2

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

	TENT				KIN	D -	DATE			APPL		ION I			D	ATE
	9618				A1		1996	0620		WO 1		US15	902		1:	99512 6
	W:	ES, LU,	FI, LV,	GB, MD,	GE,	HU, MK,	BG, IS, MN,	JP,	KE,	KG,	KP,	KR,	KZ,	LK,	LR,	LT,
	RW:	KE,	LS, IT,	MW, LU,	SD,	SZ,	UG, PT,									
CA	2207						1996	0620		CA 1	995-	2207.	591		1:	99512 6
AU	9643	762			A		1996	0703		AU 1	996-		2		1:	99512 6
EP	7977	91			A1		1997	1001		EP 1	< 995-		81		1:	99512 6

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	R:	AT,		CH,	DE,	DK,	ES,	FR,	GB,	GR	, IT,	LI,	LU,	NL,	SE	, MC,
JP	1051				T		1998	1215	ċ	JP :	1995-	5191	50			
																199512 06
73	9510	611			2		1006	0612	-	77	> 1995-	1061	,			
24	3310	011			А		1,,,,,	0015	_	Jr.		1001				199512 13
He	6399	270			D.1		2002	0604		TC .	> 1996	cc 12.	10			
US	0399	210			PI		2002	0004				0043.	10			199606 10
											<					
US	6403	269			В1		2002	0611		JS .	1996-	/338	9 0			199610 18
											<					
PRIORIT	Y APP	LN.	INFO	.:					τ	JS :	1994-	3551	22		A	199412 13
											<					
									Ţ	JS :	1995-	47570	03	1	31	199506 07
											<					
									V	10	1995-	US159	902	1	rī.	199512 06
											<					

AB Clean running printing plates for flexog, printing may be prepared by the cophotopolymm, of a mixture comprising a liquid, acrylate-or methacrylate-terminated polyurethane oligomer, an ethylenically unsatd. compound, and a photopolymm, initiator. The liquid oligomer is preferably the acrylated or methacrylated reaction product of a diisocyanate, a liquid hydrophobic polyalkylene oxide, and a diol that is at least one of polypropylene oxide and a copolymer of ethylene oxide and propylene oxide, where reaction with a hydroxy-containing acrylate or methacrylate compound incorporates terminal acrylate or methacrylate groups into the oligomer. The photopolymerizable blend may be used to form printing plates for flexog, printing, where the plates have a reduced tendency to pick up paper fibers, dust and dried ink during the printing process. Methodol. for preparing the printing plates and printing with the printing plates of the invention are also disclosed.

IT 39420-45-6, Polypropylene glycol monomethacrylate RL: TEM (Technical or engineered material use); USES (Uses)

(flexog. printing plate preparation using photosensitive compose, containing urethane oliomers and)

RN 39420-45-6 HCAPLUS

CN

Poly[oxy(methyl-1,2-ethanediyl)],

 $\alpha - (2-methyl-1-oxo-2-propen-1-yl) - \omega - hydroxy - \quad (CA INDEX NAME)$

- IC ICM G03F007-028
- ICS G03F007-30; B41M001-00
- CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)
- ST photosensitive compo flexog printing plate
- IT Urethane polymers

RL: TEM (Technical or engineered material use); USES (Uses)

(oligomers; flexog. printing plate manufacture using photosensitive compas. containing)

IT Printing plates

(flexog., photosensitive compos. containing urethane oligomers for manufacture of)

IT 180151-66-0 180151-67-1 180151-68-2 180151-69-3 180308-81-0
RL: TEM (Technical or engineered material use); USES (Uses)
(flexog. printing plate preparation using photosensitive compas. containing)

IT 109-17-1 123-28-4 142-90-5, Lauryl methacrylate 301-02-0,

Oleamide 544-63-8, Tetradecanoic acid, uses 3290-92-4, Trimethylolpropane trimethacrylate 16545-54-3, Dimyristyl thiodipropionate 24650-42-8, 2,2-Dimethoxy-2-phenylacetophenone 39420-45-6, Polypropylene glycol monomethacrylate 53879-54-2 56641-05-5, Photomer 4039

RL: TEM (Technical or engineered material use); USES (Uses) (flexog, printing plate preparation using photosensitive compns. containing urethane oligomers and)

L46 ANSWER 33 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1995:994828 HCAPLUS Full-text

DOCUMENT NUMBER: 124:71644

ORIGINAL REFERENCE NO.: 124:13137a,13140a

TITLE: Liquid photosensitive resin composition

for forming relief structures
INVENTOR(S): Tomita, Hiroaki; Kobavashi, Ta

INVENTOR(S): Tomita, Hiroaki; Kobayashi, Takashi; Sakata,
Norihiko

PATENT ASSIGNEE(S): Asahi Kasei Kogyo Kabushiki Kaisha, Japan

KIND DATE

SOURCE: PCT Int. Appl., 48 pp.
CODEN: PIXXD2

DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

L Pl	IDINI NO.	ICTIVE	Drill	ALLBICATION NO.	Drill
WO	9523998	A1	19950908	WO 1995-JP354	199503 03
	W: AU, US			<	03
		DE, DK	ES, FR, GB	, GR, IE, IT, LU, MC,	NL, PT,
AU	9518615	A	19950918	AU 1995-18615	199503 03
				<	
	684151	B2	19971204	TR 4005 C0000	
JP	07295218	A	19951110	JP 1995-68900	199503

APPLICATION NO.

DATE

					03
			<		
JP 3508788	B2	20040322			
EP 750229	A1	19961227	EP 1995-910745		
					199503
					0.3
			<		
EP 750229	В1	19991006	•		
R: BE, DE, ES,					
ES 2136838			ES 1995-910745		
DD 2130030	10	15551201	BO 1990 910.40		199503
					03
			{		0.5
US 5843622	A	19981201	US 1996-702537		
05 3843622	n	19901201	05 1990-702557		199609
					04
			<		04
PRIORITY APPLN. INFO.:			JP 1994-58378	A	100100
					199403
					04
			<		
			WO 1995-JP354	W	
					199503
					03
			<		

СТ

AB The title resin composition comprises an unsatd. polyesterpolyetherpolyurethane prepolymer, an ethylenically unsatd. monomer and a photopolymn. initiator, in which the prepolymer has weight ratio of the polyester diol segments to the polyether diol segments range from 1:3 to 4:1 and the polyester diol segments each independently comprises repeating units I (RI represents a divalent aliphatic or aromatic group) or (II). A relief structure (e.g. a press plate) produced from the composition scarcely causes tunneling of the relief and has an improved durability.

IT 9019-16-3DP, reaction product with polyurethane-polyester-polyether

RL: IMF (Industrial manufacture); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(prepared for liquid photosensitive resin composition)

RN 9019-16-3 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)],

 $\alpha\text{-(2-methyl-1-oxo-2-propenyl)-}\omega\text{-hydroxy-, homopolymer}$ (9CI) (CA INDEX NAME)

CM 1

CRN 39420-45-6 CMF (C3 H6 O)n C4 H6 O2 CCI IDS, PMS

IC ICM G03F007-027

74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

ST liq photosensitive compo polyester polyether polyurethane

IT Printing plates

(flexog., liquid photosensitive resin composition for manufacture of)

Urethane polymers, uses

RL: TEM (Technical or engineered material use); USES (Uses) (polyester-polyether-, for liquid photosensitive resin composition for forming relief structure)

109-17-1, Tetraethylene glycol dimethacrylate 142-90-5, Laurvl methacrylate 45219-55-4 62722-22-9 117646-83-0, Diethylene glvcol-2-ethvlhexvlether acrylate RL: TEM (Technical or engineered material use); USES (Uses)

(contained in liquid photosensitive resin composition) ΙT 9019-16-3DP, reaction product with

polyurethane-polyester-polyether 25322-68-3DP, Polvethylene glycol, polymer with other polyoxyalkylene glycol and diol and diisocyanate, reaction product with poly(oxypropylene) glycol monomethacrylate 25322-69-4DP, Polypropylene glycol, polymer with other polyoxyalkylene glycol and diol and diisocyanate, reaction product with poly(oxypropylene) glycol monomethacrylate 26471-62-5DP, Tolylenediisocyanate, polymer with polyoxyalkylene glycol and diol, reaction product with poly(oxypropylene) glycol monomethacrylate 58991-77-8DP, polymer with polyoxyalkylene glycol and diisocyanate, reaction product with poly(oxypropylene) glycol monomethacrylate 97145-14-7DP,

Poly(β -methyl- δ -valerolactone), polymer with

polyoxyalkylene glycol and diisocyanate, reaction product with poly(oxypropylene) glycol monomethacrylate

RL: IMF (Industrial manufacture); TEM (Technical or engineered

material use); PREP (Preparation); USES (Uses)

(prepared for liquid photosensitive resin composition)

L46 ANSWER 34 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1995:746497 HCAPLUS Full-text DOCUMENT NUMBER: 123:213334

ORIGINAL REFERENCE NO.: 123:37737a,37740a

TITLE: Water-developable photosensitive resin

compositions

INVENTOR(S): Koshimura, Katsuo; Nishioka, Takashi; Sato, Hozumi

PATENT ASSIGNEE(S): Japan Synthetic Rubber Co Ltd, Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 8 pp. CODEN: JKXXAF

DOCUMENT TYPE: Pat.ent. LANGUAGE: Japanese November 26, 2008 80

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 07140655	A	19950602	JP 1993-248630	199309

09

PRIORITY APPLN. INFO .:

<--JP 1993-248630

199309 09

<--

AB The resin compos. contain (A) 100 parts granular copolymer (a) obtained by emulsion-polymerization or suspension-polymerization of a monomer mixture containing (1) alignatic conjugated diene monomers 10-95, (2) α, β -ethylenic unsatd. carboxylic acids 0.1-30, (3) compds. having ≥2 addition-polymerizable group 0.1-20, (4) monoyinvl monomers having NH2 group 0.1-30, and (5) other copolymerizable monomers 0-30 mol.% at the total of (1), (2), (3), (4), and (5) 100 mol.%, (B) 5-100 parts photopolymerizable unsatd. monomers, and (C) 0.1-20 parts photopolymn, initiators. Also claimed are resin compns. which contains (A) 100 parts blend containing granular copolymer (b) obtained by emulsion-polymerization or suspension-polymerization of a monomer mixture containing (1) 10-95, (2) 0.1-30, (3) 0.1-20, and (5) 0-30 mol.% and granular copolymer (c) obtained by emulsion-polymerization or suspension-polymerization of a monomer mixture containing (1) 10-95, (3) 0.1-20, (4) 0.1-30, and (5) 0-30 mol.% at (b)/(c) ratio 95/5-5/95, (B) 5-100 parts photopolymerizable unsatd. monomers, and (C) 0.1-20 parts photopolymn. initiators. The compos. provide photocured products with high mech. strength and are useful for printing plates, photoresists, printing inks, photosensitive paints, photosensitive adhesives, photomolding materials, etc.

25736-86-1

RL: TEM (Technical or engineered material use); USES (Uses) (water-developable photosensitive resin compas . providing resists with high mech. strength and resilience)

25736-86-1 HCAPLUS RN

CN Poly(oxy-1,2-ethanediy1), α -(2-methyl-1-oxo-2-propen-1-y1)ω-hydroxy- (CA INDEX NAME)

IC ICM G03F007-038

ICS G03F007-027; H01L021-02

74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

ST water developable resist polymer compn

Resists

(photo-, water-developable photosensitive resin compas. providing resists with high mech, strength and resilience)

TT Lithographic plates

(presensitized, water-developable photosensitive resin compas, providing resists with high mech, strength and resilience)

114465-17-7P 165956-57-0P 168091-81-4P 168091-82-5P RL: PNU (Preparation, unclassified); TEM (Technical or engineered material use); PREP (Preparation); USES (Uses)

(water-developable photosensitive resin compas.

providing resists with high mech. strength and resilience) 142-90-5, Lauryl methacrylate 3290-92-4, Trimethylolpropane trimethacrylate 3845-76-9, N,N-Dimethylaminopropylacrylamide 13048-33-4 25736-86-1

RL: TEM (Technical or engineered material use): USES (Uses)

(water-developable photosensitive resin compos

. providing resists with high mech. strength and resilience)

L46 ANSWER 35 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1995:360861 HCAPLUS Full-text DOCUMENT NUMBER: 122:201459

ORIGINAL REFERENCE NO.: 122:36563a,36566a

TITLE:

Unsaturated group-containing polycarboxylic acid resin, resin composition containing

it, and resin composition for color filter

INVENTOR(S):

Kato, Yoshinori; Kano, Hirokazu; Ichinose, Naoko PATENT ASSIGNEE(S):

Nippon Kayaku Kk, Japan SOURCE: Jpn. Kokai Tokkyo Koho, 7 pp.

CODEN: JKXXAF DOCUMENT TYPE: Patent

LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PA	TENT NO.	KIND	DATE	APPLICATION NO.	DATE	
JP	06332177	A	19941202	JP 1993-145371		
					19930	
					26	
				<		
PRIORIT	Y APPLN. INFO.:			JP 1993-145371		

<--

199305 26

AB The polycarboxylic acid resin is maleic anhydride-≥1 monomer copolymer whose maleic anhydride parts are half-esterified with HO[CH2C(CH2OX)2CH2O]nX [X = (meth)acryloyl; n = 1, 2] and HO(C2H4O)nR (R = alkyl, alkylphenyl, alkanoyl, methacryloyl; $n\geq 2$). The ≥ 1 monomer may be styrene, α -methylstyrene, isobutylene, (meth)acrylic acid alkyl ester, and/or benzyl (meth)acrylate. The resin composition contains the polycarboxylic acid resin optionally containing a pigment for the manufacture of color filters. The composition gave high-resolution images.

25736-86-1

RL: RCT (Reactant); RACT (Reactant or reagent) (esterification with maleic anhydride-styrene copolymer; unsat. group-containing polycarboxylic acid resin and photosensitive resin composition for color filter)

RN 25736-86-1 HCAPLUS

CN Poly(oxy-1,2-ethanediy1), α -(2-methy1-1-oxo-2-propen-1-y1)ω-hydroxy- (CA INDEX NAME)

TC TCM G03F007-038

ICS G02B005-20; G03F007-004; H05K003-00

74-13 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Section cross-reference(s): 38

IT Optical filters

(unsat. group-containing polycarboxylic acid resin and photosensitive resin composition for color filter)

IT Carbon black, uses

RL: TEM (Technical or engineered material use); USES (Uses) (unsat.group-containing polycarboxylic acid resin and photosensitive resin composition for color filter)

IT Resists

(photo-, unsat. group-containing polycarboxylic acid resin and photosensitive resin composition for color filter)

IT 3524-68-3 25736-86-1

RL: RCT (Reactant); RACT (Reactant or reagent)

(esterification with maleic anhydride-styrene copolymer; unsat. group-containing polycarboxylic acid resin and photosensitive

resin composition for color filter)

IT 161817-72-7

RL: POF (Polymer in formulation); TEM (Technical or engineered material use); USES (Uses)

(unsat. group-containing polycarboxylic acid resin and photosensitive resin composition for color filter)

IT 147-14-8, C.I. Pigment Blue 15 4051-63-2, C.I. Pigment Red 177 5567-15-7, C.I. Pigment Yellow 83 14302-13-7, C.I. Pigment Green 36 215247-95-3, C.I. Pigment Violet 23

RL: TEM (Technical or engineered material use); USES (Uses) (unsat. group-containing polycarboxylic acid resin and photosensitive resin composition for color filter)

L46 ANSWER 36 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1995:302729 HCAPLUS Full-text

DOCUMENT NUMBER:

122:68317 122:12831a.12834a

ORIGINAL REFERENCE NO.: 122:12831a,12834a
TITLE: Water-developable photosensitive resin

composition useful for manufacturing resists, inks, and printing plates

Jpn. Kokai Tokkyo Koho, 12 pp.

INVENTOR(S): Tanabe, Takashi; Sato, Hozumi
PATENT ASSIGNEE(S): Japan Synthetic Rubber Co Ltd, Japan

CODEN: JKXXAF

SOURCE:

DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

19921

PRIORITY APPLN. INFO .:

<--JP 1992-287164

199210 0.2

AB The title composition comprises (1) a diene polymer containing COOH, (2) a photopolymerizable unsatd, monomer, (3) a photopolymn, initiator, and (4) \geq 1 compound selected from thiourea, a thiourea derivative containing an Naminoalkyl, and a thiourea derivative containing a heterocyclyl. The composition exhibited excellent developability even after a long storage. 25736-86-1

RL: MOA (Modifier or additive use); TEM (Technical or engineered material use); USES (Uses)

(water-developable photosensitive resin compa

RN 25736-86-1 HCAPLUS

CN Poly(oxy-1,2-ethanediyl), α -(2-methyl-1-oxo-2-propen-1-yl)ω-hydroxy- (CA INDEX NAME)

ICM G03F007-038 ICS C08F279-02; C09D004-00; C09D011-10; C09J004-00; C09J113-00; G03F007-004; G03F007-027; G03F007-028

74-4 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38, 42

water developable photosensitive resin compn; diene polymer photosensitive resin compn; thiourea deriv photosensitive resin compn

Printing plates

(water-developable photosensitive resin composition)

Photoimaging compositions and processes (water-developable resin composition)

Resists

(photo-, water-developable photosensitive resin composition)

Inks

(printing, water-developable photosensitive resin compn . 1

62-56-6, Thiourea, uses 96-45-7, Ethylene thiourea 583-39-1, 2-Mercaptobenzimidazole 3290-92-4, Trimethylolpropane trimethacrylate 3845-76-9 18884-15-6 24650-42-8 25736-86-1 114465-17-7 RL: MOA (Modifier or additive use); TEM (Technical or engineered

material use); USES (Uses) (water-developable photosensitive resin compo

L46 ANSWER 37 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1995:169571 HCAPLUS Full-text DOCUMENT NUMBER: 122:68341 ORIGINAL REFERENCE NO.: 122:12838h,12839a

Photosensitive resin composition TITLE:

INVENTOR(S): Koshimura, Katsuo; Tanabe, Takayoshi; Sato,

Hozumi; Ooshima, Noboru; Nishioka, Takashi PATENT ASSIGNEE(S): Japan Synthetic Rubber Co Ltd, Japan SOURCE: Jpn. Kokai Tokkvo Koho, 13 pp.

CODEN: JKXXAF DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

KIND	DATE	APPLICATION NO.	DATE
A	19940726	JP 1993-267725	199310
			01
		<	
B2	20011225		
		EP 1994-302283	
****			199403
			30
		<	50
B1	20010117	•	
DI	20010117		
		TD 1002-267725	
		0F 1993-207723	199310
			01
			0.1
		A 19940726 B2 20011225 A1 19951004	A 19940726 JP 1993-267725 B2 20011225 A1 19951004 EP 1994-302283 B1 20010117 JP 1993-267725

AB The composition comprises (1) a carboxy group-containing diene polymer, (2) a hydrogenated diene polymer containing aliphatic conjugated diene repeating units and in which ≥80% of the double bonds are hydrogenated, (3) photopolymerizable unsatd. monomer(s), (4) a amino group-containing compound, and (5) a photopolymn. initiator. The compound can be developed with water, swelling is prevented, and the compound is useful for photoresists, printing plates, and inks.

25249-16-5, Polyethyleneglycol monomethacrylate RL: TEM (Technical or engineered material use); USES (Uses)

(photosensitive composition containing diene polymer and amino compound)

25249-16-5 HCAPLUS RN

2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, homopolymer (CA CN INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

H2C Me_C_C_C_O_CH2_CH2_OH

TC: TCM G03F007-038

ICS C08L053-02; C09D004-00; C09J004-00; C09J113-00; G03F007-028

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

photosensitive resin compn diene; amine compd resist

ΙT Resists

(photo-, photosensitive composition containing diene polymer and

amino compound)

IT 6956-56-5

RL: CAT (Catalyst use); USES (Uses) (photopolymn. initiator; photosensitive composition containing

diene polymer and amino compound) 3290-92-4, Trimethylolpropane trimethacrylate 3845-76-9, N, N-Dimethylaminopropylacrylamide 9003-17-2D, Polybutadiene, hydrogenated 25249-16-5, Polyethyleneglycol

monomethacrylate 100601-84-1 106107-54-4D, Butadiene-styrene block copolymer, hydrogenated 114465-17-7

RL: TEM (Technical or engineered material use); USES (Uses) (photosensitive composition containing diene polymer and amino compound)

L46 ANSWER 38 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1994:334935 HCAPLUS Full-text

DOCUMENT NUMBER: 120:334935

ORIGINAL REFERENCE NO.: 120:58681a,58684a TITLE:

Photosensitive resin composition

useful for resist INVENTOR(S):

Hagio, Shigeru; Kohda, Kazuhiko; Uehara, Shinichi

PATENT ASSIGNEE(S): San Nopco Ltd., Japan; Ibiden Co., Ltd.

SOURCE: PCT Int. Appl., 47 pp.

CODEN: PIXXD2 DOCUMENT TYPE: Patent

LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 2

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
WO 9306529	A1	19930401	WO 1992-JP1166	199209 11
			<	
W: DE, US JP 05072735	A	19930326	JP 1991-262701	199109 14
JP 06083052		19940325	< лр 1991-262703	
JP 06083052	A	19940325	JP 1991-262703	199109 14
JP 06095379	A	19940408	< JP 1991-262704	
35 06032373	A	19940408	JP 1991-262/04	199109 14
DE 4293400	TO	19931007	< DE 1992-4293400	
DE 4253400	10	19931007		199209 11
PRIORITY APPLN. INFO.:			< JP 1991-262701 A	199109 14
			< JP 1991-262703 А	199109

AB A photosensitive resin composition which is developed by an aqueous alkali solution and has excellent sensitivity, resolution and resistance against electroless plating solution, comprising a graft polymer having, as branch polymers, a polymer of a monomer that has hydrophilic groups, and a binder polymer which is soluble or swellable in an aqueous alkali solution and is capable of forming a film. The composition comprises a graft polymer which has, as branch polymers, a polymer of a monomer that has hydrophilic groups, a

binder polymer which is soluble or swellable in an aqueous alkali solution, an

ethylenically unsatd. compound, and a photopolymn. initiator. IT 117650-37-0P, 2-Hydroxyethyl methacrylatemethyl methacrylate

graft copolymer
RL: SPN (Synthetic preparation); PREP (Preparation)
(preparation and use of, photosensitive resin compa

. from)

RN 117650-87-0 HCAPLUS

CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, polymer with methyl 2-methyl-2-propenoate, graft (9CI) (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 80-62-6

CMF C5 H8 O2

IC G03F007-038

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

ST photosensitive resin compn resist

IT Phenolic resins, uses

RL: USES (Uses)

(epoxy, novolak, photosensitive resin composition from)
T Epoxy resins, uses

IT Epoxy resins, use RL: USES (Uses)

87

(phenolic, novolak, photosensitive resin composition from)

Resists

(photo-, resin composition for)

2760-98-7 15625-89-5 17831-71-9 24979-70-2, Maruka Lyncur M-S 3 25035-69-2, Butyl acrylate-methacrylic acidmethyl methacrylate copolymer 26300-51-6, Acrylic acidbutyl acrylatemethyl methacrylate copolymer 59372-10-0, Butyl acrylate-2-ethylhexyl acrylate-methacrylic acidmethyl methacrylate copolymer 63939-13-9, Epikote 154 106209-33-0, SMA Resin 1000 RL: USES (Uses)

(photosensitive resin composition from)

IT 117650-87-0P, 2-Hydroxyethyl methacrylatemethyl methacrylate graft copolymer 131004-72-3P, Butyl methacrylate-2-hydroxyethyl methacrylate-methyl methacrylate graft copolymer RL: SPN (Synthetic preparation); PREP (Preparation) (preparation and use of, photosensitive resin compo

. from)

110224-97-0P, 2-Hydroxyethyl methacrylate-thioglycolic acid telomer 155646-48-3P, 2-Hydroxyethyl methacrylate-thioglycolic acid telomer glycidyl methacrylate RL: PREP (Preparation)

(preparation of, photosensitive resin composition from)

L46 ANSWER 39 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN 1992:540657 HCAPLUS Full-text ACCESSION NUMBER:

DOCUMENT NUMBER: 117:140657

ORIGINAL REFERENCE NO.: 117:24211a,24214a

TITLE:

Photoresist composition INVENTOR(S):

Matsumura, Akira; Ishikawa, Katsukiyo PATENT ASSIGNEE(S): Nippon Paint Co., Ltd., Japan

SOURCE: Eur. Pat. Appl., 6 pp.

CODEN: EPXXDW Patent

DOCUMENT TYPE: LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
EP 469584	A1	19920205	EP 1991-112888	
FE 402304	AI	19920203	EF 1991-112000	199107 31
			<	
EP 469584	В1	19970305		
R: DE, GB, NL JP 04088346	A	19920323	JP 1990-205678	
DE 04088240	A	19920323	JP 1990-205678	199007 31
			<	
PRIORITY APPLN. INFO.:			JP 1990-205678 A	199007 31

AB A photoresist composition, which can be used in forming a pos. or neg. resist pattern having excellent phys. properties, such as chemical resistance, comprises (a) 20-90 weight% of a polymer pendanted with a branched group which is unstable against an acid and present repeatedly, (b) 10-80 weight% of a polymer having a group which is reactive at an elevated temperature with the groups which are produced by the decomposition of the branched groups of the

November 26, 2008 10/577,255 88

polymer (a) with an acid, and (c) 0.1-50 weight%, based on (a) and (b), of a photopolymn. initiator which generates an acid in response to photoirradn., wherein the branched group of (a) is a tert-Bu ester group of a carboxylic acid or a tert-Bu carbonate of a phenolic compound and the photoresist composition may further contain a photosensitizer 0.01-10 weight% based on (a) and (b).

129698-93-7 RL: USES (Uses)

(photoresist compas, containing acid-generating

chotosensitive compds. and)

RN 129698-93-7 HCAPLUS

2-Propenoic acid, 2-methyl-, 1,1-dimethylethyl ester, polymer with CN 2-hydroxyethyl 2-methyl-2-propenoate (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

CM 2

CRN 585-07-9 CMF C8 H14 O2

25249-16-5, Poly(2-hydroxyethylmethacrylate)

RL: USES (Uses)

(photoresist compns. containing acid-generating photosensitive compds. and acid-decomposable polymers

and)

25249-16-5 HCAPLUS RN

2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, homopolymer (CA INDEX NAME)

CM 1

CRN 868-77-9 CMF C6 H10 O3

ICM G03F007-039

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

II 57840-38-7, Triphenylsulfonium hexafluoroantimonate 62613-15-4 RL: USES (Uses)

(photoresist compns. containing acid-decomposable polymers and reactive polymers and)

IT 129698-93-7

RL: USES (Uses)

(photoresist compos. containing acid-generating photosensitive compds. and)

IT 25249-16-5, Poly(2-hydroxyethylmethacrylate)

RL: USES (Uses)

(photoresist compas, containing acid-generating photosensitive compds, and acid-decomposable polymers

IT 25189-00-8, Poly(tert-butylmethacrylate) 87261-04-9,
Poly(p-tert-butoxycarbonyloxystyrene)
RL: USES (Uses)

(photoresists compas. containing acid-generating photosensitive compds. and reactive polymers and)

L46 ANSWER 40 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1992:501063 HCAPLUS Full-text

DOCUMENT NUMBER: 117:101063

ORIGINAL REFERENCE NO.: 117:17399a,17402a

TITLE: A photosensitive resin composition for use in forming a relief structure

use in forming a relief structure
INVENTOR(S): Takahashi, Gensho; Sato, Reijiro

PATENT ASSIGNEE(S): Asahi Chemical Industry Co., Ltd., Japan SOURCE: Eur. Pat. Appl., 22 pp.

CODEN: EPXXDW

DOCUMENT TYPE: Patent
LANGUAGE: English
FAMILY ACC. NUM. COUNT: 1
PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
EP 427950	A2	19910522	EP 1990-119036	
				199010
				04
			<	
EP 427950		19911016		
EP 427950	B1	19960717		
R: BE, DE, ES	FR, GE	B, IT, NL		
JP 03157657	A	19910705	JP 1989-296113	
				198911
				16
			<	
JP 2644898	B2	19970825		
AU 9062273	A	19910523	AU 1990-62273	
				199009
				07
			<	
AU 624994	B2	19920625		
ES 2088935	Т3	19961001	ES 1990-119036	
				199010
				04
			<	
US 5336585	A	19940809	US 1992-999578	

90

- AB A process for producing a photosensitive resin composition for use in forming a relief structure comprises blending the following components: (A) a liquid photosensitive resin component comprising: (a) a urethane prepolymer 100 weight parts comprising a plurality of diol segments linked through a urethane linkage and having an addition-polymerizable ethylenically unsatd, group at both terminals thereof, the diol segments comprising ≥1 polyoxyalkylene diol segment and ≥1 saturated polyester diol segment, the urethane prepolymer having a number average mol. weight of from 2.0 + 103 to 3.0 + 104, and (b) an addition-polymerizable ethylenically unsatd. monomer 10-200 weight parts; (B) a photopolymn. initiator 0.1-10 wt % of A; (C) a thermal polymerization inhibitor 0.01-5 weight % of A; and (D) ≥1 unsatd. amine compound CH2:CR1CO2ANR2R3 0.1-5 weight % of A [R1 = H, Me; R2, R3 = alkyl; A = straight chain or branched alkylene]. The composition gives a photoresin relief structure which not only is characterized with a tunnel-free structure and excellent mech. properties, but also exhibits excellent performances.
- IT 39420-45-6 39420-45-6D, reaction product with

urethane polymer

RL: USES (Uses)

(in photosensitive composition for tunnel-free relief structures)

RN 39420-45-6 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)],

 α -(2-methyl-1-oxo-2-propen-1-yl)- ω -hydroxy- (CA INDEX NAME)

RN 39420-45-6 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)], α -(2-methyl-1-oxo-2-propen-1-yl)- ω -hydroxy- (CA INDEX NAME)

- IC ICM G03F007-027
- CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)
- ST photosensitive compo urethane amine; relief structure

photoimaging compn; printing plate photoimaging

Urethane polymers, uses

RL: USES (Uses)

(in photosensitive composition for tunnel-free relief structures)

Printing plates

(relief, tunnel-free structure producing photosensitive composition for)

105-16-8, N,N-Diethylaminoethyl methacrylate 109-17-1, Tetraethylene glycol dimethacrylate 128-37-0, 2,6-Di-tert-butyl-p-cresol, properties 142-90-5, Lauryl methacrylate 868-77-9, 2-Hydroxyethyl methacrylate 923-26-2, 2-Hydroxypropyl methacrylate 923-26-2D, 2-Hydroxypropyl methacrylate, reaction product with urethane polymer 2439-35-2 2867-47-2, N.N-Dimethylaminoethyl methacrylate 3290-92-4, Trimethylolpropane trimethacrylate 17577-32-1, 3-N, N-Diethylaminopropyl methacrylate 32360-05-7, Stearyl methacrylate 39420-45-6 39420-45-6D, reaction product with urethane polymer 54951-50-7 117646-83-0, Diethyleneglycol 2-ethylhexyl ether acrylate 142875-48-7D, Adipic acid-ethylene oxide-propylene glycol-propylene oxide-toluene diisocyanate block copolymer, reaction product with hydroxypropyl methacrylate or oxypropylene glycol monomethacrylate 142875-49-8D,

ε-Caprolactone-hexamethylene diisocyanate-propylene glycol block copolymer, reaction product with polyoxypropylene glycol monomethacrylate

RL: USES (Uses)

(in photosensitive composition for tunnel-free relief structures)

L46 ANSWER 41 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1990:488297 HCAPLUS Full-text
DOCUMENT NUMBER: 113:88297

ORIGINAL REFERENCE NO.: 113:14723a,14726a TITLE: Photosensitive resin compositions for

flexographic plates INVENTOR(S):

Iwanaga, Shinichiro; Matsunaga, Tatsuaki; Tanaka, Masaji; Nobuyo, Koji

PATENT ASSIGNEE(S): Japan Synthetic Rubber Co., Ltd., Japan SOURCE: Jpn. Kokai Tokkvo Koho, 10 pp.

CODEN: JKXXAF

DOCUMENT TYPE: Patent

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 02058059	A	19900227	JP 1988-208002	
				198808
				24
			<	

JP 1988-208002 PRIORITY APPLN. INFO.:

198808 24

The title compas, contain conjugated diene copolymer A 50-90, conjugated diene copolymer B (with number-average mol. weight 5000-10,0000) 10-50 (A+B = 100),

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photopolyma, unsatd, monomers 10-200, and photopolyma, initiators 0.1-10 parts; the copolymer A consist of conjugated diene unit a 40-90, α , β -ethylenic acid unit b 0.5-10, polyfunctional vinylic unit c 0.1-5, and monoolefin unit d 0-59.4 mol%, and the copolymer B contains a 30-90, b 0-30, and d 5-70 mol%. These compas, are highly developable with aqueous and alkaline developers and provide flexog, printing plates with high performance. Thus, 100 parts of a 7:3 (solid weight) mixture of copolymer A [84.8:2.0:1.2:12.0 (mol) butadienemethacrylic acid-ethylene glycol dimethacrylate-Et acrylate copolymer] and copolymer B [81:7:12 (mol) butadiene-methacrylic acid-Et acrylate copolymer, number-average mol. weight 18,000], nonaethylene glycol monoacrylate 10, tetraethylene glycol diacrylate 20, dimethylaminopropylacrylamide 10, trimethylolpropane triacrylate 5, benzoin isopropyl ether 2.0, and 2,6-tertbutylcatechol 0.2 q, were kneaded with heating to obtain the photosensitive composition with good workability. A SBR sheet was coated with a 2-mm-thick layer of this composition, and which layer was imagewise exposed, developed with 40° water, to obtain a flexog printing plate with good elasticity, and the use of this plate for printing showed good ink transfer. 26403-58-7

RL: USES (Uses)

(photosensitive compos. containing, for photosensitive flexog. plates)

RN 26403-58-7 HCAPLUS

CN Poly(oxy-1,2-ethanediy1), α -(1-oxo-2-propen-1-y1)- ω -hvdroxv- (CA INDEX NAME)

$$\mathtt{H}_{2}\mathtt{C} = \mathtt{C}\mathtt{H} - \overset{\circ}{\mathtt{C}} \underbrace{\hspace{1.5cm}} \mathtt{C} - \mathtt{C}\mathtt{H}_{2} - \mathtt{C}\mathtt{H}_{2} \underbrace{\hspace{1.5cm}} \mathtt{n} \mathtt{O}\mathtt{H}$$

IC ICM G03F007-033 ICS G03F007-00

CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 38

flexog plate photosensitive polymer compa

IT 3845-76-9 15625-89-5 17831-71-9, Tetraethylene glycol diacrylate 26403-58-7

RL: USES (Uses)

(photosensitive compns. containing, for shotosensitive flexog. plates)

L46 ANSWER 42 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1989:467975 HCAPLUS Full-text DOCUMENT NUMBER: 111:67975

ORIGINAL REFERENCE NO.: 111:11315a,11318a

TITLE: Photosensitive resin compositions

INVENTOR(S): Kawamura, Kiyoshi; Matsuda, Tatsuto; Otsuki,

Nobuaki; Sano, Sadanori

PATENT ASSIGNEE(S): Nippon Shokubai Kagaku Kogyo Co., Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 9 pp.

CODEN: JKXXAF

DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION: AB

CRN 999-61-1 CMF C6 H10 O3

PATENT NO. APPLICATION NO. DATE KIND DATE JP 63234248 A 19880929 JP 1987-67876 198703 2.4 <---PRIORITY APPLN. INFO.: JP 1987-67876 198703 24 The title compas, for high-performance lithog, printing plates contain polymers of a (meth)acrylamide monomer of the formula CH2:CRCON[(CH2CHRO)1H](CH2CHRO)mH (R = H, Me; 1, m = 0-20; 1 + m 1-20) and/or a HO group-containing (meth) acrylate oligomer of the formula CH2:CRCO2ZO(CH2CHRCO2ZO)nH (R = H, Me; Z = C2-20 divalent organic group; n = 1-100) and a diazo compound 25249-16-5, 2-Hydroxyethylmethacrylate polymer 26022-14-0 32029-53-1, 2-Hydroxypropylacrylate polymer RL: USES (Uses) (photosensitive compas. containing, for lithog. plates) RN 25249-16-5 HCAPLUS CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, homopolymer (CA INDEX NAME) CM 1 CRN 868-77-9 CMF C6 H10 O3 ²Й_Й_о_онг_снг_он RN 26022-14-0 HCAPLUS CN 2-Propenoic acid, 2-hydroxyethyl ester, homopolymer (CA INDEX NAME) CM 1 CRN 818-61-1 CMF C5 H8 O3 RN 32029-53-1 HCAPLUS CN 2-Propenoic acid, 2-hydroxypropyl ester, homopolymer (CA INDEX NAME) CM 1

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Me-CH-CH2-O-C-CH-CH2
IC ICM G03C001-71
    ICS G03C001-68; G03F007-08
   74-6 (Radiation Chemistry, Photochemistry, and Photographic and
    Other Reprographic Processes)
IT Lithographic plates
       (photosensitive compas. containing acrylic compds. for
       fabrication of)
IT 79-10-7, Acrylic acid, uses and miscellaneous 79-41-4, Methacrylic
     acid, uses and miscellaneous 80-62-6, Methyl methacrylate
     96-33-3, Methyl acrylate 107-13-1, Acrylonitrile, uses and miscellaneous 868-77-9, 2-Hydroxyethylmethacrylate 999-61-1,
     2-Hydroxypropylacrylate 1184-84-5, Vinyl sulfonic acid
     5238-56-2, N-(2-Hydroxyethyl)methacrylamide 25249-16-5,
     2-Hydroxyethylmethacrylate polymer 26022-14-0
     32029-53-1, 2-Hydroxypropylacrylate polymer 45011-26-5
     99207-50-8
     RL: USES (Uses)
        (photosensitive compas. containing, for
        lithog, plates)
L46 ANSWER 43 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN
ACCESSION NUMBER: 1989:467964 HCAPLUS Full-text
DOCUMENT NUMBER:
                        111:67964
ORIGINAL REFERENCE NO.: 111:11315a,11318a
                       Photosensitive resin compositions
TITLE:
                     Minami, Yoshitaka; Kakumaru, Hajime; Kawaguchi,
INVENTOR(S):
Taku; Tanaka, Yumiko
PATENT ASSIGNEE(S): Hitachi Chemical Co., Ltd., Japan
SOURCE: Jpn. Rokai Tokkyo Koho, 6 pp.
                        CODEN: JKXXAF
DOCUMENT TYPE: Patent
LANGUAGE:
                        Japanese
FAMILY ACC. NUM. COUNT: 1
PATENT INFORMATION:
    PATENT NO. KIND DATE APPLICATION NO.
                                                                  DATE
     JP 01048803
                    A
                              19890223 JP 1987-206084
                                                                   198708
                                                                   19
                                                 <--
     JP 2570758 B2 19970116
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JP 1987-206084

<--

198708

OTHER	SOURCE(S):	MARPAT	111:67964

PRIORITY APPLN. INFO.:

AΒ Title compas, with improved sensitivity, useful for formation of precise circuits, comprise thermoplastic polymers, photopolymerizable compds. containing ≥1 terminal ethylene group, and photopolymn, initiators (weight average mol. weight ≥320) having the acridinyl group I [R1-8 = H, halo, C1-8 alkyl, OMe; X = (un)substituted heterocyclic group conjugated with acridinyl group]. Thus, Ph2NH, p-n-hexylbenzoic acid, and polyphosphoric acid were stirred at 220° for 8 h to give 9-(p-n-hexylphenyl)acridine (II, mol. weight 326). Then, a poly(ethylene terephthalate) film was coated with a composition containing 20:60:20 2-ethylhexyl acrylate-Me methacrylate-methacrylic acid copolymer 157.5, BPE 10 30.0, NK Ester A-TMM 3L 6.0, II 1.0, Leuco Crystal Violet 1.0, tribromomethyl Ph sulfone 1.0, Malachite Green 0.05, and MEK 150 parts and dried at 100° to form a 50-um photosensitive layer, which was covered with a protection film (polyethylene) to obtain a photosensitive film. Then, the film was laminated, after peeling off the protective film, with a Cu-clad laminate, exposed to UV, and developed to obtain a photoresist with good resolution and no dissoln. of solder during etching process.

IT 39420-45-65, Blemmer P 1000, reaction products with (hydroxyphenyl)acridine and isophorone diisocyanate RL: USES (Uses)

(photopolymn. initiator, photosensitive resin compos. containing, for photoresists)

RN 39420-45-6 HCAPLUS

CN Poly(oxy(methyl-1,2-ethanediyl)),

 $\begin{array}{lll} \alpha-(2\text{-methyl-}1\text{-oxo-}2\text{-propen-}1\text{-yl})\text{-}\omega\text{-hydroxy-} & \text{(CA INDEX NAME)} \end{array}$

IC ICM C08F002-50

ICS C08F002-44; G03C001-68

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 76

ST photosensitive polymer compo photoresist; acridine

photopolymn initiator photoresist; elec circuit photoresist

IT Polymerization catalysts

(photochem., acridine derivs., photosensitive resin

compas. containing, for photoresists)

IT 4098-71-9D, reaction products with (hydroxyphenyl)acridine and polypropylene glycol monoacrylate 36482-93-6D,

9-(p-Hydroxyphenyl)acridine, reaction products with isophorone diisocyanate and polypropylene glycol monoacrylate

39420-45-60, Blemmer P 1000, reaction products with

(hydroxyphenyl)acridine and isophorone diisocyanate 121819-78-1,

9-(p-n-Hexylphenyl)acridine

RL: USES (Uses)

(photopolymn. initiator, photosensitive resin compas. containing, for photoresists)

IT 56093-53-9, Tetramethylolmethane triacrylate RL: USES (Uses)

(photosensitive resin compos. containing, A-TMM 3L, for photoresists)

IT 25133-98-6, 2-Ethylhexyl acrylate-methacrylic acid-methyl methacrylate copolymer 41637-38-1, BPE 10 RL: USES (Uses)

(photosensitive resin compas. containing, for photoresists)

L46 ANSWER 44 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1987:25797 HCAPLUS Full-text

DOCUMENT NUMBER: 106:25797

ORIGINAL REFERENCE NO.: 106:4233a,4236a

TITLE: Photosensitive solder resist ink compositions

INVENTOR(S): Kamayatsu, Yuichi; Sawazaki, Kenji; Suzuki,

Morio

PATENT ASSIGNEE(S): Taiyo Ink Seizo K. K., Japan SOURCE: Jpn. Kokai Tokkyo Koho, 11 pp.

CÔDEN: JKXXAF
DOCUMENT TYPE: Patent

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 61000272	A	19860106	JP 1984-119106	
				198406
				12
			<	
JP 01039698	В	19890823		
PRIORITY APPLN. INFO.:			JP 1984-119106	

198406 12

AB Solder resist ink compns. contain (1) a radiation-curing type resin obtained by reaction of a novolak type epoxy resin-unsatd. monocarboxylic acid reaction product with a diisocyanate-hydroxy group-containing (meth) acrylate reaction product, (2) a photopolymn. initiator, and (3) an organic solvent. Thus, a cresol novolak type epoxy resin acrylate was made to react with an isophorone diisocyanate-pentaerythritol triacrylate reaction product, and the resultant resin was mixed with butyl Cellosolve, benzoin iso-Pr ether, phthalocyaning green, and Modaflow (a leveling agent) to give a screen printing ink. The ink was coated on a Cu laminate (for printed circuits) to form a UV resist layer, from which a soldering resistant pattern was prepared

IT 26022-14-0, Modaflow

RL: USES (Uses)

(photosensitive ink composition containing, for soldering-resistant pattern formation)

RN 26022-14-0 HCAPLUS

CN 2-Propenoic acid, 2-hydroxyethyl ester, homopolymer (CA INDEX NAME)

CM 1

CRN 818-61-1

CMF C5 H8 O3

IC ICM C09D011-10

ICS G03C001-71; H05K003-28; H05K003-34

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes) Section cross-reference(s): 76

ΙT Epoxy resins, compounds

RL: USES (Uses)

(cresolic, reaction products with acrylic acid, isophorone diisocyanate, methacrylic acid, pentaerythritol triacrylate, and TDI, photosensitive ink composition containing, for soldering-resistant pattern formation)

Phenolic resins, compounds

RL: USES (Uses)

(epoxy, cresol-based, reaction products with acrylic acid, isophorone diisocyanate, methacrylic acid, pentaerythritol triacrylate, and TDI, photosensitive ink composition containing, for soldering-resistant pattern formation)

TТ 75-57-0. Tetramethylammonium chloride 79-10-7D, reaction products with cresol-based epoxy resins, isophorone diisocyanate, and pentaerythritol triacrylate 79-41-4D, reaction products with cresol-based epoxy resins, pentaerythritol triacrylate, and TDI 84-51-5, 2-Ethylanthraquinone 103-83-3, Benzyldimethylamine 110-80-5 111-76-2, Butyl cellosolve 111-90-0, Carbitol 112-15-2, Carbitol acetate 471-34-1, Calcium carbonate, uses and miscellaneous 931-36-2, 2-Ethyl-4-methylimidazole 1328-53-6, Phthalocyanine green 4098-71-9D, reaction products with acrylic acid, cresol-based epoxy resins, and pentaerythritol triacrylate 6652-28-4, Benzoin isopropyl ether 7727-43-7 13750-62-4 14807-96-6, Talc, uses and miscellaneous 15625-89-5, Trimethylolpropane triacrylate 15625-89-5D, reaction products with acrylic acid, cresol-based epoxy resins, isophorone diisocyanate, methacrylic acid, and TDI 25068-38-6 26022-14-0, Modaflow 26471-62-5D, reaction products with cresol-based epoxy resins, methacrylic acid, and pentaerythritol triacrylate 29570-58-9, Dipentaerythritol hexaacrylate 82799-44-8 104074-13-7

RL: USES (Uses)

(photosensitive ink composition containing, for soldering-resistant pattern formation)

L46 ANSWER 45 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN 1986:177734 HCAPLUS <u>Full</u>-text ACCESSION NUMBER: DOCUMENT NUMBER: 104:177734

ORIGINAL REFERENCE NO.: 104:27995a,27998a

TITLE: A photosensitive resin composition

which is improved with respect to its surface

tack-free characteristic after curing INVENTOR(S): Minonishi, Kuniaki; Sato, Reijiro PATENT ASSIGNEE(S): Asahi Chemical Industry Co., Ltd., Japan

SOURCE: Eur. Pat. Appl., 59 pp.

CODEN: EPXXDW

DOCUMENT TYPE: Patent LANGUAGE: English FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
EP 154994	A2	19850918	EP 1985-102895	198503
			<	13
EP 154994 EP 154994	A3 B1	19860122 19890614		
R: BE, DE, FR JP 60191237	, GB A	19850928	JP 1984-46472	198403
			<	13
JP 05055857 US 4716094	B A	19930818 19871229	US 1985-709186	
				198503 07
AU 8539769	A	19850919	< AU 1985-39769	
				198503 12
AU 574766	B2	19880714	<	
JP 08286361	A A	19961101	JP 1996-51909	199603
			<	08
PRIORITY APPLN. INFO.:			JP 1984-46472 A	198403 13
			<	

OTHER SOURCE(S): MARPAT 104:177734

A photosensitive resin composition for photoresists and relief images for use as letterpress printing plates, molding matrixes, and decorative materials is comprised of ethylenically unsatd. compds., a photoinitiator, a prepolymer, and a compound having the general formula R1CO2H, R1CONH2, or R1CH2OR2 (R1 = CnH2n+1, CnH2n-1 where n = 11-21; R2 = H, COZSZCO2CH2R3 where Z = C1-6divalent hydrocarbon group and R3 = CnH2n+1, CnH2n-1 where n = 11-21). The photosensitive resin composition is imagewise exposed to actinic radiation, developed by removing the uncured resin layer, and post-exposed to actinic radiation, with the resin images immersed in an aqueous solution containing an alkali metal salt or alkaline earth metal salt of H2SO3 to give tack-free relief images. Thus, polypropylene glycol (Mn = 2000) 1 and polypropylene glycol adipate 1 part were mixed with tolylene diisocyanate 0.2 part and reacted at 80° for 3 h to give a polyurethane. The polyurethane 2.2 parts was reacted with polypropylene glycol monomethacrylate (Mn = 380) 0.47 part at 80° for 2 h to give a modified polyurethane. The modified polyurethane 100, polypropylene glycol monomethacrylate (Mn = 380) 25, lauryl methacrylate 15, tetraethylene glycol dimethacrylate 10, 2,2-dimethoxy-2-phenylacetophenone 1.5, myristic acid 2, and 2,6-di-tert-butyl-p-cresol 0.2 part were mixed at 50° to give a photosensitive resin composition, poured over a polypropylene film, exposed to near UV (370 nm), developed in an aqueous solution of a nonionic surfactant (Wash Out Agent W-7), rinsed, immersed in 0.1% Na2SO3, exposed to the above UV source, dried, and the surface tack of the photocured relief-image plate determined to be 0 q.

99

ΤТ 39420-45-6

RL: USES (Uses)

(photosensitive resin compas. containing

prepolymer and photoinitiator and carboxylic acid or amide and ethylenically unsatd. monomers and, for nontacky relief image formation)

39420-45-6 HCAPLUS RN

Poly[oxy(methyl-1,2-ethanediyl)], CN

> α-(2-methyl-1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX NAME)

IT 39420-45-60, reaction product with isocyanate terminated polyurethane

RL: USES (Uses)

(photosensitive resin compns. containing, for nontacky relief image formation)

RN 39420-45-6 HCAPLUS

Poly[oxy(methyl-1,2-ethanediyl)],

α-(2-methyl-1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX NAME)

ICM G03C001-68

CC 74-4 (Radiation Chemistry, Photochemistry, and Photographic and

Other Reprographic Processes)

photosensitive prepolymer nontacky relief image; photoresist prepolymer nontacky carboxylic acid; amide prepolymer photoimaging comps nontacky

Carboxylic acids, uses and miscellaneous

RL: USES (Uses)

(photosensitive compns. containing prepolymer and

photoinitiator and ethylenically unsatd. monomers and, for production of nontacky relief images)

IT Amides, uses and miscellaneous

RL: USES (Uses)

(photosensitive resin compas, containing prepolymer and photoinitiator and ethylenically unsatd, monomers and, for production

of nontacky relief images)

Decoration

(relief plastic, photosensitive resin compas, containing prepolymer and ethylenically unsatd. monomers and photoinitiator

and carboxylic acid or amide for production of nontacky) Printing plates

(relief, photosensitive resin compas. containing prepolymer and ethylenically unsatd. monomers and photoinitiator and carboxylic acid or amide for production of nontacky)

IT Polyesters, uses and miscellaneous

Urethane polymers, uses and miscellaneous

RL: USES (Uses)

(unsatd., photosensitive resin compas. containing

ethylenically unsatd. monomers and photoinitiator and carboxylic acid or amide and, for nontacky relief image formation)

IT 9003-17-2D, hydroxy terminated polymer with TDI, reaction product with 2-hydroxy Et methacrylate or 2-hydroxy Et methacrylate, lauryl methacrylate, and diester 101516-71-6 101628-14-2D, reaction product with polypropylene glycol monomethacrylate RI: USES (Uses)

(photosensitive resin compose containing ethylenically unsatd. monomers and photoinitiator and carboxylic acid or amide and, for nontacky relief image formation)

IT 6652-28-4 22499-13-4 24650-42-8

RL: USES (Uses)

(photosensitive resin compns. containing prepolymer and ethylenically unsatd. monomers and carboxylic acid or amide and, for nontacky relief image formation)

IT 109-17-1 142-90-5 923-26-2 25852-49-7 39420-45-6

RL: USES (Uses)

(photosensitive resin compns. containing

prepolymer and photoinitiator and carboxylic acid or amide and ethylenically unsatd. monomers and, for nontacky relief image formation)

IT 128-37-0, uses and miscellaneous 150-76-5

RL: USES (Uses)

(photosensitive resin compns. containing prepolymer and photoinitiator and ethylenically unsatd. monomers and carboxylic acid or amide and, for nontacky relief imace formation)

IT 57-10-3, uses and miscellaneous 112-84-5 544-63-8, uses and miscellaneous 16545-54-3 36653-82-4

RL: USES (Uses)

(photosensitive resin compns. containing prepolymer and photoinitiator and ethylenically unsatd. monomers and, for nontacky relief image formation)

IT 923-26-2D, reaction product with isocyanate terminated polybutadiene diol tolylene diisocyanate copolymer 39420-45-6D, reaction product with isocyanate terminated polyurethane RL: USES (Uses)

(photosensitive resin compns. containing, for nontacky relief image formation)

L46 ANSWER 46 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1985:222322 HCAPLUS Full-text

DOCUMENT NUMBER: 102:222322

ORIGINAL REFERENCE NO.: 102:34897a,34900a

TITLE: Photosensitive ink compositions
PATENT ASSIGNEE(S): Ono, Takao, Japan; Ishii, Ginya

SOURCE: Jpn. Kokai Tokkyo Koho, 5 pp.
CODEN: JKXXAF

DOCUMENT TYPE: Patent LANGUAGE: Japanese

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 60004512	A	19850111	JP 1983-112333	

November 26, 2008 10/577,255 101

198306 22

PRIORITY APPLN. INFO.:

JP 1983-112333

198306 22

AB The compns. useful as etching and plating resists comprise a phenone-type photoinitiator and a monoester (polymer) prepared from (a) (methyl)tetrahydrophthalic acid, (methyl)tetrahydrophthalic acid, or their anhydrides and (b) a compound containing a polymerizable double bond and ≥1 alc. OH. Thus, a Cu-plated laminate was screen printed by a photosensitive composition containing polymer [36663-78-4] of monoester prepared from 2-hydroxyethyl methacrylate (I) [868-77-9] and methylhexahydrophthalic anhydride, I, phthalocyanine blue, 2-hydroxy-2-methylpropiophenone [7473-98-5], and BaSO4 and irradiated by Hg lamp. The cured coating showed pencil hardness 3H, dissoln. time by 3% NaOH spray 5-10 s, and good etchant resistance.

IT 96663-78-4 96663-84-2

RL: USES (Uses)

(photosensitive ink compns. containing)

RN 96663-78-4 HCAPLUS

CN 1,2-Cyclohexanedicarboxylic acid, methyl-, mono[2-[(2-methyl-1-oxo-2-propenyl)oxy]ethyl] ester, homopolymer (9C1) (CA INDEX NAME)

CM 1

CRN 93951-37-2 CMF C15 H22 O6 CCI IDS

CM 2

CRN 57567-84-7 CMF C9 H14 O4

CM 3

CRN 868-77-9 CMF C6 H10 O3

CME CO HIO OS

RN 96663-84-2 HCAPLUS

4-Cyclohexene-1,2-dicarboxylic acid, 3-methyl-,

```
mono[2-[(2-methyl-1-oxo-2-propenyl)oxy]ethyl] ester, homopolymer
 (9CI) (CA INDEX NAME)
 CM 1
 CRN 96663-83-1
 CMF C15 H20 O6
 CCI IDS
      CM
      CRN 15941-50-1
      CMF C9 H12 O4
      CM
           3
      CRN 868-77-9
      CMF C6 H10 O3
     -O-CH2-CH2-OH
ICM C08F020-20
 ICS C08F002-50; G03C001-68
 42-12 (Coatings, Inks, and Related Products)
 Section cross-reference(s): 74
 Resists
    (photo-, UV, acrylic compns. containing propiophenone
    derivs. for)
 Crosslinking catalysts
 Polymerization catalysts
    (photochem., propiophenone derivs., for acrylic ink
    compris.)
 Inks
    (photocurable, acrylic compas, for, containing
    propiophenone derivs.)
    (photogravure, acrylic compos. for, containing
    propiophenone derivs.)
 611-70-1 7473-98-5
 RL: USES (Uses)
    (photochem. crosslinking and polymerization catalysts, photosensitive
    acrylic ink compos. containing)
 868-77-9 96663-55-7 96663-72-8 96663-78-4
 96663-84-2
```

IC

ΙT

RL: USES (Uses)

(photosensitive ink compas. containing)

L46 ANSWER 47 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1983:513720 HCAPLUS Full-text

DOCUMENT NUMBER: 99:113720

ORIGINAL REFERENCE NO.: 99:17357a,17360a
TITLE: Photosensitive resin co

TITLE: Photosensitive resin compositions for

flexographic plates
PATENT ASSIGNEE(S): Teijin Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 10 pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 58076828	A	19830510	JP 1981-172932	
				198110
				30
			<	
PRIORITY APPLN. INFO.:			JP 1981-172932	
				198110

<--

30

AB Photosensitive resin compas, suitable for flexog, plate preparation consist of: (1) a urethane prepolymer (number-averaged mol. weight, Mn = 2000-8000) having (a) prepolymer main chain derived from polyols, whose main constituent is a hydroxy-terminated polyester (Mn = 500-3000), and diisocyanates, whose main constituent is OCNCH2ZCH2NCO (Z = phenylene, cyclohexylene; Z may be substituted with lower alkyl), and (b) photopolymerizable double bondcontaining groups which are urethane-bonded to both ends of the main chain; (2) another urethane prepolymer (Mn = 2000-8000) having similar prepolymer main chain as (1) and a photopolymerizable double bond-containing group which is urethane-bonded to one end of the main chain; (3) crosslinking agent(s) having ≥1 photopolymerizable double bond/mol.; and (4) sensitizers. Thus, a PET film was coated with a 0.8-µm thick layer containing a urethane prepolymer (mixture of 1 and 2) obtained by reaction of poly(butylene adipate) with terminal OH groups (Mn = 2000), hydrogenated m-xylene diisocyanate (mol. weight = 194), oxyethylene-oxypropylene block polyether (mol. weight = 2000), 2-hydroxypropyl methacrylate, Bu2Sn dilaurate, p-methoxyphenol, and polyethylene diethylene adipate; polypropylene glycol monomethacrylate, dipropylene glycol dimethacrylate, and diallyl phthalate; benzoin iso-Pr ether; and p-methoxyphenol to obtain a photopolymer layer. The photopolymer layer showed excellent characteristics with respect to elasticity. ΙT 39420-45-6

RL: USES (Uses)

(photosensitive composition containing, for flexog.

plate preparation) RN 39420-45-6 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)],

 α -(2-methyl-1-oxo-2-propen-1-yl)- ω -hydroxy- (CA INDEX NAME)

IC G03C001-71; G03C001-68; G03F007-10

ICA C08F002-50; C08F299-06

74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

TT Urethane polymers, uses and miscellaneous RL: USES (Uses)

(photosensitive resin composition containing, for flexog. plate preparation)

ΙT Printing plates (flexog., photosensitive resin compas. for preparation of)

131-17-9 7559-82-2 39420-45-6 86714-41-2 RL: USES (Uses)

(photosensitive composition containing, for flexog.

plate preparation)

109-16-0 109-17-1 1087-21-4 86714-41-2 86714-42-3 86714-43-4 86714-44-5 86714-45-6 86745-86-0 86745-87-1 RL: USES (Uses)

(photosensitive resin composition containing, for flexog. plate preparation)

L46 ANSWER 48 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1983:25534 HCAPLUS Full-text

DOCUMENT NUMBER: ORIGINAL REFERENCE NO.: 98:3899a,3902a

98:25534

TITLE:

Image-forming compositions containing

APPLICATION NO.

בת גם

pigments and ionic polvester dispersing agents INVENTOR(S): Noonan, John M.; Ryan, Raymond W.; Houle, James

KIND DATE

PATENT ASSIGNEE(S): Eastman Kodak Co., USA PCT Int. Appl., 39 pp. SOURCE:

CODEN: PIXXD2 DOCUMENT TYPE: Patent

LANGUAGE: English FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION: DATENT NO

					Dilli
WO 820278	30	A1	19820819	WO 1982-US168	198202
				<	10
	AU, BR, JP BE, DE, FR, B7	GB, NL		US 1981-233526	
					198102 11
CA 117570)3	A1	19841009	< CA 1982-394903	100001
				<	198201 26
AU 828208	34	A	19820826	AU 1982-82084	

110 10111001 20, 2000		10/5//,255		
				198202 10
			<	
AU 545584	B2	19850718		
BR 8206154	A	19830111	BR 1982-6154	
				198202
				10
			<	
EP 70898	A1	19830209	EP 1982-900889	
22 10030	***	15050205	11 1902 900009	198202
				10
			<	10
PD 30000	D.1	10051016	<	
EP 70898		19851016		
R: BE, DE, FR,				
JP 58500221	T	19830210	JP 1982-500956	
				198202
				10
			<	
JP 01046050	В	19891005		
PRIORITY APPLN. INFO.:			US 1981-233526 A	
				198102
				11
			<	
			WO 1982-US168 A	
				198202
				10
			<	10
			\	

AB Substantially amorphous polyesters containing ionic moleties are useful as pigment dispersing agents in preparation of photoimaging compns. for lithog, plates and resists fabrication. The dispersing agents reduce pigment agglomeration and improve the dispersion stability. Thus, Monastral Red B pigment 1 kg and di-Me succinate-1,4-bis(B-hydroxyethoxy)cyclohexane-dimethyl-3,3'- [(sodioimino)disulfonyl]-benzoate copolymer 25 g were mixed with 1,2-dichloroethane to give 20 weights pigment solids, ball milled, mixed with addnl. 1,2-dichloroethane to give a dispersion with 11 weights solids. The obtained pigment dispersion was used to form a photoimaging composition containing pigment dispersion 36.3, poly(1,4-cyclohexylenebis(oxyethylene)-1,4-phenylenediacrylate 10, Piccolastic A-50 resin binder 3.4, 2,6-di-tert-butyl-p-cresol 0.4, 2-benzoylmethylene-1-ethylnaphtho-[1,2-d]-thiazoline 0.5, leucopropyl violet dye 0.48, 2-azido-1-[carbobutoxymethylcarbamyl]benzimidazole 0.96,

2-azido-1-(carbobutoxymethylcarbamyl]benzimidazole 0.96, dihydroanhydropiperidinohexose reductone 0.048, Modaflo surfactant 0.04, 1.2-dichloroethane to give 478 g total. The composition was stored 7 days at 50° and 50% relative humidity. A conventional Al support with a coating of CM-cellulose and Zn acetate was coated with the photoimaging composition, dried, imagewise exposed to a 2000 W Xe light source for 60 s, processed, treated with finisher, dried. The resultant coating was smooth and had uniform priment d.

IT 26022-14-0

RL: USES (Uses)

(photoimaging composition containing polyester pigment dispersing agent and, litheg. plates production with)

RN 26022-14-0 HCAPLUS

CN 2-Propenoic acid, 2-hydroxyethyl ester, homopolymer (CA INDEX NAME)

CM 1

CRN 818-61-1

CMF C5 H8 O3

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HO-CH2-CH2-O-U-CH-CH2
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TC: G03C001-68

CC 74-6 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

Pigments

(dispersing agents for, polyesters as, photoimaging

compos. from)

Polyesters, uses and miscellaneous

RL: USES (Uses) (dispersing agents, for pigments, photoimaging compas.

from)

Photoimaging compositions and processes

(polyester pigment dispersing agents for)

Lithographic plates

(polyester pigment dispersing agents for photoimaging compos, for fabrication of)

58608-19-8

RL: USES (Uses)

(in photoimaging compass, for lithog, plate production) 128-37-0, uses and miscellaneous 1680-16-6 9003-53-6

26022-14-0 35976-48-8 53710-66-0

RL: USES (Uses) (photoimaging composition containing polyester pigment dispersing agent and, lithog, plates production with)

1047-16-1 ΙT

RL: USES (Uses) (photoimaging composition containing, polyester dispersing

agents for) 68508-90-7P 83970-21-2P 83970-22-3P 83970-23-4P 83970-24-5P RL: PREP (Preparation)

> (pigment dispersing agent for photoimaging compns., preparation of)

L46 ANSWER 49 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1982:43859 HCAPLUS Full-text

DOCUMENT NUMBER:

96:43859 ORIGINAL REFERENCE NO.: 96:7109a,7112a

TITLE: Photopolymerizable polyester-containing

compositions INVENTOR(S): Okuya, Ken

PATENT ASSIGNEE(S): Tamura Kaken Co., Ltd., Japan

SOURCE: U.S., 5 pp. CODEN: USXXAM DOCUMENT TYPE: Patent

LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION: PATENT NO

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
US 4293636	A	19811006	US 1980-178233	

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198008

JP 57013444 A 19820123 JP 1980-88408

198006 27

JP 01012376 PRIORITY APPLN. INFO.: B 19890228

JP 1980-88408 A

198006 27

AB Photosensitive polyester compas. for use in the fabrication of printed circuit

B Photosensitive polyester compns. for use in the fabrication or printed circuit boards are composed of a polyester, a half-esterified hydroxyalkyl acrylate or methacrylate of a polybasic acid or its anhydride, an ethylenically unsatd. bond-containing vinyl monomer, and a photopolymm. initiator. Thus, an ethylene glycol-fumaric acid-phthalic acid polymer 15.0, a half ester of maleic anhydride with glycerin diacrylate 33.8, p-tert-butylmonochloroacetophenone diacrylate 14.7, p-tert-

butylmonochloroacetophenone 3, BaSO4 31.0, Modaflo 2.0, and Cyanin green 0.5 weight% was screen printed on a Cu foil of a printed circuit board and then UV-cured to give a coating with a pencil hardness of 2H. The coating endured treatment with FeCl3, CuCl2, and NH4 persulfate etchants for ≥20 min and was strioped in 10 s in a 3% acueus NaOH solution of 55°.

IT 26022-14-0

RL: USES (Uses)

(photosensitive compas. containing, for printed elec. circuit fabrication)

RN 26022-14-0 HCAPLUS

CN 2-Propenoic acid, 2-hydroxyethyl ester, homopolymer (CA INDEX NAME)

CM 1

CRN 818-61-1

CMF C5 H8 O3



IC G03C001-68

INCL 430281000

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic and Other Reprographic Processes)

IT Fatty acids, polymers

RL: USES (Uses)

(dimers, photosensitive compass. containing, for printed elec. circuit fabrication)

IT Polyesters, uses and miscellaneous

RL: TEM (Technical or engineered material use); USES (Uses) (photoresist compas. containing, for fabrication of printed circuits)

IT Resists

(photo-, photopolymerizable polyester-containing compns.
for)

IT Electric circuits

(printed, photopolymerizable polyester-containing compns.
in fabrication of)

IT 27697-00-3 80440-96-6

RL: USES (Uses)

(photosensitive compas. containing polyesters and, for

printed elec. circuit fabrication) 51252-88-1 RL: USES (Uses) (photosensitive compas. containing polyesters and, for printed elec. circuits fabrication) 85-42-7D, esters with hydroxyalkyl acrylates or methacrylates 85-43-8D, esters with hydroxyalkyl acrylates or methacrylates 85-44-9D, esters with hydroxvalkyl acrylates or methacrylates 89-32-7D, esters with hydroxyalkyl acrylates or methacrylates 97-65-4D, esters with hydroxyalkyl acrylates or methacrylates 97-90-5 100-21-0D, esters with hydroxyalkyl acrylates or methacrylates 103-11-7 106-74-1 108-31-6D, esters with hydroxyalkyl acrylates or methacrylates 109-16-0 110-17-8D, esters with hydroxyalkyl acrylates or methacrylates 111-20-6D, esters with hydroxyalkyl acrylates or methacrylates 121-91-5D, esters with hydroxyalkyl acrylates or methacrylates 123-99-9D, esters with hydroxyalkyl acrylates or methacrylates 124-04-9D, esters with hydroxyalkyl acrylates or methacrylates 142-90-5 498-23-7D, esters with hydroxyalkyl acrylates or methacrylates 552-30-7D, esters with hydroxyalkyl acrylates or methacrylates 688-84-6 818-61-1 818-61-1D, esters with polybasic acids and anhydrides 821-38-5D, esters with hydroxyalkyl acrylates or methacrylates 868-77-9 868-77-9D, esters with polybasic acids and anhydrides 923-26-2 923-26-2D, esters with polybasic acids and anhydrides 999-61-1 999-61-1D, esters with polybasic acids and anhydrides 1070-70-8 1189-08-8 1680-21-3 1985-51-9 2082-81-7 2156-97-0 2223-82-7 2274-11-5 2351-43-1D, esters with polybasic acids and anhydrides 2358-84-1 2370-63-0 2399-48-6 2421-27-4 2455-24-5 2495-35-4 2495-37-6 2761-08-2D, esters with polybasic acids and anhydrides 2761-09-3D, esters with polybasic acids and anhydrides 3121-61-7 3253-41-6 3253-41-6D, esters with polybasic acids and anhydrides 3290-92-4 3326-90-7D, esters with polybasic acids and anhydrides 3524-66-1 3524-68-3 3524-68-3D, esters with polybasic acids and anhydrides 4074-88-8 4813-57-4 4986-89-4 6606-59-3 6976-93-8 7251-90-3 7559-82-2 7727-43-7 10595-06-9 13048-33-4 13159-51-8 13159-52-9D, esters with polybasic acids and anhydrides 13532-94-0 13533-05-6D, esters with polybasic acids and anhydrides and anhydrides 22499-12-3 24599-21-1 25151-33-1 25852-47-5 25852-49-7 26022-14-0 26183-87-9 26301-26-8 26570-48-9 26590-20-5D, esters with hydroxyalkyl acrylates or methacrylates 28497-59-8D, esters with polybasic acids and anhydrides 29570-58-9 30145-51-8 31249-11-3 32120-16-4 32360-05-7 41680-37-9 48145-04-6 52174-50-2D, esters with polybasic acids and anhydrides 52496-08-9 53664-39-4 57472-68-1 58593-15-0 64111-89-3 80440-97-7 RL: USES (Uses) (photosensitive compas, containing, for printed elec. circuit fabrication) L46 ANSWER 50 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: DOCUMENT NUMBER: 1980:224298 HCAPLUS Full-text 92:224298 ORIGINAL REFERENCE NO.: 92:36171a,36174a TITLE: Photohardening type resin compositions INVENTOR(S): Yamaura, Michio; Nakamura, Takahiro; Oe, Michisuke; Tomie, Takashi; Naka, Kivomi

Teijin Ltd., Japan

PATENT ASSIGNEE(S):

109 SOURCE: Jpn. Kokai Tokkvo Koho, 11 pp.

> CODEN: JKXXAF Patent

DOCUMENT TYPE: LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO. KIND DATE APPLICATION NO. DATE

JP 55000717 A 19800107 JP 1978-73169

197806 19

PRIORITY APPLN. INFO.:

<--JP 1978-73169 A

197806 19

AΒ A photohardening type resin composition for relief printing plates contains (1) a polyester (mol. weight 600-4000) having ≤1 (on average) ethylenic double bond and ≥1 end CO2H group, (2) an unsatd. polyurethane (mol. weight 1000-10000), (3) ≥1 unsatd, compound of the general formula H2C:CRCO2ZO2CCR:CH2 [R = H, Me; Z = -(CHR1CHR2On)mCHR1CHR2-(R1, R2 = H, Me; n = 0, 1; m = 1, 2)],and (4) a photopolymn. initiator. The photosensitive resin compast give relief images having good moisture resistance, low Young's modulus, high elongation, and good organic solvent resistance. Thus, adipic acid-diethylene glycol-fumaric acid copolymer (acid value 90; 1022:742:116 weight ratio) 35, a polyurethane [prepared by reacting poly(diethylene adipate) 2080, m-xylylene diisocyanate 376, and 2-hydroxyethyl methacrylate 286 gl 36, acrylamide 4, diethylene glycol diacrylate 10, methoxytetraethylene glycol monoacrylate 15, benzoin Et ether 1.0, and monomethoxyhydroquinone 0.02 part were mixed to give photosensitive resin composition. The relief printing plate prepared from the composition exhibited good tensile strength, elongation, heat- and moistureresistances, and low Young's modulus.

50858-51-0 TT

RL: USES (Uses)

(photosensitive resin compas, containing, for relief printing plate)

RN 50858-51-0 HCAPLUS

Poly[oxy(methyl-1, 2-ethanediyl)], CN

α-(1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX NAME)

$$H_2C = CH - U = C - (C_3H_6) - n OH$$

- IC C08F299-06; C08F002-50
- 74-5 (Radiation Chemistry, Photochemistry, and Photographic
- photosensitive resin relief printing plate; polyester photosensitive resin compa; polyurethane photosensitive resin compa
- TT Printing plates

(relief, photosensitive resin compas. containing polyester, polyurethane, and acrylic monomers for)

IT 79-06-1, uses and miscellaneous 79-39-0 123-31-9, uses and

miscellaneous 574-09-4 824-46-4 1680-21-3 2358-84-1 4074-88-8 6606-59-3 9046-11-1 28348-42-7 41026-23-7 5085-51-0 57472-68-1 71602-73-8 71602-74-9 71602-75-0 RI: USES (Uses)

(photosensitive resin compos. containing, for relief printing plate)

L46 ANSWER 51 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1980:189241 HCAPLUS Full-text

DOCUMENT NUMBER: 92:189241
ORIGINAL REFERENCE NO.: 92:30541a,30544a

TITLE: Photohardening resin compositions for

printing plates

INVENTOR(S): Yamaura, Michio; Nakamura, Takahiro; Tomie, Takashi; Oe, Michisuke; Naka, Kiyoshi

PATENT ASSIGNEE(S): Teijin Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 10 pp.
CODEN: JKXXAF

DOCUMENT TYPE: Patent

LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

P#	ATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JE	P 54142293	A	19791106	JP 1978-50145	
					197804 28
				<	
JE	P 61017854	В	19860509		
PRIORIT	IY APPLN. INFO.:			JP 1978-50145 F	7
					197804

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28

AB Photosensitive resin compas, contain (1) a polyester of average mol. weight 600-4000 which has ≤1 ethylenic double bond and ≤1 end carboxyl group/mol.; (2) an unsatd. polyurethane of average mol. weight 1000-10,000; (3) ethylenically unsatd. monomers, and (4) photopolymn. initiators. The photosensitive resin compas, give relief images with good moisture resistance, low Young's modulus, good elongation, and good swelling resistance. The photosensitive resins also exhibit good developability. Thus, adipic aciddiethylene glycol-fumaric acid (116:584:636 weight ratio) copolymer (acid value 20, number of ethylenic double bond 0.3/mol., number of end CO2H group 0.7/mol.) 35, a polyurethane prepared by reacting poly(diethylene adipate) with m-xylylene diisocyanate and 2-hydroxyethyl methacrylate (2080, 376, and 286 g, resp.) 36, acrylamide 4, tetraethylene glycol diacrylate 10, methoxytetraethylene glycol monomethacrylate 15, benzoin Et ether 1.0, and monomethoxyhydroquinone 0.02 part were mixed to give a photosensitive resin having good developability. The tensile strength, Young's modulus, and elongation of the relief images were 0.83, 0.22 kg/mm2, and 187%, resp. The relief images also exhibited good heat resistance.

IT 50858-51-0

RL: USES (Uses)

(photosensitive resin compns. containing, for relief printing plates)

RN 50858-51-0 HCAPLUS

CN Polv(oxv(methvl-1,2-ethanedivl)),

α-(1-oxo-2-propen-1-v1)-ω-hvdroxv- (CA INDEX NAME)

November 26, 2008 10/577,255 111

$$\text{H}_2\text{C} \underline{\hspace{1cm}} \text{CH-} \overset{\circ}{\text{C}} \underline{\hspace{1cm}} \text{O--} (\text{C}_3\text{H}_6) \underline{\hspace{1cm}} \underline{\hspace{1cm}} \text{n}$$

IC C08F299-06; C08F002-50

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic

Processes)

IT Polyesters, uses and miscellaneous

Urethane polymers, uses and miscellaneous RL: USES (Uses)

> (photosensitive resin compas. containing, for relief printing plates)

IT Printing plates

(relief, photosensitive resin compns. containing polyesters and urethane polymers for)

IT 79-06-1, uses and miscellaneous 79-39-0 123-31-9, uses and miscellaneous 574-09-4 824-46-4 6652-28-4 17831-71-9 25053-83-2 28348-42-7 50858-51-0 52496-08-9 57454-26-9 71602-73-8 71602-74-9 71602-75-0 71602-76-1 73501-88-9

RL: USES (Uses)

(photosensitive resin compns. containing, for relief printing plates)

L46 ANSWER 52 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1979:620345 HCAPLUS Full-text

DOCUMENT NUMBER: 91:220345

ORIGINAL REFERENCE NO.: 91:35367a,35370a
TITLE: Photosensitive resin composition for

flexographic plates

INVENTOR(S): Hagiwara, Tsuneo; Iwata, Kaoru; Horike, Akihiro PATENT ASSIGNEE(S): Teijin Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 11 pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent

LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 54058790	A	19790511	JP 1977-125100	
				197710 20
			<	
PRIORITY APPLN. INFO.:			JP 1977-125100 A	
				197710 20

AB Photosensitive resin compos. contain (1) polymerizable ethylenically unsatd. monomers, (2) a photosensitizer, and (3) reaction products of glycidyl (meth)acrylate with a polymer having chain-terminating groups of formula H2C:CRC02(Z0)pCOZ1(CO2H)2CO- or H2C:CRC02(Z0)pCOZ1(CO2H)2CO2Z2O- (R = H, Me; Z = C2-5 alkylene; p = 1-20; Z1 = C3-40 tetravalent organic moiety in which the COZH and CO groups are attached to adjacent C atoms; Z2 = aliphatic polyol

mojety whose average mol. weight is 300-4000) and having structural repeating units of the formulas -OZ202CZ1(CO2H)2CO- and/or -OZ202CNHZ3NHCO- (Z1,Z2 are same as above; Z3 = C2-15 divalent aliph, arom, or heterocyclic moiety). The photosensitive resin compas. have good sensitivity, are water-base solution developable, and are suitable for preparing flexog. printing plates. Thus, polyethylenebutylene adipate (average mol. weight 1000, OH groups at both ends of chain; Nipporan 141) 4000 and hexahydroxylylene diisocyanate (m/p ratio 3/7) 388 parts were heated at 90°, then reacted with 1,2,3,4butanetetracarboxylic acid dianhydride 594 parts to give a polyester urethane. The polyester urethane and 2-hydroxyethyl methacrylate 260 parts were reacted, and the resultant polymer was reacted with qlycidyl methacrylate. The reaction products 100, diallyl phthalate 6.25, tetraethylene glycol dimethacrylate 6.25, polypropylene glycol monomethacrylate (average mol. weight 370) 12.5, and benzoin Et ether 1.25 parts were mixed to give a photosensitive resin composition. The resin composition showed good sensitivity and developability (with 0.5% NaCO3) and gave a high-guality flexog, plate. 39420-45-6 RL: USES (Uses)

(photosensitive resin compas. containing, for flexog. plates)

39420-45-6 HCAPLUS RN

CN Poly[oxy(methyl-1,2-ethanediyl)],

> α-(2-methyl-1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX NAME)

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C08F299-04; C08F002-50; G03C001-68; G03F007-02
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74-5 (Radiation Chemistry, Photochemistry, and Photographic Processes)

Polyesters, uses and miscellaneous TT

RL: USES (Uses)

(photosensitive resin compas, containing, for flexog. plates)

Printing plates

(flexog., photosensitive resin compas. for)

84-65-1 97-88-1 109-17-1 131-17-9 574-09-4 1187-59-3 1746-23-2 2156-97-0 2873-97-4 3524-62-7 6652-28-4 17831-71-9 20166-49-8 25852-47-5 39420-45-6 39420-45-6 45314-30-5 72058-44-7 72058-45-8 72061-10-0 72061-11-1 72063-42-4 72063-43-5 72068-04-3 RL: USES (Uses)

(photosensitive resin compas, containing, for

flexog. plates)

L46 ANSWER 53 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1979:620344 HCAPLUS Full-text

DOCUMENT NUMBER: 91:220344

ORIGINAL REFERENCE NO.: 91:35367a,35370a

TITLE: Photosensitive resin compositions for

flexographic plates

INVENTOR(S): Iwata, Kaoru; Hagiwara, Tsuneo; Horike, Akihiro PATENT ASSIGNEE(S): Teijin Ltd., Japan

November 26, 2008 10/577,255 113

Jpn. Kokai Tokkvo Koho, 12 pp.

CODEN: JKXXAF

DOCUMENT TYPE: Patent LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

SOURCE:

PATENT NO. KIND DATE APPLICATION NO. DATE JP 54058793 A 19790511 JP 1977-125102 197710 2.0 <--PRIORITY APPLN. INFO.: JP 1977-125102 A

197710 20

AB Photosensitive resin compas. contain (1) sensitizers, (2) polymerizable unsatd. polyesters, (3) polymerizable ethylenically unsatd. monomers, and (4) polymers having chain-terminating groups of the formula H2C:CRCO2(ZO)PCOZ1(CO2H)2CO- or H2C:CRCO2(ZO)PCOZ1(CO2H)2COZ2O- (R = H, Me; Z = C2-5 alkylene; p = 1-20; Z1 = C3-40 tetravalent organic moiety in which the CO2H and CO groups are attached to adjacent C atoms; Z2 = aliphatic polyester and/or polyol moiety whose average mol. weight is 300-4000) and structural repeating units of formulas -OZ202CZ1(CO2H)2CO- and/or -OZ202CNHZ3NHCO- (Z1,Z2 = same as above; Z3 = C2-15 divalent aliphatic, aromatic, or heterocyclic moiety). The photosensitive compns . have good developability in aqueous developer and give high-quality flexog. plates. Thus, polyethylenebutylene adipate (average mol. weight 1000, OH groups on both ends of the main chain; Nipporan 141) 2000 parts was reacted with hexahydroxylylene diisocyanate 194 parts, then with 1,2,3,4-butanetetracarboxylic acid dianhydride 297 parts, and finally with 2-hydroxyethyl methacrylate 130 parts to give a polyester urethane. Sep. trimellitic anhydride 96, fumaric acid 232, adipic acid 365, and ethylene glycol 477 parts were copolymd, to give an unsatd, polyester. The polyester urethane 70, the unsatd. polyester 30, methacrylamide 5, tetraethylene glycol dimethacrylate 7.5, diallyl isophthalate 7.5, tetradecaethylene glycol dimethacrylate 15, and benzoin Et ether 1.3 parts were mixed to give a photosensitive resin composition which showed good sensitivity and developability. The flexog, plate prepared from the resin had good elasticity and good size reproducibility.

IT 39420-45-6 RL: USES (Uses) (photosensitive resin compns. containing, for

flexog. plates)

39420-45-6 HCAPLUS

RN

CN Poly[oxy(methyl-1,2-ethanediyl)],

α-(2-methvl-1-oxo-2-propen-1-vl)-ω-hvdroxv- (CA INDEX NAME)

$$\operatorname{Me}^{\begin{subarray}{c} \begin{subarray}{c} \begin{subarray}{$$

- IC C08F299-04; C08F002-50; G03C001-68; G03F007-02
- CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic

Processes)

I Printing plates

(flexog., photosensitive resin compas. for)

IT 79-39-0 109-17-1 112-47-0 131-17-9 574-09-4 1087-21-4 1746-23-2 2156-97-0 2873-97-4 3524-62-7 6652-28-4 20166-49-8 28852-47-5 39420-43-6 39420-43-6

45314-30-5 56343-22-7 71402-86-3 71402-87-4 71437-35-9 71437-36-0 71437-37-1 71437-38-2 71602-74-9 72058-43-6

72061-09-7 72076-61-0 72103-88-9 RL: USES (Uses)

(photosensitive resin compas. containing, for flexog. plates)

L46 ANSWER 54 OF 58 HCAPLUS COPYRIGHT 2008 ACS on SIN ACCESSION NUMBER: 1979:549492 HCAPLUS Full-text DOCUMENT NUMBER: 91:149492

DOCUMENT NUMBER: 91:149492
ORIGINAL REFERENCE NO.: 91:23975a,23978a

TITLE: Photosensitive resin compositions for

flexographic plates

INVENTOR(S): Iwata, Kaoru; Hagiwara, Tsuneo; Horike, Akihiro

PATENT ASSIGNEE(S): Teijin Ltd., Japan SOURCE: Jpn. Kokai Tokkyo Koho, 9 pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

PATENT NO. KIND DATE APPLICATION NO. DATE

JP 54058792 A 19790511 JP 1977-124463 197710

PRIORITY APPLN. INFO.: JP 1977-124463 A

197710 19

/__

AB Photosensitive resin compas. contain a sensitizer, ≥1 monomer having ethylenic double bond(s), and a polymer having structural repeating units of the formula -OZO2CZ1(CO2H)2CO- or -OZO2CNHZ2NHCO- (where Z = aliphatic polyester or polyol moiety whose average mol. weight is 300-4000; Z1 = C3-40 tetravalent organic moiety; Z2 = C2-15 aliphatic, alicyclic, or aromatic moiety) and having end terminating groups of formula H2C:CRCO2(Z3O)pCOZ1(CO2H)2CO- or H2C:CRCO2(Z30)pCOZ1(CO2H)2CO2ZO-(R = H, Me; Z, Z1 = same as above; Z3 = C2-5alkylene; p = 1-20). The photosensitive resins can be developed with waterbased developers and are useful for preparing flexog. plates. Thus, polyethylene butylene adipate (average mol. weight 1000, OH groups on both ends; Nipporan 141) 2000 and hexahydroxylylene diisocyanate (m/p ratio = 3/7) 194 parts were heated at 90°, then 1,2,3,4-butanetetracarboxylic acid dianhydride 297 parts was added, and the mixture was heated at 140°. The resultant polyester-urethane was heated with 2-hydroxyethyl methacrylate 130 parts in the presence of N-nitrosodiphenylamine to give a polyester-urethane having pendant groups containing double bond and carboxyl groups. The polymer 100, diallyl phthalate 6.25, tetraethylene glycol dimethacrylate 6.25, polypropylene glycol monomethacrylate (average volume weight 370) 12.5, and benzoin Et ether 1.25 parts were mixed to give a photosensitive resin composition which yielded a high quality flexog, plate.

RL: USES (Uses)
(photosensitive resin compns. containing, for flexog. plates)
33420-45-6 RCAPLUS
Poly(oxy(methyl-1,2-ethanediy1)],
a-(2-methyl-1-ox-2-propen-1-v1)-m-hydroxy- (CA INDEX

IC C08F299-02; C08F002-50

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic Processes)

IT Printing plates

NAME)

DM

CN

(flexog., photosensitive resin compas. for, containing

polyester derivs.)
T 84-65-1 97-88-1 109-17-1 574-09-4 1026-92-2 1187-59-3 2156-97-0 2873-97-4 3524-62-7 6652-28-4 17831-71-9 20166-49-8 25338-51-6 25852-47-5 39420-45-6

71437-35-9 71437-36-0

APPLICATION NO.

DATE

45314-30-5 71402-86-3 71402-87-4 71437-37-1 71437-38-2 71497-18-2

RL: USES (Uses)

(photosensitive resin compos. containing, for flexog. plates)

L46 ANSWER 55 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1979:549489 HCAPLUS Full-text DOCCUMENT NUMBER: 91:149489

DOCUMENT NUMBER: 91:149489
ORIGINAL REFERENCE NO.: 91:23975a,23978a

TITLE: Photosensitive resin compositions

KIND DATE

INVENTOR(S): Yamaura, Michio; Oe, Michisuke; Naka, Kiyomi
PATENT ASSIGNEE(S): Teijin Ltd., Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 7 pp. CODEN: JKXXAF

DOCUMENT TYPE: Patent
LANGUAGE: Japanese
FAMILY ACC. NUM. COUNT: 1

PATENT INFORMATION:

JP 54054192	A	19790428	JP 1977-119965
			197710 07
			<
PRIORITY APPLN. INFO.:			JP 1977-119965 A
			197710 07

AB Photosensitive resin compos. for relief printing plate production are composed of (1) an unsatd. polyester (mol. weight 500-4000) which has ethylenically unsatd. polycarboxylic acid units (1-3 units/mol) and CO2H chain-terminating groups, (2) an acrylurethane prepared by reacting a polyester polyol (average

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mol. weight 500-4000) with a polyisocyanate (22 mol/mol polymer) and end-double bond-forming compound (22 mol/mol polymer), (3) ethylenically unsatd. monomers, and (4) photosensitizers. The resins give relief images with low Young's modulus, high elongation, and mech strength. Thus, fumaric acid 116, adipic acid 876, and diethylene glycol 636 g were copolymat to give an unsatd. polyester having 2 CO2H groups. Sep., polydiethylene adipate (OH value 54, acid value 51) 2080 g was reacted with m-xylene diisocyanate 376 g and subsequently with 2-hydroxyethyl methacrylate 286 g to give an acrylurethane. The unsatd. polyester 35, the acrylurethane 36, acrylamide 4, tetraethylene glycol diacrylate 10, methoxytetraethylene glycol monomethacrylate 15, benzoin Et ether 1, and monomethoxyhydroquinome 0.02 part were mixed to give a photosensitive resin composition from which a flexible relief printing plate was prepared The Young's modulus, tensile strength, and elongation of the relief printing plate were 0.19 kg/mm2, 0.41 kg/mm2, and 123%, resp.

IT 50858-51-0

RL: USES (Uses) (photosensitive resin composition containing, for flexog. plates)

RN 50858-51-0 HCAPLUS

CN Poly[oxy(methyl-1,2-ethanediyl)],

α-(1-oxo-2-propen-1-yl)-ω-hydroxy- (CA INDEX NAME)

IC C08F299-06; C08F002-50; G03C001-68; G03F007-08

CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic Processes)

IT Printing plates

(relief, photosensitive resin compns. containing unsatd. polvester and acrylurethane for)

Top-06-1, uses and miscellaneous 79-39-0 123-31-9, uses and miscellaneous 574-09-4 824-46-4 652-28-4 17831-71-9 25852-49-7 50858-51-0 52496-08-9 57454-26-9

RL: USES (Uses)

(photosensitive resin composition containing, for flexog. plates)

IT 28348-42-7 71602-73-8 71602-74-9 RL: USES (Uses)

RL: USES (Uses) (photosensitive resin compns. containing acrylurethane and, for flexog. plates)

IT 71602-75-0 71602-76-1 71602-77-2

RL: USES (Uses)

(photosensitive resin compas. containing unsatd. polyester and, for flexog. plates.)

L46 ANSWER 56 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1975:570906 HCAPLUS Full-text

DOCUMENT NUMBER: 83:170906

ORIGINAL REFERENCE NO.: 83:26751a,26754a

TITLE: Photosensitive compositions for lithographic printing plates

INVENTOR(S): Kita, Nobuyuki; Narutomi, Yasuhisa

PATENT ASSIGNEE(S): fugi, Japan

SOURCE: Jpn. Kokai Tokkyo Koho, 9 pp.

CODEN: JKXXAF
DOCUMENT TYPE: Patent
LANGUAGE: Japanese

FAMILY ACC. NUM. COUNT: 2 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.		DATE
JP 50030604	A	19750326	JP 1973-82850		197307 23
			<		23
JP 52007364	В	19770302			
GB 1460978	A	19770106	GB 1974-30835		197407 11
			<		
DE 2434912	A1	19750206	DE 1974-2434912		197407 19
0.0.00			<		
DE 2434912 FR 2238952		19830811	FR 1974-25584		
FR 2230332		19750221	IN 1374 23304		197407 23
			<		
FR 2238952 CA 1041346		19781124	CA 1974-205472		
CA 1041346	AI	19/81031	CA 1974-205472		197407 23
			<		
US 4275138	A	19810623	US 1976-723061		197609 14
			<		
PRIORITY APPLN. INFO.:			JP 1973-82850	A	197307 23
			<		
			US 1974-489434	A1	197407 17

Photosensitive compast contain diazo compds, and polymers having ≥50 weight % AB monomeric units of structure [CH2CR1[CO2(CH2CHR2O)nH]] (R1 = H, Me; R2 = H, Me, Et, C1CH2; n = 1-10). The polymers improve the abrasion resistance of the photosensitive layer without degrading the storage stability of the photosensitive layer, and hence, the compos. are useful for preparing lithog. printing plate. Thus, \(\beta \)-hydroxyethyl methacrylate 100g and benzoyl peroxide 0.75 g were added dropewise (in 2 hr) to 180g of 2-methoxyethanol 180g, heated to 100° under N, then a mixture of 2-methoxyethanol 20 and benzoyl peroxide 0.025g was added slowly (15 min), and the reaction was continued for 3 hr at 100° to give a poly(β-hydroxyethyl methacrylate)(I) solution in 2methoxyethanol. The 32% solution of (I) 2.4 was then mixed with (1) 0.2g of an acrylurethane compound prepared by reacting β -hydroxyethyl acrylate with Koronato L (a poly isocyanate compound from Nippon Polyurethane Kogyo K. K.), (2) 0.2g of 2-methoxy-4-hydroxy-5-benzovlbenzene sulfonic acid, (3) Oil Blue 603 (Hodogaya Kayaku Kogyo K. K.) 0.03q, (4) 2-methoxyethanol 20q, and (5)

MeOH 5 g to give a photosensitive composition which was coated on an Al substrate to give a photosensitive lithog, printing plate. The photosensitive plate was exposed to a 30-A C arc lamp for 30 sec at 70 cm, and developed 1 min in a developer consisting of benzyl alc. 20, aqueous 40% Na silicate solution 10, Monogen Y-100 30, and H2O 940g to give a printing plate. RL: USES (Uses) (photosensitive composition containing, for lithog. plates) 25249-16-5 HCAPLUS RN CN 2-Propenoic acid, 2-methyl-, 2-hydroxyethyl ester, homopolymer (CA INDEX NAME) CM 1 CRN 868-77-9 CMF C6 H10 O3 H2C Me_C_C_C_O_CH2_CH2_OH INCL 116A415; 103B1; 25(1)A29 CC 74-5 (Radiation Chemistry, Photochemistry, and Photographic photosensitive compo lithog printing; diazo photosensitive compn Urethane polymers, uses and miscellaneous RL: USES (Uses) (acrylates, photosensitive compas. containing hydroxyethyl methacrylate polymer and, for lithog. plates) Lithographic plates (photosensitive compas, for, containing hydroxyethyl methacrylate and urethane acrylate polymers) ΙT 25249-16-5 RL: USES (Uses) (photosensitive composition containing, for lithog, plates) L46 ANSWER 57 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1975:112760 HCAPLUS Full-text DOCUMENT NUMBER: 82:112760 ORIGINAL REFERENCE NO.: 82:18027a,18030a TITLE: Photocrosslinkable resin compositions INVENTOR(S): Nishikubo, Tadatomi; Imaura, Masakazu; Hiramatsu, Fumio PATENT ASSIGNEE(S): Nippon Oil Seal Industry Co., Ltd., Japan Jpn. Kokai Tokkyo Koho, 5 pp. SOURCE: CODEN: JKXXAF DOCUMENT TYPE: Pat.ent. LANGUAGE: Japanese FAMILY ACC. NUM. COUNT: 1 PATENT INFORMATION:

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
JP 49107047	A	19741011	JP 1973-17263	

197302 10

JP 52026259 B 19770713

PRIORITY APPLN. INFO.: JP 1973-17263

197302 10

Alkyl acrylate copolymers with pendant functional group-containing comonomers AB were treated with photopolymerizable monomers reactive to the copolymer functional group, and the product was mixed with photopolymerizable monomer and photoinitiator to give photocrosslinkable resin compas. For example, 250 q 40% 1.8:98.2 acrylic acid-ethyl acrylate polymer (I) [25085-35-2] solution (in toluene) was treated with glycidyl acrylate (II) [106-90-1] 3.1, triethylbenzylammonium chloride 0.3, and p-HOC6H4OMe 0.05 q at 100-5° for 3 hr, and the product solution (88 parts) was mixed with 10 parts trimethylolpropane triacrylate [15625-89-5] and 2 parts benzoin Et ether, cast on glass to 0.3 mm thickness, and uv-irradiated to give acetone-insol. film. Et acrylate-2-hydroxyethyl acrylate polymer [28136-76-7] and Et acrylateqlycidyl acrylate polymer [28430-94-6] were also used in place of I and 2,4tolylene diisocyanate-2-hydroxyethyl acrylate adduct (1:1) [54554-39-1] and acrylic acid [79-10-7] in place of II, and other crosslinkers were, e.g., ethylene glycol diacrylate [2274-11-5] and ethylene glycol dimethacrylate [97-90-5].

IT 28136-76-7

RL: USES (Uses)

(crosslinking agents for, photosensitive)

RN 28136-76-7 HCAPLUS

CN 2-Propenoic acid, ethyl ester, polymer with 2-hydroxyethyl 2-propenoate (CA INDEX NAME)

CM 1

CRN 818-61-1 CMF C5 H8 O3

CM 2

CRN 140-88-5

CMF C5 H8 O2

INCL 25(1)C142.12; 24(5)B515

CC 36-6 (Plastics Manufacture and Processing)

ST photosensitive resin compn acrylic

IT 28136-76-7 28430-94-6

RL: USES (Uses)

(crosslinking agents for, photosensitive)

L46 ANSWER 58 OF 58 HCAPLUS COPYRIGHT 2008 ACS on STN ACCESSION NUMBER: 1968:482318 HCAPLUS Full-text

DOCUMENT NUMBER: 69:82318

ORIGINAL REFERENCE NO.: 69:15399a,15402a

TITLE: Light-sensitive composition consisting of organic color-generator, photooxidant and

organic thermally activatable reducing agent

progenitor
INVENTOR(S): Manos, Philip

PATENT ASSIGNEE(S): du Pont de Nemours, E. I., and Co.

SOURCE: U.S., 10 pp.
CODEN: USXXAM

DOCUMENT TYPE: Patent LANGUAGE: English

FAMILY ACC. NUM. COUNT: 1

PATENT NO.	KIND	DATE	APPLICATION NO.	DATE
US 3390995	A	19680702	US 1964-363625	
				196404
				29

PRIORITY APPLN. INFO.: US 1964-363625

196404 29

<--AB A photosensitive composition contains in intimate association, essentially nonhygroscopic interreactant progenitors of intensely colored organic color bodies. The progenitors are activated by radiation of wavelength 2000-4200 A. which can be applied in a graphic pattern. They are permanently deactivated when heated to 80-160°. The composition consists of (1) an essentially colorless, oxidizable N-containing, organic color-generator which, when contained in the photosensitive composition, is stable to oxidation by atmospheric O under normal room and storage conditions but which can be oxidized to an intensely colored species; (2) a photo-oxidant which, when mixed with the oxidizable color generator and irradiated with 2000-4200 A. radiation, will oxidize the color generator to an intensely colored species as an essential part of the compn .; (3) an organic progenitor of a reducing agent which, when mixed with components 1 and 2 but prior to the heat treatment it does not function as a reducing agent. It is chemical changed by the heat treatment to produce a reducing agent which prevents the photooxidation A preferred composition contains an aminotriarylmethane with an orthosubstituent in at least 2 of the aryl groups as the organic color generator, a hexaarylbiimidazole as photooxidant, and an acetal of hydroquinone as the organic progenitor of reducing agent. Thus, photosensitive paper is prepared by dipping unsized paper in a 4:1 (by volume) methanol-N, N-dimethylformamide solution containing (by weight) 0.4% tris(4diethylamino-o-tolyl)methane-3HCl and 0.4% 2,2'-bis(o-chlorophenyl)-4,4',5,5'tetraphenylbiimidazole followed by drying under an ir lamp. The paper is then dipped into a 0.5% benzene solution of a progenitor of a reducing agent and again dried. The paper is folded so that part of it is exposed for 10 sec. to a 275-w. sun lamp at a distance of 10 in. whereupon an intense blue color forms. The whole paper is then heated for 5 sec. between the plates of a hydraulic press at 125° and the unirradiated portion of the paper exposed to the sun lamp for 10 sec. In the absence of an agent other than the colorgenerator and the photooxidant no deactivation occurs with heating. When a reducing agent deactivates the photosensitive composition prior to heating,

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no image is formed on light exposure. With acetals of hydroquinone, substituted hydroquinones, and other phenolic compds., however, the photosensitive composition gives sharp images on uv exposure and is readily deactivated by moderate heating to preserve the initial image during subsequent light exposure.

RL: USES (Uses)

(light-sensitive composition containing, stabilized by heat, for photoduplication)

25120-30-3 HCAPLUS RN

CN 2-Propenal, 2-methyl-, homopolymer (CA INDEX NAME)

CM

CRN 78-85-3 CMF C4 H6 O

INCL 096048000

CC 74 (Radiation Chemistry, Photochemistry, and Photographic Processes) ST

light sensitive compn; imidazoles printing; color

printing; arylmethanes printing; leuco dye; dye leuco

ΙT Photothermography

(light-sensitive composition containing color generator and photooxidant and reducing agent for)

Photoduplication

(light-sensitive composition for, stabilized by heat)

Phenol, p-methoxy-, orthoformate (3:1)

RL: USES (Uses)

(light-sensitive composition containing, for photoduplication)

ΙT 67-72-1 68-12-2D, Formamide, N,N-dimethyl-, tin complex 82-90-6 92-66-0 120-78-5 121-69-7 507-25-5 558-13-4 630-25-1 1249-97-4 632-52-0 811-32-5 1614-15-9 1706-74-7 1707-68-2

1750-13-6 2139-44-8 3069-07-6 4482-56-8 5968-67-2

6271-40-5 13545-99-8 16902-02-6 17720-63-7 19447-48-4

19447-54-2 19447-56-4 20443-88-3 21545-19-7 21545-20-0

21545-21-1 21545-22-2 21545-23-3 21545-24-4 21545-26-6

21545-27-7 21545-28-8 21545-29-9 21545-31-3 21545-32-4

21545-35-7 21545-37-9 21545-45-9 21545-46-0 21545-34-6

21645-25-0 22468-38-8 25120-30-3 29382-42-1

RL: USES (Uses)

(light-sensitive composition containing, stabilized by heat, for photoduplication)